

Vacuum Components Portolio

Components Business HQ ULVAC, Inc. ULVAC CRYOGENICS, Inc. Vol.09

Pressure unit conversion table

Pa (N⋅m ⁻²)	Torr(mmHg)	Bar	kg∙cm ⁻²	Psi (lb∙in⁻²)	atm	Water Column (15°C) m
1	7.500 62×10 ⁻³	10 ⁻⁵	1.019 72x10 ⁻⁵	1.450 38x10 ⁻⁴	9.869 23x10 ⁻⁶	1.020 63x10 ⁻⁴
133.322	1	1.333 22x10⁻³	1.359 51x10 ⁻³	1.933 68x10 ⁻²	1.315 79x10 ⁻³	1.360 73x10 ⁻²
10 ⁵	750.062	1	1.019 72	14.503 8	0.986 923	10.206 3
9.806 65x10 ⁴	735.559	0.980 665	1	14.223 4	0.967 841	10.009 0
6.894 75x10 ³	51.714 9	6.894 75x10 ⁻²	7.030 69x10 ⁻²	1	6.804 59x10 ⁻²	0.703 702
1.013 25x10 ⁵	760	1.013 25	1.033 23	14.696 0	1	10.341 6
9.797 82×10 ³	73.489 7	9.797 82x10 ⁻²	9.991 0x10 ⁻²	1.421 06	9.669 70×10 ⁻²	1

Flow rate unit conversion table

1 lb·in^2 = 144 lb·ft^2 , 1 short ton·ft^2 = 0.945 08 atm, psi: pound per square inch

Pa⋅m³⋅s⁻¹	Torr·L·s ⁻¹	atm·cm ³ ·s ⁻¹	mbar·L·s ⁻¹	molecule • s ⁻¹	sccm	
1	7.500 62	9.869 23	10	2.651 65x10 ²⁰	5.921 540x10 ²	
0.133 322	1	1.315 79	1.333 22	3.535 23x10 ¹⁹	78.947 4	
0.101 325	0.76	1	1.013 25	2.686 78x10 ¹⁹	60	
0.1	0.750 062	0.986 923	1	2.651 65x10 ²¹	59.215 40	
3.771 24x10 ⁻²¹	2.828 67x10 ⁻²⁰	3.721 92x10 ⁻²⁰	3.771 24x10 ⁻²⁰	1	2.233 15x10 ⁻¹⁸	
1.688 75×10 ^{−3}	1.266 67x10 ⁻²	1.666 67x10 ⁻²	1.688 75x10 ⁻²	4.477 97x10 ¹⁷	1	

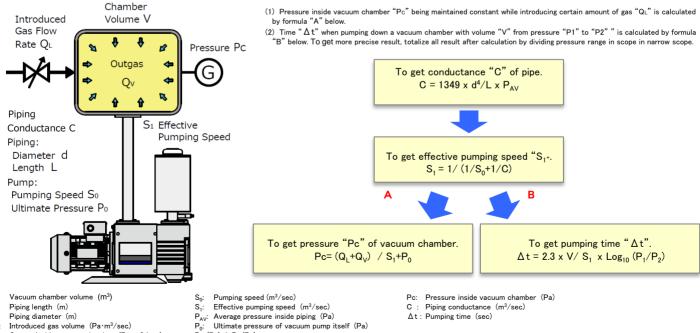
molecule is ideal gas (value of $0^\circ C)$, sccm: standard cubic centimeter per minute

Pumping speed and conductance unit conversion table

m ³ • s ^{−1}	L∙s ^{−1}	L∙min ⁻¹	cm³⋅s⁻¹	m ³ · hr ⁻¹	ft³∙s⁻1
1	10 ³	6x10 ⁴	10 ⁶	3600	35.31
10 ⁻³	1	60	10 ³	3.6	3.531×10 ^{−2}
1.667x10 ⁻⁵	1.667x10 ⁻²	1	16.67	0.06	5.885×10 ⁻⁴
10 ⁻⁶	10 ⁻³	0.06	1	3.6x10 ⁻³	3.531x10⁻⁵
2.778×10 ⁻⁴	0.277 8	16.67	2.778×10 ²	1	9.808×10⁻³
2.832x10 ⁻²	28.32	1.699x10 ³	2.832×10 ⁴	1.019 52x10 ²	1

Pumping speed calculation (viscous flow range)

Followings show how to calculate pumping speed in the range of viscous flow when using oil rotation vacuum pumps, dry vacuum pumps, mechanical booster pumps, etc. (Actual result could change from the calculated value depending on vacuum chamber, piping shape, contents in side chamber, leak rate, outgas, etc.)



Piping diameter (m) Introduced gas volume (Pa·m³/sec) d٠ Q

V:

L:

0... Outgas inside vacuum chamber (Pa·m3/sec) P_{AV}:

 P_0 : Ultimate press P_1 (Pa) > P_2 (Pa).

 Δt : Pumping time (sec)

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 Oil Diffusion Pump 	40
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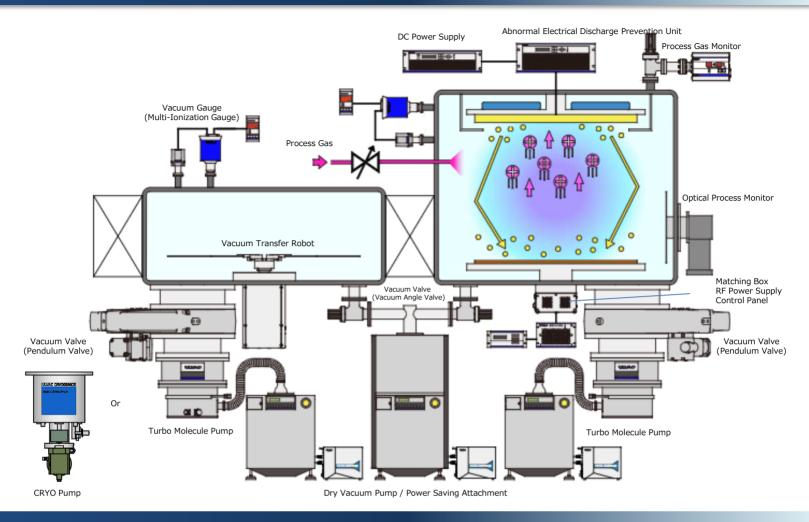
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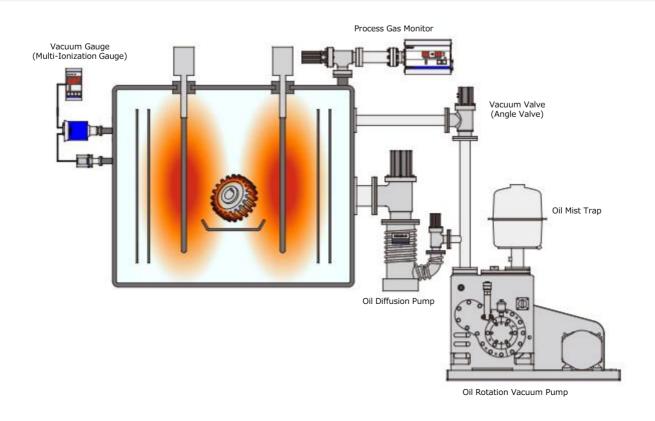
Cryogenic	Equipment	

P.8 Vacuum Pump
P.44 Vacuum Valve
P.46 Vacuum Gauge
P.52 Process Gas Monitor (Residual Gas Analyzer)
P.56 Leak Detector
P.58 Power Supply (DC/RF)
P.66 EB Power Supply / EB Source
P.69 Deposition Controller
P.72 Thin Film Measurement
P.74 Accessories
P.76 Vacuum Transfer Robot
P.77 Cryogenic Equipment

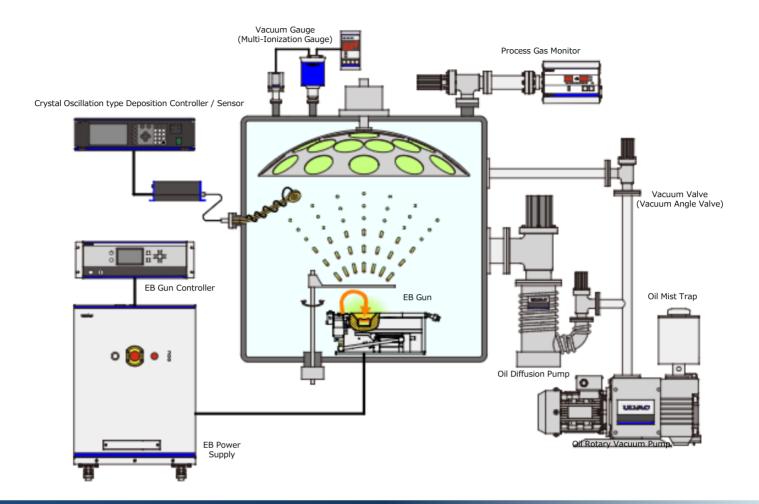
Sputtering Equipment



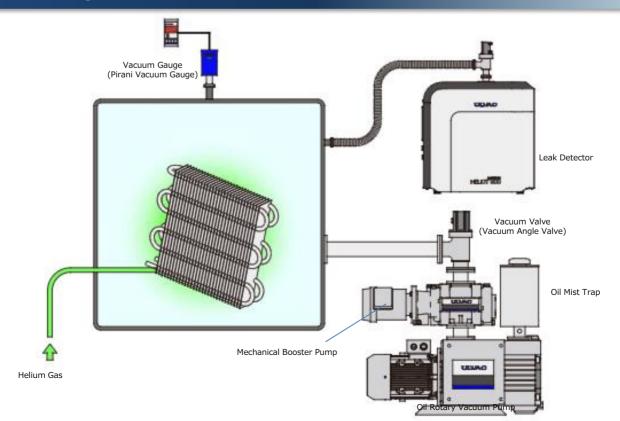
Vacuum Heat Treatment Furnace



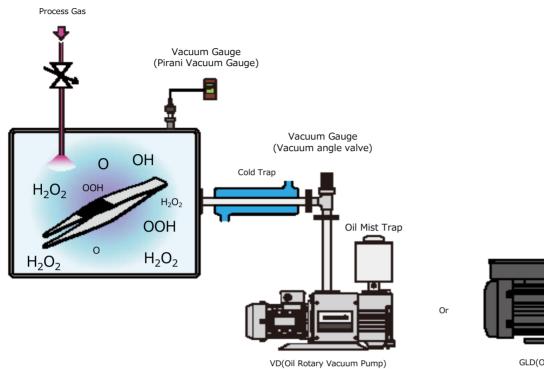
Evaporation Equipment



Leak Test System



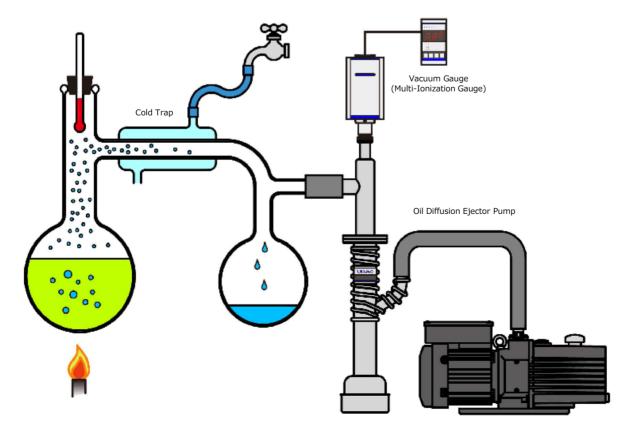
Plasma sterilization





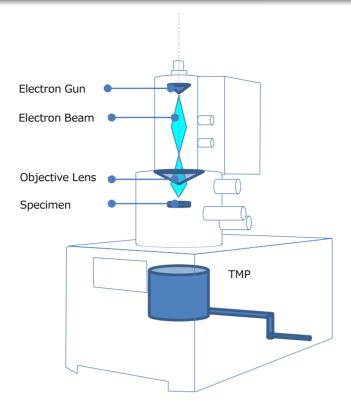
GLD(Oil Rotary Vacuum Pump)

Vacuum Distillation Equipment

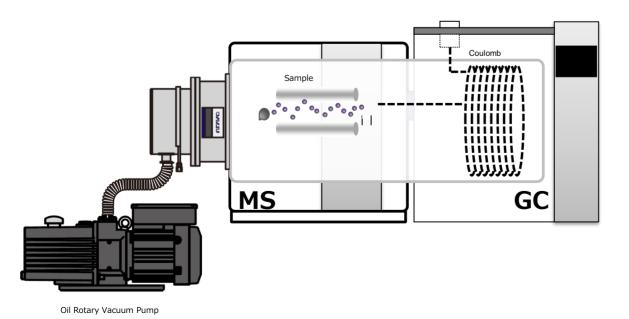


Oil Rotary Vacuum Pump

Scanning Electron Microscope



Gas chromatography-mass spectrometry



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Vacuum Pump ► Selection Guide

Selection Guide

															Unit	: Pa
Product	-10	-9	-8	-7	-6	-5	-4	-3	-2	-1	0	+1	+2	+3	+4	+5
														DA	P serie	s
														DA /	DAT se	ries
															C serie	
														DO	P serie	S
													DA	U / DT	'U serie	es
													DIS s	series		
Dry Vacuum Pump													GR s	eries		
									_R / H	r / Ur	R series	;				
											_		s serie		_	
											_		S serie		_	
											_				_	
											_		R serie	25	_	
												RDA :	series		_	
												_	VS s		_	
												_	PKS s	series	_	
											_	(G serie	S	_	
												GL	D seri	ies		
Oil Rotary Vacuum Pump											_	Gŀ	ID ser	ies	_	
											GCD series VD series			ies		
									PVD series							
											MB					
										MBS / VMR series PMB series Ver.D						
Mechanical Booster Pump																
												RC ser				
											РМВ-С	: serie	S			
					_	UTN	4-B se	ries	_	_	_					
Turbo Molecular Pump							UTM	I-MI s	eries							
						U	TM-M	S serie	es							
Oil Diffusion Ejector Pump									P	BL seri	es					
								PI	- FL ser	ies						
Oil Diffusion Pump							UL	_K ser	ies	_	_					
Cryo Pump						С	RYO-L									
Sputter Ion Pump				PS	ST seri							• •				
Sputter Ion Pump PST series																
Dry vacuum pump			D)ry va	cuum	pum	p		Po	wer s	aving	attac	hment	for D	Dry	
Multi-stage roots type					Sci	rew ty	/ре					vac	uum p	oump		
To the Inlet of Next Stage To t									Inle	+						
To the Inlet of Next Stage To the Next Stage				6	\checkmark	\mathcal{A}					itlet /	Valve Uni	t			
	inlet	7		Cylind	er		Tok	$\left(\right)$				4		_		
Inlet Cylinder	. (Å		50	Y			A		-, 			
					A	87		ſ			M	<i>۳</i> /۲			SHOCK	
BOTTS 12	æ			Inlet 🏉	6KS	X JA										
	JD			Quelat	N		Roto	or			C			•	~ •	
Rotor				Dutlet	VRL	~						ım Pump		ECO-SHO		
A clean pumping down because of	oil is no	t	t Gas in the groove partitioned by rotor and			partitio	nd					onary di atically r	y pump			

accessory that can dramatically reduce

pump exhaust line.

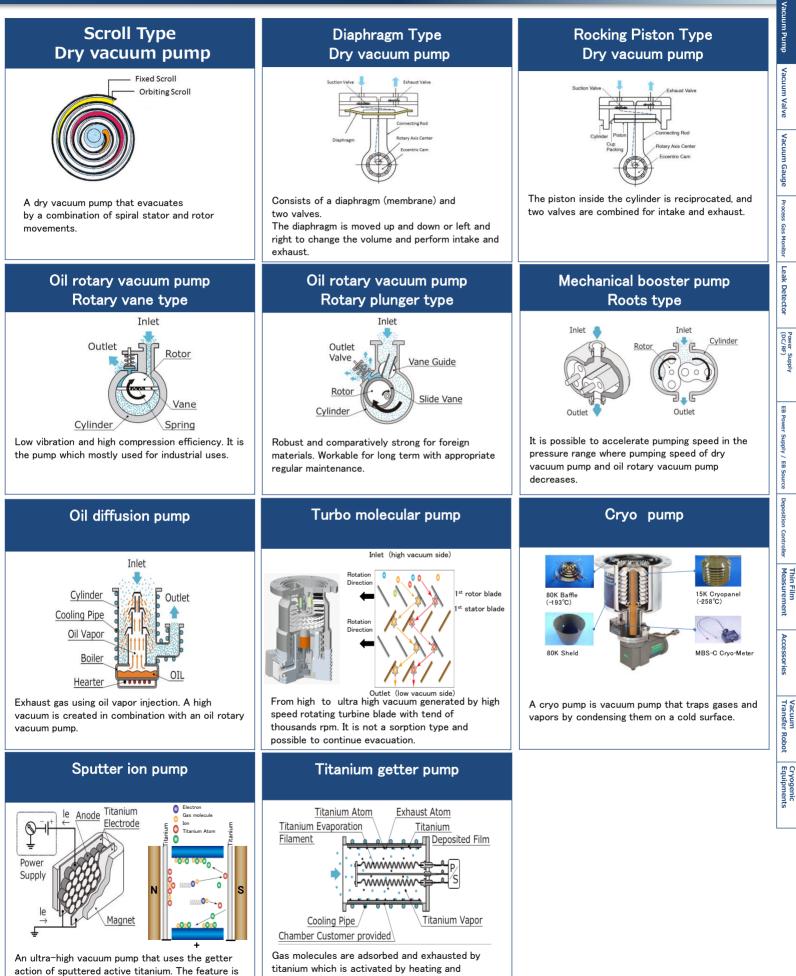
power consumption by attaching to the dry

A clean pumping down because oil is not used in the working chamber. It is effective for CVD and etching processes as there are no oil which react to active gases.

Vacuum Pump ►Selection Guide

Selection Guide

that there is no rotating part.



evaporating titanium directly.

Vacuum Pump Selection Guide

Selection Guide (Application Examples)

Vacuum pumps are also used for the following applications other than for the exhaust of gases such as for clean air.

Product	Model	Water vapor	Flammable gas	Dust	Sublimation gas
	LR series	√√	√	11	√
	HR / UR series		 ✓	11	111
ry Vacuum Pump	LS series	111	√		√
y vacuum rump	MS series	VV	✓	$\sqrt{\sqrt{2}}$	√
	CR series	V	✓		
	GR series	√√	✓	V	√
	VD series	<u></u>	✓ ✓	~~~~~	√
Rotary Vacuum Pump	VS series PVD series	11	✓ ✓ ✓	$\sqrt{}$	✓ ✓
	PVD series PKS series		 ✓	VV	√
		vv		~~~	V
Example o	f water vapor evad and problems	cuation	Example of c	combustible gas e and problems	evacuation
<problems> • Water condensation • Oil deterioration Ir</problems>	Cooling Water Trap	Outlet Oil-Water Separator	<problems> Oxygen interfusion (leak) Spark, heat flammability Explosion Explosion-Procement Motor</problems>	Inlet Conductive Piping N ₂ Dilution	Outlet Conductive Piping Oil Mist Tra N2 Dilution
· · ·	Oil rotation vacuum pump → Gas ba Dry vacuum pump → Gas ba Water cooling trap for the high temp Piping connection not to return wate of dusty gas evacu	oil water separator. llast. ierature water vapor. er to pump.	■Countermeasure in the Inlet port: ■Countermeasure in the Outlet port:	$\begin{array}{c} {\rm tra}\\ {\rm Dry\ vacuum\ pump\ } \rightarrow {\rm GR}\\ {\rm Conductive\ piping,\ dilution\ with\ N} \end{array}$	or, electrostatic belt, oil mis: p (helium tight type) . series. 12 purge. 12 purge.
	Dust Filter Inlet	Conductive Piping Oil Filtration	Problems> Deposition of reactive product (solid substance) 	and problems) Outlet Pipe Heating	Inlet Pipe Heating N ₂ Dilutio
Countermeasures in pumps: Countermeasure in the inlet port: ICountermeasure in the outlet port:	Oil rotation vacuum pump → Oil exc Dry vacuum pump → Purge gas from Dust trap. Prevention of explosion by overpres	filtration. n the Inlet port, gas ballast.	 Countermeasures in pumps: Countermeasure in the Inlet port: Countermeasure in the Outlet port: 	High temperature type dry vacu ballast gas (N2) introduction. Dilution gas introduction (N2 pu Heated piping.	
What	is sublimation gas	···?	What is	s helium tight typ	e…?
it is cooled or compressed. There are cases which make di sublimation gases generated du	solid state to gas state without t fficult to run vacuum pumps bec rring CVD and dry etching proces rring will change to solid materia	ause many of sses for electronic	It is one of optional selections of helium leak detector and has a below.		•• •
Prec	aution of IE3 moto	r	Wha	at is gas ballast…	•?
become higher than convention Especially for large pumps (5.5k conventional standard efficience	W or more), inrush current value	e tends to be higher than	Gas ballast is a countermeasure etc. Condensable gas is compr pump, condensed and changed inside in the case of dry vacuur condensable gas exhaust withou	essed through compression p to liquid which mixes with va n pump. In order to prevent t	process inside oil vacuun cuum pump oil. It is left his, it is possible to let

Accordingly, it may be necessary to review primary power supply equipment (circuit breaker or overload protection device), so please confirm power supply capacity when purchasing.

condensable gas exhaust without changing from air state to liquid state by opening gas ballast valve and introducing certain amount of air or nitrogen to the working chamber inside pump.

Notes

Vacuum Pump

Vacuum Valve

Vacuum Gauge

Process Gas Monitor

Leak Detector

Power Supply (DC/RF)

EB Power Supply / EB Source Deposition Controller

Thin Film Measurement

Accessories

Vacuum Transfer Robot

Cryogenic Equipment

Diaphragm Type DAP series

A small, high performance, low noise, low vibration diaphragm type dry vacuum pump.



DAP-6D

Model			DAP-6D	DAP-12S	DAP-9D-DC24	DAP-18S-DC24		
	[m ³ /h] 50Hz/60Hz		0.36 / 0.42	0.72 / 0.84	0.54	1.08		
Maximum pumping	[L/min]	50Hz/60Hz	6 / 7	12 / 14	9	18		
speed	[CFM]	50Hz/60Hz	2.1 x 10-1 / 2.45 x 10-1	4.2 x 10-1 / 4.9 x 10- 1	3.18 x 10−1	6.35 x 10-1		
		[Pa]	6.65 x 10 ³	24.0 x 10 ³	6.65 x 10 ³	24.0 × 10 ³		
Ultimate pressure [Torr]		50	180	50	180			
[mbar]		66.5	240 66.5		240			
Inlet port		·	Rc1/8					
Outlet port			Rc1/8					
Power supply [V]			Single phase 100	0 200 220 to 230	DC24V BrushlessDCMotor			
Motor [kW]			0.	.01	0.014			
Full load current [A]		0.5 (100V)	1.3 1.4				
Weight [kg]		1	.9	1.75				
Dimensions W x D x H [mm]			91 x 16	3 x 100.6	83.5 x 165 x 123.8			
Applicable standard				_	CE , TUV , cTUVus			

Diaphragm Type DA/DAT series

A small, high performance, low noise, low vibration diaphragm type dry vacuum pump.



DA-30D



DAT-50D







DA-41D

Model			DA-30D	DA-60S	DAT-50D	DAT-100S			
	[m ³ /h]	50Hz/60Hz	1.8 / 2.16	3.6 / 4.32	3 / 3.3	6 / 6.6			
Maximum pumping speed	[L/min]	50Hz/60Hz	30 / 36	60 / 72	50 /55	100 / 110			
pumping speed	[CFM]	50Hz/60Hz	1.05 / 1.26	2.1 / 2.52	1.75 / 1.93	3.5 / 3.85			
		[Pa]	6.7 x 10 ³	2.13 x 10 ³	3.3 x 10 ³	13.3 x 10 ³			
Ultimate pressur	e	[Torr]	50	16	25	100			
		[mbar]	67	21.3	33	133			
Inlet port			O.D.∮9 × (Female F	,	O.D. ϕ 12 × I.D. ϕ 8.5 (Female Rc1/4)				
Outlet port			$\begin{array}{c c} O.D. \phi 9 \times I.D. \phi 5 \\ (Female Rc1/4) \end{array} \qquad O.D. \phi 12 \times I.D. \phi 8.5 \\ (Female Rc1/4) \\ (Female Rc1/4) \end{array}$						
Power supply [\	/]			Single phase 10	0 200 220				
Motor [kW]				0.2					
Full load current	[A]		5.6 (100V , 50Hz) , 5.0 (100V , 60Hz)						
Weight [kg]				11					
Dimensions W x D x H [mm]			212 x 278	× 224.5	150 x 232 x 305				
Applicable standard			- CE,TUV,cTUVus Compatible mod						

*1) DAT-50DA (Three phase 200 to 220V) , DAT-100SA (Three phase 200 to 220V)

Model			DA-20DC	DA-40SC	DA-41D DA-81S		
[m ³ /h]		50Hz/60Hz	1.2 / 1.44	2.4 / 2.76	2.4 / 2.76	4.5 / 5.1	
Maximum pumping speed	[L/min]	50Hz/60Hz	20 / 24	40 / 46	40 / 46	75 / 85	
pumping speed	[CFM]	50Hz/60Hz	0.7 / 0.84	1.4 / 1.61	1.4 / 1.61	2.63 / 2.98	
		[Pa]	5.33 x 10 ³	19.9 x 10 ³	3.3 x 10 ³	13.3 x 10 ³	
Ultimate pressur	e	[Torr]	40	149	25	100	
		[mbar]	53.3	199	33	133	
Inlet port				× I.D. ϕ 5 Rc1/4)	O.D. ϕ 12 × I.D. ϕ 8 (Female G1/4)		
Outlet port				× I.D. ϕ 5 e Rc1/4)	O.D. ϕ 12 × I.D. ϕ 8 (Female G1/4)		
Power supply [\	/]		Single pl	nase 220	Single phase 220		
Motor [kW]			0.	06	0.1		
Current [A]			0	.8	1.2 (50Hz) ,	1.25 (60Hz)	
Weight [kg]		7	.2	10.3			
Dimensions W x D x H [mm]		118 x 242 x 178	128 x 242 x 178	157 x 336.5 x 217	181 x 336.5 x 217		
Applicable standard		CE,TUV Comp	atible models ^{*1}	<u> </u>			

(1) DA-20DA (Single phase 100V), DA-20DB (Single phase 115V), DA-20DC (Single phase 220V) DA-40SA (Single phase 100V), DA-40SB (Single phase 115V), DA-40SC (Single phase 220V)

Diaphragm Type DA series

A small, high performance, low noise, low vibration diaphragm type dry vacuum pump.



DA-60D



Model			DA-60D	DA-120S	DA-121DF	DA-241SF	
		50Hz/60Hz	3.6 / 4.32	7.2 / 8.64	7.2 / 8.7	14.4 / 15.6	
Maximum pumping speed	[L/min]	50Hz/60Hz	60 / 72 120 / 144		120 / 145	240 / 260	
speed	[CFM]	50Hz/60Hz	2.1 / 2.52	4.2 / 5.04	4.2 / 5.08	8.4 / 9.1	
		[Pa]	3.32 x 10 ³	13.3 x 10 ³	3.3 x 10 ³	16 x 10 ³	
Ultimate pressure		[Torr]	25	100	25	120	
		[mbar]	33.2	133	33	160	
Inlet port			Ο.D. φ 14 × I.D. α	⊅9(Female G3/8)	O.D. ϕ 16 × I.D. ϕ 12 (Female G1/2)		
Outlet port			Ο.D. φ 14 × I.D. α	∮9(Female G3/8)	O.D. ϕ 16 × I.D. ϕ 12(Female G1/2)		
Power supply [V]			Single p	hase 220	Single phase 220 to 230		
Motor [kW]			0).2	0.4		
Full load current [A]		2.4		2.3 (50Hz) 2.6 (220V) / 2.5(230V (60Hz)	2.5 (220V) / 2.4(230V , 50Hz) 2.7 (220V) / 2.6(230V , 50Hz)		
Weight [kg]		19			26		
Dimensions W x D	x H [mm]		156 x 358 x 238	162 x 358 x 238	193.5 x 411 x 285	207 x 411 x 285	
Applicable standard			-	_	CE,TUV,cTUVus Compatible models*1		

DA-121DF

*1) DA-121DC (100V), DA-121DD (115V), DA-121DE (200V), DA-121DF (220 to 230V) DA-241SC (100V), DA-241SD (115V), DA-241SE (200V), DA-241SF (220 to 230V) %All single phase

Diaphragm Type DAU/DTU series

High vacuum type diaphragm type dry vacuum pump.



DAU-20D

_		DAU-20D	DTU-20D (Chemical type)								
[m³/h]	50Hz/60Hz	1.2 / 1.38									
[L/min]	50Hz/60Hz	20 /	23								
[CFM]	50Hz/60Hz	0.7 /	0.8								
	[Pa]	200	0								
Ultimate pressure [To		1.5									
	[mbar]	2									
	•	$O.D.\phi 10 \times I.D.\phi 6$	(Female Rc1/8)								
		Ο.D.φ10 × I.D.φ6	(Female Rc1/8)								
		Single pha	ase 220								
		0.0	8								
]		0.7 / 0	0.72								
		7.5	ō								
x H [mm]		161 x 327 x 217					161 x 327 x 217				
andard CE,TUV,cTUVus Compatible models*1											
	[L/min] [CFM]] x H [mm]	[L/min] 50Hz/60Hz [[CFM] 50Hz/60Hz [[Pa] [[Torr] [[mbar] [[m³/h] 50Hz/60Hz 1.2 / [L/min] 50Hz/60Hz 20 / [CFM] 50Hz/60Hz 0.7 / [Pa] 200 [Torr] 1.5 [mbar] 20 0.D. \$\phi\$ 10 × 10.\$\phi\$ 0.0.\$\phi\$ 0.0.\$\phi\$ 0.0.\$\phi\$ 10.\$\phi\$ 10.\$\phi\$								

*1) DAU-20A (100V), DAU-20B (115V), DAU-20C (200V), DAU-20D (220V), DAU-20E (230V), DTU-20A (100V), DTU-20B (115V) DTU-20C (200V), DTU-20D (220V) , DTU-20E (230V) %All single phase

Diaphragm Type DTC series

Chemical type diaphragm type dry vacuum pump.



DTC-22



Model	_		DTC-22B	DTC-41E	DTC-60				
	[m³/h]	50Hz/60Hz	1.2 / 1.44	2.4 / 2.76	3.6 / 4.2				
Maximum pumping speed	[L/min]	50Hz/60Hz	20 / 24	40 / 46	60 / 70				
specu	[CFM]	50Hz/60Hz	0.7 / 0.84	1.4 / 1.61	2.1 / 2.45				
		[Pa]		1.0 x 10 ³	•				
Ultimate pressure		[Torr]		7.5					
[mbar]			10						
Inlet port			O.D.φ10 × I.D.φ	O.D. ϕ 14 × I.D. ϕ 9 (Female G3/8)					
Outlet port			Ο.D. <i>φ</i> 10 (Female	O.D. ϕ 14 × I.D. ϕ 9 (Female G3/8)					
Power supply [V]			Single phase 220	Single phase 220	Single phase 220				
Motor [kW]			0.05	0.1	0.2				
Full load current [A	J		0.6 (50Hz) / 0.72 (60Hz)	1.1	2.0 (50Hz) / 2.1 (60Hz)				
Weight [kg]			7.1 10.3		18				
Dimensions W x D	x H [mm]		142 x 288.5 x 202	158 x 340 x 242					
Applicable standard			CE , TUV , cTUVus*1						

Robot

Equipments

Rocking Piston Type DOP series

A large displacement, compact size rocking piston type dry vacuum pump.



DOP-40D



DOP-181SD



DOP-301SB

Model			DOP-40D	DOP-	30S		DOP-81SPF
	[m³/h]	50Hz/60Hz	2.4 / 2.64	4.8 / 5	.28		5.1 / 6.0
Maximum pumping speed	[L/min]	50Hz/60Hz	40 / 44	80 / 8	38		85 / 100
speed	[CFM]	50Hz/60Hz	1.4 / 1.61	2.8 / 3	.08		2.975 / 3.5
		[Pa]	1.2 x 10 ³	5.33 x	10 ³		[0.5 MPa]
Ultimate pressure [Maximum pressure	1	[Torr]	9	40			[3750 Torr]
Linaximum pressure	-1	[mbar]	12	53.3			[500 mbar]
Inlet port				Ο.D.φ9 × I.D.φ	5(Female R	c1/4)	
Outlet port			O.D. ϕ 9 × I.D. ϕ 5 (Female Rc1/4)				
Power supply [V]			Single phase 220			Single phase 220 to 240	
Motor [kW]				0.21			0.3
Full load current [A	\]		3.2 (100V ,	50Hz), 3.9(100V,60H;	<u>z</u>)	2.6 (220	V,50Hz)/3.0(220V,60Ha)
Weight [kg]				7			9
Dimensions W x D x H [mm]			160 x 270 x 179			168.5 x 288 x 181	
Applicable standard	b						
Model			DOD-181SD	DOP-301SB		0058	DOD-4205A

Model			DOP-181SD	DOP-301SB	DOP-400SB	DOP-420SA
	[m³/h]	50Hz/60Hz	10.8 / 12	18 / 19.8	24 / 26.4	25.2 / 27.6
Maximum pumping speed	[L/min]	50Hz/60Hz	180 / 200	300 / 330	400 / 440	420 / 460
specu	[CFM]	50Hz/60Hz	6.3 / 7	10.5 / 11.6	14 / 15.1	14.7 / 16.1
		[Pa]	10 x 10 ³	8 x 10 ³	12 x 10 ³	17.3 x 10 ³
Ultimate pressure		[Torr]	75	60	90	130
		[mbar]	100	80	120	173
Inlet port Outlet port			Rc3/8	$\begin{array}{c} \text{O.D.} \phi 16 \times \text{I.D.} \phi 12 \\ (\text{Female Rc1/2}) \end{array}$	Adapted tubing O.D. dia.16 (Female Rc1/2)	$O.D. \phi 26 \times I.D. \phi 20$ (Female Rc3/4)
Power supply [V] (*2)			Single phase 220	Three phase 200 to 230	Three phase 200 (50Hz / 60Hz) to 220V (60Hz)	Three phase 200 (50Hz / 60Hz) to 220V (60Hz)
Motor [kW]				0.4		0.55
Full load current [A]		2.6 (60Hz)	2.5 (60Hz)	2.4 (200V , 50Hz) 2.8 (200V , 60Hz) 2.7 (220V , 60Hz)	3.5 (200V , 50Hz) 3.1 (200V , 60Hz) 3.2 (220V , 60Hz)	
Weight [kg]		12	20	23	33	
Dimensions W x D	Dimensions W x D x H [mm]		172 x 266 x 235	315 x 443 x 231	316 x 434 x 231	310 x 523 x 253
Applicable standard				CE,TUV		

*1) DOP-181SB (Single phase 115V), DOP-181SC (Single phase 200V), DOP-181SD (Single phase 220V) DOP-181SE (Three phase 200 to 200V) are compatible models too.

Scroll Type DIS series

A large displacement, compact size scroll type dry vacuum pump.



DIS-252

Model			DIS-90	DIS-252	DIS-501			
	[m³/h]	50Hz/60Hz	5.4 / 6.48	12 / 14.4	30 / 36			
Maximum pumping speed	[L/min]	50Hz/60Hz	90 / 108	200 / 240	500 / 600			
speed	[CFM]	50Hz/60Hz	2.52 / 3.01	7.0 / 8.4	14.0 / 16.8			
		[Pa]	5.0	1.6	1.0			
Ultimate pressure		[Torr]	3.75 x 10 ⁻²	1.2 x 10 ⁻²	7.5 x 10 ^{−3}			
	[mt		5.0 x 10 ⁻²	1.6 x 10 ⁻²	1.0 x 10 ⁻²			
Inlet port			KF	25	KF40			
Outlet port			KF	16	KF25			
Power supply [V] Single phase Three phase				100 115 200 230				
			-	80 400 415 460				
Motor [kW]			0.15	0.4	0.6			
	Sing	te 50Hz	2.6 (100V) , 1.3 (200V) 1.6 (230V)	4.8 (100V) , 2.6 (200V) 2.4 (230V)	8.5 (100V) , 4.3 (200V) 3.9 (230V)			
	pha	se 60Hz	2.1 (100V) , 2.2 (115V) 1.1 (200 , 230V)	4.8 (100V) , 4.3 (115V) 2.8 (200V) , 2.4 (230V)	10 (100V) , 8.6 (115V) 4.8 (200V) , 4 (230V)			
Full load current [A	A] Thre phas		_	1.6 (200V) , 0.9 (380V) 0.9 (400V) , 1 (415V)	2.7 (200V) 1.57 (380V , 400V) 1.63 (415V)			
	pna	60Hz	_	1.9 (200V , 208V) 1.8 (230V), 1 (460V)	2.8 (200V) , 2.6 (208V) 2.5 (230V) , 1.47 (460V)			
Weight [kg]			14 (Single phase)	25 (Single phase) 23 (Three phase)	44 (Single phase) 38 (Three phase)			
Dimensions W x D	x H [mm]		Single phase 214 x 308 x 225	Single phase 264 x 397 x 338				
Applicable standard	b			CE , cTUV	•			

Air cooling Type CR series

Air-cooled dry vacuum pump. 4 models from16 to 300m³/hr.



CR60B

• Air-cooled roots-type vacuum pump. Oil is not used inside working chambers. Long-time stable operation is possible because there is no contact between its rotor and cylinder.

Model		CR16B	CR30B	CR	60B	CR300B	
	[m ³ /h]	16	30	5	5	300	
Maximum Pumping Speed	[L/min]	280	500	9:	20	5,000	
	[CFM]	9.8	17.6	32	2.4	176	
	[Pa]		3	•		0.5	
Ultimate pressure (*1)	[Torr]		2×10^{-2}			4 x 10 ⁻³	
	[mbar]		3 x 10 ⁻²			5×10^{-3}	
Inlet port		KF	KF	40	KF50		
Outlet port		KF		KF4	0		
Power supply [V] (*2)		1 phase 100 , 1 phas	1 phase 200	3 phase 200	3 phase 200		
Motor rated value [kW]		0.7	12	1	.5	3	
Cooling method			Ai	r cooled	·		
Gas ballast mechanism			Optio	nal Support			
Maximum water vapor tolerance (*3)		< 300	∣g/h		< 500 g	g/h	
Weight [kg]		35		4	8	100	
Dimensions W x D x H [mm]		180 × 52	210 x 5	50 x 430	280 x 594 x 595		
Applicable standard		CE , cTUVus					

*1) With OSLM gas ballast gas flow.

*2) When requesting for an estimate or ordering, specify power supply and voltage

*3) Maximum value when gas ballast is used. Make sure to use a gas ballast mechanism when pumping down water vapor.

Multi-Stage Roots Type RDA series

Dry vacuum pump achieves equivalent performance as oil rotary vacuum pump.



RDA-281HA

• Single phase or three phase power can be used with one model.

DO Material advected

Model		RDA-281HA	RDA-501HA				
	[m ³ /h]	16.8	30				
Maximum pumping speed	[L/min]	280	500				
	[CFM]	9.84	17.6				
	[Pa]	≦ 8.0 ×	× 10 ⁻²				
Ultimate pressure ^{*1}	[Torr]	≦ 6.0 x 10−4					
	[mbar]	≦ 8.0 x 10−4					
Inlet port		KF25					
Outlet port		KF25					
Power supply [V]		Single phase 100 to 115 / 200 to 240 Three phase 200 to 240					
Motor [kW]		0.72 + 0.01 DC Motor					
Full load current [A] Single phase / Three phase	9	10 (100 to 115V) , 5 (200 to 240V) / 5 (200 to 240V)					
Cooling		Air coo	bling				
Water Capability [g/h]		≦ 3	00				
Weight [kg]		38					
Dimensions W x D x H [mm]		180 × 520 × 377					
Applicable standard		CE , cTUVus Com	patible models ^{*2}				

*1) Flush Air Close

*1) Flush. Air Glose *2) RDA-281HA (Single phase 100 to 115V , 200 to 240V , Three phase 200 to 240V) RDA-501HA (Single phase 100 to 115V , 200 to 240V , Three phase 200 to 240V)

durna uur

Vacuum i Valve

Vacuum

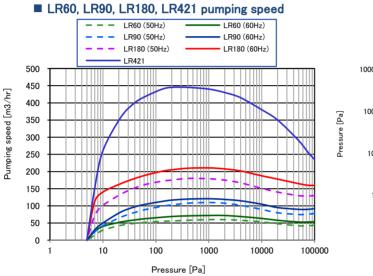
1 Gauge

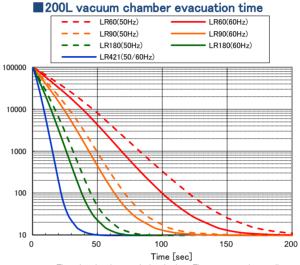
Process

Roots type LR series

For high speed chamber evacuation.







*The values herein are calculated values. These may vary in actuality depending on the emission of gas, etc.

• Suitable for high speed evacuation for large vacuum chamber because of high pumping speed at high pressure range is high.

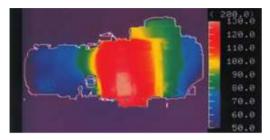
• Special surface processing which has high solidity and excellent corrosion resistant is used for their main parts. This reduces corrosion during pumping of corrosive gases.

Model			LR60	LR90	LR180	LR421-T	LR300	LR600	LR1200	LR1800	LR3601-R	
	5 3 4 7	50Hz	62	112	183	440	359	653	1,012	1,701	0.000	
	[m³/h]	60Hz	80	126	237	440	365	701	1,051	1,784	3,200	
Maximum	[L/min]	50Hz	1,030	1,860	3,100	7,333	5,980	10,900	16,900	28,350	53,333	
pumping speed	[L/min]	60Hz	1,333	2,100	3,950	7,333	6,080	11,700	17,500	29,700	53,333	
	[CFM]	50Hz	36	66	108	259	211	384	596	1001	1,883	
		60Hz	47	74	139	235	215	413	618	1048	1,000	
		[Pa]			5.0				6.7 x 10 ⁻¹			
Ultimate pre	ssure [Pa]	[Torr]		3.7	x 10 ⁻²				5×10^{-3}			
		[mbar]		5.0	x 10 ⁻²		6.7×10^{-3}					
Inlet port (o	ptional)		VG50 (KF40)	VG (KF		VG100	VG80 VG100 (KF80) (KF100)				VG150	
Outlet port			KF40 VG50 KF40				KF50					
Dry pump su	irface treatme	nt					with					
Mechanical t treatment	pooster pump	surface	n/a	n/a	n/a	n/a		wi	th		none	
Power supply	y [VAC](Hz)	3 phase	:	200 (50/60) , 220 (6	0)	180 to 240, 380 to 440 (50/60)		200 (50/60), 220 (60)		180 to 240, 380 to 440 (50/60)	
Current (at	max. load)[A]	7.0	11.8	20.6	48.5	9.6	19	24.2	39.8	82	
Cooling Wate	er Flow Rate [I	_/min]		>5.0		>4.0		>	5.0		>4.0	
NC		Shaft seal					5					
Nitrogen purge [SLM] Gas ballast							0 to 45					
Weight [kg]			180	245	335	415	251	371	403	553	660	
		W	378	428	528	668	378	47	70	528	668	
Dimensions [mm]		D	900	967	1,042	1,106	910	98	37	1,213	1,111	
		н	530	579	645	742	831	95	51	1,037	1,274	

*) When making a request for an estimate or ordering, notify us about the voltage.

Roots type HR / UR series

Whole working chambers inside the pump are uniformly kept at high temperature by utilizing excellent aluminium heat conductivity. Most suitable for processes such as CVD and dry etching processes for semiconductor, electronic devices and displays manufacturing, where sublimation gases are generated.



Whole working chambers inside the pump are uniformly kept at high temperature by utilizing excellent aluminum heat conductivity.

Experience in multi layer film process in liquid crystal low temperature polysilicon CVD production line.

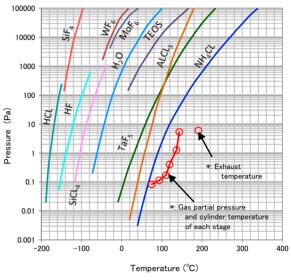
UR series is the best for processes where a large volume of sublimation gases occurs.



HR series Stuck by by-product in 3 months.



UR series After 12 months running, exceedingly a few byproducts are found but the pump could still run.



The left side of each curved line of the steam pressure indicates a solid (liquid) state while the right side indicates a gas state.
*) An example of process gas evacuation by HR series.

High temperature uniformity makes it possible to exhaust reactive gases (sublimation gases) generated in CVD, etching, etc. in gas state, and to restrain from being in solid state.
 Special surface processing which has high solidity and excellent in corrosion resistance is used for their main parts. This reduces corrosion during corrosive gas evacuation.

Model			HR60	HR90	UR421-T	HR300	HR600	UR600	HR1200	UR1200	UR1800	UR3601-TT
	[m3/h]	50Hz	62	112	410	359	653	653	1,012	1.010	1.701	2.700
	[m3/n]	60Hz	80	126	410	365	701	653	1,051	1,012	1,701	2,700
Maximum	D / 1 3	50Hz	1,030	1,860	0.000	5,980	10,900	10.000	16,900	10.007	00.050	45.000
pumping speed	[L/min]	60Hz	1,333	2,100	6,833	6,080	11,700	10,883	17,500	16,867	28,350	45,000
	[CFM]	50Hz	36	66	242	211	384	204	596	596	1.001	1.589
	[CFM]	60Hz	47	74	242	215	413	384	618	290	1,001	1,589
	[Pa]		5	.0	10	6.7 ×	10 ⁻¹	1.2	6.7 x 10 ⁻¹	1	.2	6.7 x 10 ⁻¹
Ultimate pressure (*1) [Torr]		[Torr]	3.7 ×	10 ⁻²	0.08	5.0 ×	< 10 ⁻³	0.01	5.0 x 10 ⁻³	0.	01	5.0 x 10 ⁻³
	[mbar]		5.0 x	10 ⁻²	0.1	6.7 ×	< 10 ⁻³	0.01	6.7 x 10 ⁻³	0.	01	6.7 x 10 ⁻³
Inlet port (optional)	nal) VG50 VG80 VG100 VG100 VG100 (KF80) VG100		VG150									
Outlet port			KF	40	VG50			KF	40			KF50
Dry pump surface treatment					•			with				
Mechanical booster p	ump surface tr	reatment		with								
Power supply [VAC]	(Hz)	3 phase	200 (50/60) , 220 (60)				200 (50/60)) , 220 (60)			180 to 240 (50/60) 380 to 440 (50/60)
Current (at max. load) [A]		7.3	11.8	52.5	8.1	13.8	17.3	18.9	22.4	34.9	68.3
Cooling Water Flow R	ate [L/min]						>5.0					> 4.0
		Shaft seal						5				
Nitrogen purge [SLM]		Gas ballast	0 to	o 45	0 to 195			0 to 45				0 to 195
Operation mode								3				
Weight [kg]			180	245	415	251	3	71	4	03	545	720
		w	378	428	668	378		4	70		528	668
Dimensions [mm]		D	900	967	1,106	910		987 (U	R:1054)		1,213	1,159
	н	530	579	742	831		9	51		1,037	1,274	
Applicable standard								CE (Option)				

*) When making a request for estimation/when ordering, please notify us about the voltage used. * The HR and UR series include the exhaust piping heater.

*) Please do not carry out continuous operation for the HR300, HR600, HR1200, UR1200, UR1800 and UR3601 at a pressure above 200Pa. There may be a case where the pump temperature may become abnormal and the interlock may activate. *) 1 Values only when flowing 5SLM shaft seal gas for HR series. The value when flowing 5SLM gas ballast gas for UR series.

acuum Pump

Vacuum Valve

Vacuum

1 Gauge

Process

Gas Monito

Leak Detector

(DC/RF

Iddne

Screw type LS series

Dry Pump which has both high pumping speed and low power consumption. Enable to select suitable pump from 4 different pumping speed model depending on the use condition.



Difference in pumping speed

·2 types for specific application

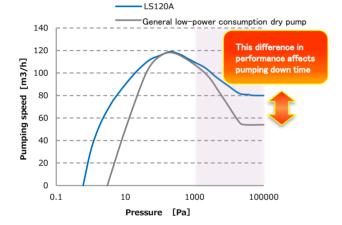
C Type:Clean process (LS***A-C)

Feature: Low power consumption model (with built-in ECO-SHOCK)

Sputtering/Vapor deposition/Lamination/Load lock/

Applications: For clean process such as air and N2

TMP backing pump etc.



Low power consumption

time can be drastically reduced

High pumping speed

ECO-SHOCK technology realizes low power consumption (C Type) Power consumption at the ultimate pressure is the industry-leading 0.6kW or less(LS120A-C)

High pumping speed at near atmospheric pressure, and pumping down

Low noise

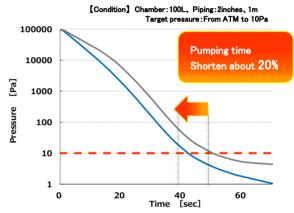
Built-in silencer achieves the noise level 61dB(A) or less

Low running-cost

No shaft sealing gas

 $\ensuremath{\mathscr{R}}$ Purge gas is available with L Type.

Influence on pumping down time



This data is a calculated value. It may differ from the actual condition under the influence of the discharge Gas etc.

L Type:Light process(LS***A-L)

Features:Light process model(with surface treatment and purge function) Applications:For light process such as steam and volatile liquid medicine Vacuum drying/Freeze drying/Ashing/ General industrial use etc.

	(C:C Type)		LS1	20A	LS3	00A	LS	600A	LS1	200A
Model	(L:LType)		С	L	С	L	С	L	С	L
		m³/h	1	20	38	30	6	00	1	000
Max.pumping speed		L/min	20	000	63	33	10	000	16666	
		CFM	71		22	23	3	53	5	588
		Pa	0.6 0.1							
Ultimate pressure		Torr	0.0	0.005 0.0008						
		mbar	0.0	0.006 0.001						
Power supply				200V Clas	s:3Phase,50/60	Hz,AC200-240V o	or 400V Class:3F	hase,50/60Hz,AC	380-480V	
Power consumption	Power consumption * 1 kV		0.6	2.0	1.0	2.5	1.3	2.6	1.3	2.7
Cooling water flow rate L/min			>	2.0		>4.0				
Purge gas flow rate *2 SLM		SLM	-	0~50	-	0~50	-	0~50	-	0~50
Max.water vapor tolerance * 3 kg/h		kg/h	-	1.5	-	1.5	-	1.5	-	1.5
Noise		dB(A)	61		61 62		62		64	
Inlet port			KF50(Horizontal)/VG50(Vertical)		ISO-	F-80	ISO-F-80		ISO-F-100	
Outlet port						KF	40			
Dimension	W×D×H	mm	311 × 6	39 × 307	311 × 63	39 × 537	311×6	39 × 563	311×6	339 × 563
Weight		kg	1	42	22	20	2	42	2	266
Applicable standard						CE, c	TUVus			
Standard accessory			Instruction manu	al(CD-R)、Power	connector, Water	proof cable clamp	, Remote connec	ctor, Guard for pov	wer connector	
Pump head option Power su			Power supply:20	ower supply:200V Class or 400V Class, Material of seal : FFKM(L type only)						
External option			MBP inlet flange	adaptor, Package	Exhaust port, Ea	rthquake-proof E	Bracket			
External option			LR compatible U	nit(Inlet, Remote)、	Purge gas valve					
* 1 · At ultimate pres	ouro (roforonao anh)			* 2 · Durgo goo in	not ovoilable wit				

* 1 : At ultimate pressure (reference only)

*3: Max.water vapor tolerance is a value when purge gas is used.

* 2 : Purge gas is not available with C Type.

*4:C type is not leak less.

18

Screw type MS series

MS series is a vacuum pump which is categorized as screw type dry vacuum pump. Corrosion resistance and powder exhaust are improved as process resistance model based on traditional LS series. This model is designed for the process of using corrosion gas and powder exhausting.



- High corrosion resistance Applying special surface treatment, corrosion resistance is equivalent to SUS.
- High powder exhausting
 Unique screw design is applied.

High motive power Applying ULVAC design high motive power motor. 6 times higher motive power than traditional model(LS120). Showing power at rebooting after powder exhausting

• Continuous exhausting in all pressure Realize Continuous running in all pressure from atmosphere to ultimate.

Model			MS120A	MS600A	MS1200A	
<u> </u>		m³/h	115	115 560		
Max.pumping speed		L/min	1917	9333	16333	
		CFM	68	331 580		
		Pa	0.6	0.	.1	
Ultimate pressure Torr			0.005	0.0	008	
		mbar	0.006	0.0	001	
Power supply			200V Class: 3Phase,50/60Hz,A	C200-240V±10% or 400V Class: 3Phase,5	50/60Hz,AC380-480V±10%	
Power consumption *1 kW		kW	2.4	3.1	3.1	
Cooling water flow rate L/min				>4.0		
Purge gas flow rate SLM				0~50		
Max.water vapor tolerand	ce * 2	kg/h		1.5		
Noise		dB(A)	61	62	64	
Inlet port			KF50(Horizontal) / VG50(Vertical)	ISO-F-80	ISO-F-100	
Outlet port				KF40		
Dimension	W×D×H	mm	311×945×536	311×945×563	311×945×563	
Weight	•	kg	139	241	264	
Applicable standard				CE、 cTUVus		
Standard accessory			Quick manual, Power connector, Wate	rproof cable clamp , Remote connector, G	Guard for power connector, Silencer	
Pump head option			Power supply: 200V Class or 400V Class, Material of seal: FKM or FFKM			
External option			Package Exhaust port, Earthquake-proof Bracket, LR compatible Unit(Inlet, Remote), Purge gas valve			

* 1: At ultimate pressure (reference only)

* 3: Max.water vapor tolerance is a value when purge

gas is used.

i Pu mj

Roots type with General-purpose Motor GR series

Simplified designed for general industrial applications based on long time experience of the LR series. • Multi-voltage motor.



GR90A

 General-purpose 	e inductior	n motor. Special	of motor is available (RFQ).					
Model			GR60A	GR90A	GR180A			
	[m ³ /h]	50Hz/60Hz	62 / 80	112 / 126	183 / 237			
Maximum pumping speed	[L/min]	50Hz/60Hz	1,030 / 1,333	1860 / 2100	3100 / 3950			
speed	[[CFM]	50Hz/60Hz	36.4 / 47.1	65.7 / 74.2	109.5 / 139.5			
		[Pa]		5.0				
Ultimate pressure (*1)		[Torr]	3.7 x 10 ⁻²					
		[mbar]	5.0 x 10 ⁻²					
Inlet port (optional)			VG50 (ISO63F)	VG50 (ISO63F) VG80 (ISO80F)				
Outlet port				KF40				
D 1 (• • •	50Hz	Multi voltage motor : AC200 to 240V / AC380 to 415V					
Power supply (*	⊧2)	60Hz	Multi voltage motor : AC200 to 240V / AC380 to 460V					
Motor rated value [kW]		2.2	3.7	7.5			
Cooling water flow	rate [L/min]]		> 5.0	-			
NIN FOLM		Shaft seal		5 (*3)				
Nitrogen gas [SLM]		Gas ballast		Optional				
Weight [kg]			128	188	268			
Maximum water va	oor toleranc	e (*4)	< 500 g/h	< 1,000 g/h	< 3,000 g/h			
External dimensions W x D x H [mm]			320 x 1000 x 442	380 x 1100 x 495	470 x 1300 x 582			

. . .

*1) With 5SLM shaft seal gas flow. *2) When requesting for an estimate or ordering, specify power supply and voltage. *3) Nitrogen gas (shaft seal) is constant at 5SLM. *4) Maximum value when gas ballast is used. Make sure to use a gas ballast mechanism when pumping down water vapor.

Silencer for Dry Vacuum Pumps RS series





Model	Anglia bla sama madal	Accessories					
Model	Applicable pump model	Clamp	Outer ring	Connection piping	Stay		
RS-01 kit A	CR60B,LR60,90,300, GR60A,90A	1	1	n/a	n/a		
RS-01 kit B	LR600,1200	2	2	1	1		
RS-01 kit C	CR300B,GR180A	2	2	1	1		
RS-01 kit D	CR16B,30B	1	1	1	n/a		
RS-02 kit A	LR180,(LR60,90,300)	2	2	1	1		
RS-02 kit B	LR1800(LR600,1200)	2	2	1	1		
RS-03 kit A	LR421(-T)	1	1	1	1		
RS-03 kit B	LR3601(-T/TT/R/TR/TTR)	3	3	1	1		
EFS-11-NW25/2/2516 (*1)	11-NW25/2/2516 (*1) CR16B,30B		1	n/a	n/a		
EFS-19-NW40/1 (*1)(*2)	CR60B,300B	1	1	n/a	n/a		

*1) Do not use for harmful gas. *2) Open type which is not connectable to rearward piping.

Power Saving Attachment for Dry Vacuum Pump ECO-SHOCK

An attachment which reduces electrical power consumption by connecting to dry vacuum pumps.

Patent Registered

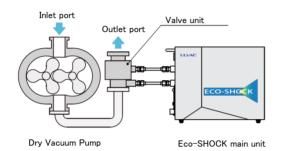


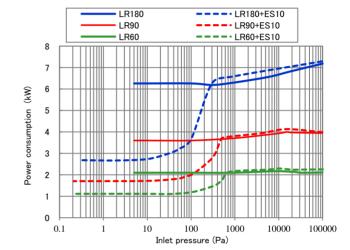
• Electrical power consumption can be reduced by connecting to dry vacuum pumps. It is possible to connect to any dry vacuum pump which there is not any problem to reduce pressure at its outlet port.

- Select the ES4A for frequently repetitive pumping down of large vacuum chamber and the pumps with an high pumping speed near atmospheric pressure.
 - * Note: Do not use for any application where pump takes combustible, burnable and toxic gases, etc. and solid materials and liquids.

■ Electric power reduction efficiency of the ECO-SHOCK ES10

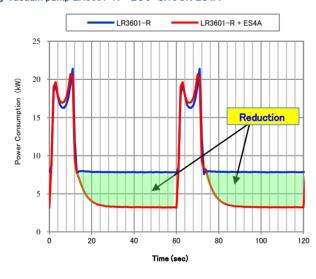
■ How to connect the ECO-SHOCK

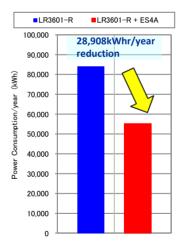




Electrical power consumption effect

300L chamber repeat pumping down by 60 sec tact time. Dry vacuum pump LR3601-R + ECO-SHOCK ES4A





Model		ES10	ES4A	
	Specifications	Single phase AC100 to 220V ($\pm 5\%$) 50/60Hz	Single phase AC200 to 220V ($\pm 5\%$) 50/60Hz	
Power Supply	Maximum apparent power [VA]	250	600	
Consumed electrical power [W]		65	400	
External	Main unit [mm]	175 x 330 x 240	250 x 515 x 373 (250 x 515 x 378) (*1)	
dimensions W x D x H Valve unit [mm]		dia. 66 x 110 (KF40)	Not included (Optional)	
Connection	port	3/8 inch tube connector	16mm tube connector	

* The valve unit is not included in the ES4A and sold separately. Select it in conformity with the pump to be connected.

Vacuum Pump

Single Stage Oil Rotary Vane type G series

High performance, low noise, low vibration directly connected oil rotary vacuum pump.

• This pump has many achievements. Inexpensive vacuum pump.







Model			G-5SA	G-25SA	G-50SA	G-101S	
Maximum pumping speed [m ³ /h] 50Hz		50Hz	0.3 (5/0.175)	1.20 (20/0.7)	3.0 (50/1.75)	6.0 (100/3.5)	
(L/min/C	FM)	60Hz	0.36 (6/0.21)	1.44 (24/0.84)	3.6 (60/2.1)	7.2 (120/4.2)	
Ultimate	pressure [Pa](Torr/mbar)	GP Close	100 (0.75/1)	9.3 (7.0x10 ⁻³ /9.3x10 ⁻³)	9.3 (7.0x10 ⁻³ /9.3x10 ⁻³)	9.3 (7.0x10 ⁻³ /9.3x10 ⁻³)	
	Output [kW](Poles)		0.04 (4)	0.1 (4)	0.2 (4)	0.4 (4)	
	Voltage [V]	50Hz	Single phase 100	Single phase 100 200	単相 100 200	Single phase 100 200	
Motor	voltage [v]	60Hz	220 to 230	220 to 230	220 to 230	Single phase 100 200	
	Full lood sumant [A]	50Hz	0.92 (100V)	3.7 (100V)	5.6 (100V)	6.4 (100V)	
	Full load current [A]	60Hz	0.73 (100V)	3.0 (100V)	4.8 (100V)	5.9 (100V)	
Oil			SMR-100				
Oil capa	acity [L]		0.23 0.23 0.36		1.2		
Cooling			Air cooled				
Inlet por	t		Ο.D.φ12 × Ι.Dφ6	O.D.φ12 × I.Dφ6	0.D.φ12 × I.Dφ6	O.D.φ12 × I.Dφ6	
Outlet port				Exhaust cap (G1)			
Weight [kg]		4.5	8.5	11.0	22.3		
Dimensions W x D x H [mm]			130 × 203 × 159.5	156 × 284 × 199.5	156 × 341 × 199.5	234 × 500.5 × 264	
Applicab	le standard		-	-	-	-	

* Select the motor voltage specification from among several specifications.

Two Stage Oil Rotary Vane type G series

High performance, low noise, low vibration directly connected oil rotary vacuum pump.



- · This pump has many achievements. Inexpensive vacuum pump.
- · Small and easy to carry. Suitable for embedding in equipment.
- · These vacuum pumps are safe because they have built-in manual reset thermal protectors.

Structure					
Single stage	Double stage				
Rotary vane	Rotary piunger				
Direct driven	Belt driven				
Air cooled	Water cooled				
Forced oil circulation	Differential pressure oil circulation				
Oil back flow prevention mechanism	Back flow prevention valve				

Structure

Differential pressure oil

circulation

Single stage

Rotary vane

Direct driven

Air cooled



G-50DA



Model			G-5DA	G-10DA	G-20DA	G-50DA	G-101D	
Maximum pumping speed [m ³ /h] 50Hz		50Hz	0.3 (5/0.175)	0.60 (10/0.35)	1.20 (20/0.7)	3.0 (50/1.75)	6.0 (100/3.5)	
(L/min/Cl	FM)	60Hz	0.36 (6/0.21)	0.72 (12/0.42)	1.44 (24/0.84)	3.6 (60/2.1)	7.2 (120/4.2)	
Ultimate	pressure [Pa](Torr/mbar)	GP Close	6.7 (5.0x10 ⁻² /6.7x10 ⁻²)	1.3 (9.8x10 ⁻³ /1.3x10 ⁻²)	1.3 (9.8x10 ⁻³ /1.3x10 ⁻²)	1.3 (9.8x10 ⁻³ /1.3x10 ⁻²)	0.67 (5.0x10 ⁻³ /6.7x10 ⁻³)	
	Output [kW](Poles)	_	0.04 (4)	0.06 (4)	0.1 (4)	0.2 (4)	0.4 (4)	
Voltage [V]		50Hz 60Hz	Single phase 100 115 220	Single phase 100 115 220	Single phase 100 200 220 to 230	Single phase 100 200 220 to 230	Single phase 100 200	
		50Hz	0.92 (100V)	1.38 (100V)	3.7 (100V)	5.6 (100V)	6.4 (100V)	
	Full load current [A]	60Hz	0.73 (100V)	1.22 (100V)	3.0 (100V)	4.8 (100V)	5.9 (100V)	
Oil			SMR-100					
Oil capa	city [L]		0.18	0.25	0.18	0.26	0.8	
Cooling			Air cooled					
Inlet port			O.D.φ12×I.Dφ6	O.D.φ18×I.Dφ14	O.D.φ18×I.Dφ14	O.D.φ18×I.Dφ14	O.D.φ27×I.Dφ20	
Outlet port			Exhaust cap (G1)					
Weight [kg]		5.0	5.5	9.0	11.0	23.1		
Dimensio	ons W x D x H [mm]		130×203×159.5	130×228×165	156×295.5×199.5	156×341×199.5	234×500.5×264	
Applicab	le standard		-	-	-	-	-	

% Select the motor voltage specification from among several specifications.

• Small and easy to carry. Suitable for embedding in equipment. · These vacuum pumps are safe because they have built-in manual reset thermal protectors.

22

Two Stage Oil Rotary Vane type GLD series

High performance, low noise, low vibration directly connected oil rotary vacuum pump.

when it is stopped due to a power failure.

• The exhaust speed is stable due to the installation of the forced oil supply mechanism. · The backflow prevention mechanism prevents oil from flowing back to the vacuum chamber



GLD-137CC

Structure				
Single stage	Double stage			
Rotary vane	Rotary piunger			
Direct driven	Belt driven			
Air cooled	Water cooled			
Forced oil circulation	Differential pressure oil circulation			
Oil back flow prevention mechanism	Back flow prevention valve			

Model			GLS-051	GLD-051	GLD-040	E	
Maximur	m pumping speed 50Hz		aximum pumping speed 50Hz 3.0 (50/1.75) 2.4 (40/1.4		2.4 (40/1.4)	Valve	
[m ³ /h] (_/min/CFM)	60Hz	3.6 (6	0/2.1)	2.88 (48/1.68)	l e	
Ultimate	pressure [Pa] (Torr/mb	ar)	9.3 (7.0x 10 ⁻² /9.3x 10 ⁻²) 6.7 x 10 ⁻¹ (5.0x 10 ⁻³ /6.7x		/6.7x 10 ⁻³) GP Close		
	Output [kW](Poles)			0.2 (4)		Vac	
	N/ K D.0	50Hz	Qia ela ela esta 400.000.000 (c. 000	Single phase 100 200 220-230		Vacuum	
	Voltage [V]	60Hz	Single phase 100 200 220 to 230	Three phase 200-240 / 380-460	Single phase 100 to 120 / 200 to 240	n G	
Motor	Votor Full load current [A] 60Hz		5.6 (100V) 4.8 (100V)		4.2 (100V) / 4.4 (110V) 4.6 (115V) / 5.05 (120V) 2.1 (200V) / 2.2 (220V) 2.3 (230V) / 2.6 (240V) 3.6 (100V) 4.2 / 3.4 (110V) 3.4 (115V) / 3.6 (120V) 1.8 (200V) / 1.7 (220V) 1.7 (230V) / 1.8 (240V) R-2	Gauge Process Gas Monitor	
Oil capa	city [1]		0.4 ~ 0.7	0.5 ~ 0.8	0.55 ~ 0.8	-	
Cooling	city [L]		Air cooled				
Inlet port				KF25		Leak De	
Outlet port				Detector			
	Veight [kg]		12.9	13.9	16	Ę	
	Dimensions W x D x H [mm]		165.5 x 361 x 222.5	165.5 x 395 x 222.5	150 x 427 x 227.5		
Applicable standard		-	CE, TUV, cTUVus	(DC)			

					·			RF
Model			GLD-137AA	GLD-137CC	GLD-202AA	GLD-202BB	GLD-280A	/RF)
Maximu	m pumping speed[m ³ /h]	50Hz	8.1 (135	5/4.725)	12 (20	00/7.0)	16.8 (280/9.8)	- 3
(L/min/C	FM)	60Hz	9.72 (16	62/5.67)	14.4 (2	240/8.4)	20.2 (336/11.76)	-
Ultimate	pressure [Pa] (Torr/mb	ar)		6.7	x 10 ⁻¹ (5.0x 10 ⁻³ /6.7x 10 ⁻³) GP C	Close		
-	Output [kW](Poles)		0.4 (4)	0.4 (4)	0.55 (4)	0.55 (4)	0.75 (4)	EB
	Veltage D/I	50Hz	Three phase	Single phase	Three phase	Single phase	Three phase	oowe
	Voltage [V]	60Hz	200 to 240 / 380 to 460	100 to 120 / 200 to 240	200 to 240 / 380 to 460	100 to 120 / 200 to 240	200 to 240 / 380 to 460	St. 21
Moto		50Hz	2.1 (200V) / 2.2 (220V) 2.3 (230V) / 2.5 (240V) 1.3 (380V) / 1.3 (400V) 1.4 (415V)	6.8 (100 ∼ 120V) 3.5 (200 ∼ 240V)	2.9 (200V) / 3.1 (220V) 3.3 (230V) / 3.6 (240V) 1.8 (380V) / 1.9 (400V) 2.0 (415V)	8.2 (100 ∼ 120V) 4.1 (200 ∼ 240V)	3.6 (200V) / 3.8 (220V) 4.0 (230V) / 4.2 (240V) 2.2 (380V) / 2.2 (400V) 2.4 (415V)	upply / EB Sou
	Full load current [A]	60Hz	2.0 (200V) / 1.9 (220V) 1.9 (230V) / 2.0 (240V) 1.1 (380V) / 1.1 (400V) 1.15 (440V) / 1.2 (460V)	5.8 (100 ~ 120V) 2.9 (200 ~ 240V)	2.7 (200V) / 2.6 (220V) 2.7 (230V) / 2.7 (240V) 1.5 (380V) / 1.6 (400V) 1.6 (440V) / 1.7 (460V)	7.9 (100 \sim 120V) 3.9 (200 \sim 240V)	3.2 (200V) / 3.2 (220V) 3.2 (230V) / 3.3 (240V) 1.8 (380V) / 1.9 (400V) 2.0 (440V) / 2.1 (460V)	arce Deposit
Oil				SMF	R-100		ULVOIL R-72	ion
Oil capa	acity [L]		1.	.0	1	.1	0.7 ~ 1.1	Cont
Cooling					Air cooled			
Inlet por	t			KF25				
Outlet port			Exhaust cap (G1)					
Weight [kg]		26	29	29	31	34.5	Measurem
Dimensi	ons W x D x H [mm]		170 x 485.5 x 240	170 x 487.5 x 249.5	170 x 513.5 x 240	170 x 515.5 x 249.5	181 x 536 x 269	ren
Applicat	ole standard		CE, TUV	CE, TUV, cTUVus	CE, TUV	CE, TUV, cTUVus	CE, TUV	nent

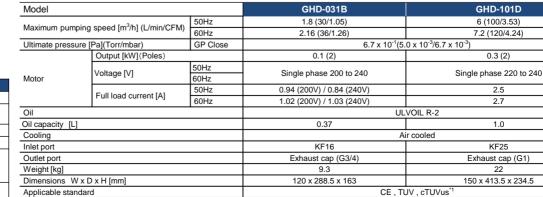
GHD series Two Stage Oil Rotary Vane type

Oil rotary vacuum pump with magnet coupling structure.



· Wide range voltage motor and correspond to CE, cTUVus.

· Integrated check valve below the inlet port for backflow prevention.



*1) GHD-031B (200 to 240V) , GHD-101B (115 to 120V) , GHD-101C (200V) , GHD-101D (220 to 240V) are compatible models too. XAII single phase

GHD-031A

Structure				
Single stage	Double stage			
Rotary vane	Rotary plunger			
Direct driven	Belt driven			
Air cooled	Water cooled			
Forced oil circulation	Differential pressure oil circulation			
Oil back flow prevention mechanism	Back flow prevention valve			

Accessories

Vacuum Transfer

Robot

Cryogenic Equipmen

ment

uum Pump

Vac

Two Stage Oil Rotary Vane type GCD series

Maximum pumping speed [m³/h]

Model

A chemical type oil rotary vacuum pump with surface treatment on the gas contact part.

50Hz

- Wide range voltage motor adopted.
- Connectable to Oil Filtration Device



GCD-136X

(L/min/CFM) 60Hz		60Hz	3.6 (60/2.1)	9.72 (162/5.67)	14.4 (240/8.4)	
Ultimate pressure [Pa](Torr/mbar)			6.7 x 10 ⁻¹ (5.0 x 10 ⁻³ /6.7 x 10 ⁻³)			
	Output [kW](P	oles)	0.2 (4)	0.4 (4)	0.7 (4)	
		50Hz	Qiasta shasa 000 ta 000	Circle share 000	Qiarla abasa 200	
Motor	Voltage [V]	60Hz	Single phase 220 to 230	Single phase 220	Single phase 220	
	Full load	50Hz	2.4 (100V) / 2.5(230V)	3.6	3.6	
	current [A]	60Hz	2.0 (220V) / 2.0(230V)	2.8	3.3	
Oil			SO-M			
Oil capacity [L]			0.5 to 0.8	1.0	1.1	
Cooling			Air cooled			
Inlet port			KF25			
Outlet port				KF25		
Weight [kg]		14.1	25.4	26.6		
Dimensions W x D	x H [mm]		165.5 x 419 x 222.7	170 x 493 x 241.1	170 x 509.5 x 241.1	
Applicable standard				_		

GCD-051X

3 (50/1.75)

GCD-136X

8.1 (135/4.73)

GCD-201X

12 (200/7)

Structure				
Single stage	Double stage			
Rotary vane	Rotary plunger			
Direct driven	Belt driven			
Air cooled	Water cooled			
Forced oil circulation	Differential pressure oil circulation			
Oil back flow prevention mechanism	Back flow prevention valve			

Double Stage Rotary Vane type VD series Ver. C

With high efficiency (IE3) full multi-voltage motor developed by ULVAC. For various kinds of application.





Structure					
Single stage Double stage					
Rotary vane	Rotary plunger				
Direct driven	Belt driven				
Air cooled	Water Cooling				
Forced oil circulation	Differential pressure oil circulation				
Oil back flow prevention mechanism	Back flow prevention valve				
Op	otion				
Type. F: Flu	orine Oil				
Type. N: NBR(Nitrile rubber)					
Type. B: Silicon & Nitrile rubber					
Type. H: He	lium tight				

- Single kind high efficient (IE3) full multi-voltage covers wide range voltage from 200 to 240V / 380 to 460V.

- Forced oil circulation makes pumping performance stable even near atmospheric pressure. Suitable for repetitive and consecutive operation between atmospheric and vacuum.
- Various specification , ${\sf F}$, ${\sf N}$, ${\sf B}$ and ${\sf H}$ are available in addition to standard model.

Model			VD30C	VD40C	VD60C	VD90C	
Designed pumping s	peed [m ³ /h]	50Hz	30 (500 / 17.7)	40 (670 / 23.5)	60 (1,000 / 35.3)	90 (1,500 / 53)	
(LPM / CFM)		60Hz	36 (600 / 21.3)	48 (800 / 28.3)	72 (1,200 / 42.4)	108 (1,800 / 63.6)	
Ultimate pressure [Pa] Gas ballast port closed (Torr / mbar)				0.67 (5 x 10 ⁻³ ∕6	.7 x 10 ⁻³)		
	Output [kW] (Poles)	1.5 (4)	1.5 (4)	2.2 (4)	3.7 (4)	
Motor	Matha and DVI	50Hz	200 to 240 / 380 to 415 (Multi-Voltage Motor)				
	Voltage [V]	60Hz		200 to 240 / 380 to 460 ((Multi-Voltage Motor)		
Standard Oil			ULVOIL R-72				
Oil capacity [L]			1.0 to 2.5 2.5 to 4.0				
Cooling method			Air cooled				
Inlet port (optional)			VG40 (KF40) VG50 (KF50 or ISO63F)				
Outlet port (optional)			VG40 (K	F40)		
Weight [kg]			58	60	90	113	
Dimensions W x D >	(H [mm]		210 × 660 × 324	210 x 680 x 324	280 x 761 x 371	280 x 831 x 371	
Applicable standard			CE, cTUVus				
Type F			0	0	0	0	
Type N			0	0	n/a	n/a	
Туре В			0	0	n/a	n/a	
Туре Н			0	0	0	0	

Туре	Target model	Spec	Remarks
F	VD series	J60F (Fluorine Oil)	Flammable Gas Countermeasures. Countermeasures against oil degradation by oxidizing gases.
Ν	VD series	NBR (Nitrile rubber)	When evacuating gases or solvents that FKM (fluorine rubber) is not resistant to.
К	PVD series PKS series	FKM(Fluorine rubber)	When the pump is used at high-temperature. For continuous vacuum evacuation at high pressure.
В	VD series	Silicone rubber + NBR (Nitrile rubber) Structure to put new oil into oil seal. Surface treatment to rotor shaft.	Brake fluid filling process.
R	VS1501/VS2401 PKS series	Cooling water pipe : SUS	Cooling water pipe for corrosion prevention.
Н	VD series PVD series PKS series	He leak test. Structure to put new oil into oil seal.	Countermeasures to Flammable Gases. Helium tight.
Z	PVD series	Large Oil Tank.	Increase the amount of oil and extend the oil change cycle.

acuum Pump

Single Stage Oil Rotary Vane type VS1501 /VS2401

Lower ultimate pressure even it is single stage oil rotary vane pump.



Main applications

- Evaporation, sputtering system
 Vacuum absorption, transportation, moulding
- Vacuum absorption, transportation, mould
- Vacuum impregnation, casting
 Vacuum drying, freeze drying
- Vacuum urying, freeze ury
- Leak test system

Structure						
Single stage	Double stage					
Rotary vane	Rotary plunger					
Direct driven	Belt driven					
Air cooled	Water cooled					
Forced oil circulation	Differential pressure oil circulation					
Oil back flow prevention mechanism	Back flow prevention valve					
Option						
Type. R: Anti-rust cooling water system						

- High efficiency multi voltage motor (IE-3) which enable to use 200–240 / 380–460 V.
- Lower vibration structure compared with Rotary plunger model. Suitable when installing at upper floor.
- Forced oil circulation makes pumping performance stable even near atmospheric pressure. Suitable for repetitive and consecutive operation between atmospheric and vacuum.

Model			VS1501	VS2401			
Designed pumping speed [m³/h] 50Hz (LPM / CFM) 60Hz		50Hz	150 (2,500 / 88.2) 240 (4,000 / 141.2)				
		60Hz	180 (3,000 / 105.9) 288 (4,800 / 169.4)				
Ultimate pressure [Pa](Torr / mbar)	Gas ballast po	rt closed	5. (3.9×10 ⁻² /				
	Output [kW] (I	Poles)	5.5 (4)	7.5 (4)			
Motor	N 10 D.C.	50Hz	200 to 240 / 380 to 415 (Multi-Voltage Motor)				
	Voltage [V]	60Hz	200 to 240 / 380 to 460 (Multi-Voltage Motor)				
Oil			ULVOIL R-72				
Oil capacity [L]			8.0 to	o 10.5			
Cooling method			Water cooled				
Inlet port (optional)			VG80 (ISO80F)				
Outlet port (optional)			VG50 (KF50 or ISO63F)				
Weight [kg]			232 271				
Dimensions W x D x H [mm]			333 x 941 x 460 333 x 1061 x 460				

Single Stage Oil Rotary Vane type VS300A-W

VS300A-W is classified as a single stage oil rotary vane pump.

Smallest footprint in the class and allows the direct mounting of Mechanical booster pump.





PMB1200D +VS300A-W

Stru	Structure							
Single stage	Double stage							
Rotary vane	Rotary plunger							
Direct driven	Belt driven							
Air cooled	Water cooled							
Forced oil circulation	Differential pressure oil circulation							
Oil back flow	Back flow prevention							
prevention mechanism	valve							

Main applications:

- Evaporation, sputtering system
- Vacuum Heat treatment furnace systems
- Vacuum dryingLeak test system

- Smallest footprint in the class $\,:\,$ Compact design of 874 \times 404mm.
- Mechanical booster pump allowed to be directly mounted : MBP mount kit allows a direct mounting without frame.
- Built-in oil mist separator : Oil mist separator is build-in in standard.

Model VS300A-W Designed pumping speed $[m^3/h]$ (LPM / CFM) 50Hz 250 (4,166 / 147.0) 60Hz 300 (5.000 / 176.5) Ultimate pressure [Pa] (Torr / mbar) Gas ballast port closed 15 (1.1x10⁻¹/1.5x10⁻¹) Output [kW] (Poles) 7.5 (4) Motor 50Hz 200 to 240 / 380 to 415 (Multi-Voltage Motor) Voltage [V] 60Hz 200 to 240 / 380 to 460 (Multi-Voltage Motor) Oil ULVOIL R-72 Oil capacity [L] 10.0 to 15.0 Cooling method Water cooled Inlet port (optional) DN 63 ISO-F Outlet port (optional) G2 Weight [kg] 270 Dimensions W x D x H [mm] 404 x 871 x 585 Overseas safety standards CE、cTUVus

Large Size Single Stage Oil Rotary Vane VS650B / VS750B

Large size and low vibration single stage oil rotary vane pump.





- Selectable from air and water cooled type. Oil cooler is used for oil temperature cooling for a air cooled model.
- Equipped with a cartridge-type oil mist filter inside the oil tank.
- VS650B-WL: Low noise (72dB) pumps has been added to the lineup.

Stru	cture
Single stage	Double stage
Rotary vane	Rotary plunger
Direct driven	Belt driven
Air cooled	Water cooled
Forced oil circulation	Differential pressure oil circulation
Oil back flow prevention mechanism	Back flow prevention valve

Main applications:

- Evaporation, sputtering system
- Vacuum furnace
- Leak test system
- Large vacuum chamber evacuation.

Model		VS650B-A	VS650B-W	VS750B-A	VS750A-W	VS650B-WL		
Design Exhaust Speed [m³/h] 50Hz (LPM / CFM) 60Hz		650 (10,833 / 383)		750 (12,5	750 (12,500 / 441)			
		60Hz	750 (12,500 / 441)		n,	′a	600 (10,000 / 353)	
Ultimate pressure [Pa] (Torr / mbar)	Gas ballast p	oort closed			8 (6x10 ⁻² × 8x10 ⁻²)			
	Output [kW]	(Poles)	22 (4)					
Motor	Voltage [V]	50Hz		200 to 2	240 / 380 to 415 (Multi-Voltage Motor)			
		60Hz	200 to 240 / 380 to 46	0 (Multi-Voltage Motor)	n/a			
Oil			ULVOIL R-72					
Oil capacity [L]			23 to 27	25 to 30	23 to 27	25 to 30	25 to 30	
Cooling method			Air cooled	Water cooled	Air cooled	Water cooled	Water cooled	
Inlet port			DN 100 ISO-K					
Outlet port		DN 100 ISO-K						
Weight [kg]		Approx. 820						
Dimensions W x D x H [mm]		1,490 x 905 x 705	1,490 x 841 x 705	1,490 x 905 x 705	1,490 x 841 x 705	1,490 x 841 x 705		

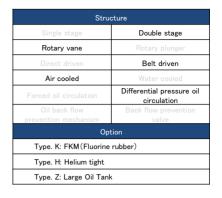
Double Stage Rotary Vane type PVD series

Legacy and small size double stage oil rotary vane pump.



Main applications:

- Vacuum drying, freeze drying
- Gas and liquid charging
- Vacuum absorption, transportation, moulding
- Vacuum impregnation, casting



• Quiet and low speed rotation.

• PVD-180B / PVD-360B: A solenoid valve is installed to prevent oil from flowing back to the intake side.

Model			PVD-180 (B)	PVD-360 (B)		
Designed pumping speed [m3/h] 50Hz (LPM / CFM) 60Hz		50Hz	9 (155 / 5.3)	19 (310 / 11.2)		
		60Hz	11 (186 / 6.5)	22 (372 / 13)		
Ultimate pressure [Pa] (Torr / mbar)	Gas ballast po	ort closed	0.67 (5×10 ⁻³ ∕ 6.7×10 ⁻³)			
	Output [kW] (Poles)		0.4 (4)	0.75 (4)		
Motor		50Hz	200 (380, 400, 415, 440)			
	Voltage [V]	60Hz	200 to 220 (480)			
Oil			ULVOIL R-72			
Oil capacity [L]			0.3	0.5		
Cooling method			Air cooled			
Inlet port			dia. 28 x dia. 19	dia. 34 × dia. 27		
Outlet port			G3/4	G1		
Weight (without Motor) [kg]			33.5	43		
Dimensions W x D x H [mm]			265 x 470 x 321	303 x 488 x 321		

Rotary Plunger type PKS series

Legacy and robust single rotary plunger pump.



Main applications:

- Vacuum heat treatment, vacuum
- sintering, vacuum carburization
- Solvent evacuation
- Vacuum impregnation, casting
- Large vacuum chamber evacuation

Structure					
Single stage	Double stage				
Rotary vane	Rotary plunger				
Direct driven	Belt driven				
Air cooled	Water cooled				
Forced oil circulation	Differential pressure oil circulation				
Oil back flow	Back flow prevention				
prevention mechanism	valve				
Op	tion				
Type. R: Anti-rust cool	ing water system				
Type. K: FKM(Fluorine rubber)					
Type. H: Helium tight					

- · Robust and long life. Low speed rotation with few sliding parts.
- Excellent abrasion resistance material are used.

High efficiency multi voltage motor (IE-3) which enable to use 200-240 / 380-460 V.
 ※ Please select the voltage of solenoid for oil circulation.

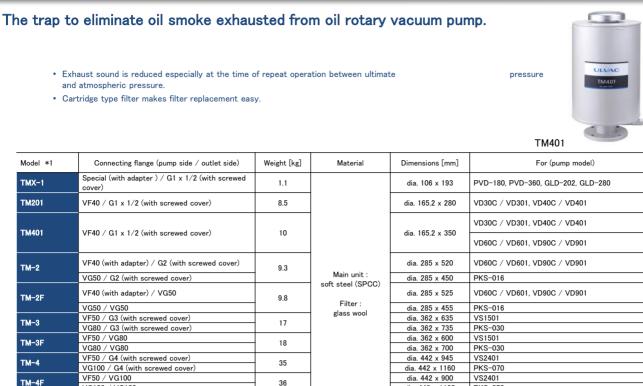
* For PKS-070B with 200V class, a single voltage motor will be recommended.

• For PKS-070B, bigger oiler and oil level gauge are introduced. Inspection hole for V belt is added.

Model		PKS-016	PKS-030	PKS-070B		
Design Exhaust Speed [m ³ /h] (LPM / CFM)			96 (1,600 / 56.5)	180 (3,000 / 105.9)	420 (7,000 / 247.2)	
Ultimate pressure [Pa] (Torr / mbar)						
	Output [kW] (Poles)		2.2 (4)	3.7B B(4)	11 (6)	
Motor	Voltage [V]	50Hz	200 to 240 / 380 to 415 (200 to 240 / 380 to 415 (Multi-Voltage Motor), 200 (Single-Voltage Motor) Only available with PKS-070B		
		60Hz	200 to 240 / 380 to 460 (200 to 240 $\scriptstyle/$ 380 to 460 (Multi-Voltage Motor) , 200(Single-Voltage Motor) C		
Oil			ULVOIL R-72			
Oil capacity [L]			6.5	8	20	
Cooling method			Air cooled	Water cooled		
Inlet port (optional)			VG50 (ASA1.5)	VG80 (ASA2)	VG100 (ASA3)	
Outlet port (optional)		VF50 (ASA1.5)	VF80 (ASA2)	VF100 (ASA3)		
Weight (without motor) [kg]			225	380	900	
Dimensions W x D x H [mm]			587 x 884 x 572	721 x 675 x 973	971 x 983 x 1190	

Vacuum Pump Accessories for Oil Rotary Pumps

Oil Mist Trap TM / TMX series



VG100 / VG100 *1 F: Flange connection type instead of screwed cover.

VG100 / VG100

VF50 / VG100

TM-4S

*2 Select the high load when the pump repeatedly runs from atmosphere to vacuum in a short period or at the pressure higher than 10,000 Pa (100mbar / 75 Torr) for a long period.

64

dia. 442 x 1120

dia. 450 x 1487

dia. 450 x 1387

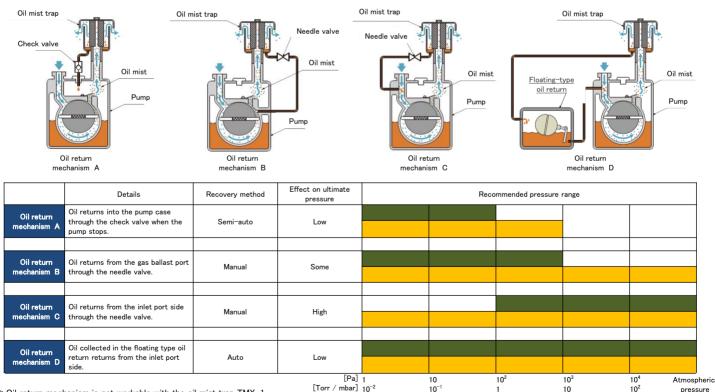
PKS-070

VS2401

PKS-070

Oil Mist Trap Oil Return Mechanism

Oil return from the oil mist trap into the pump.



* Oil return mechanism is not workable with the oil mist trap TMX-1. The TMX-1 has a check valve inside like the oil return mechanism A.

Continuously-workable pressure range

Repeatable working pressure range

1 Punit

Remarks *2

Low load type

High load type

I ow load type

High load type

High load type

High load type

High load type

Vacuum Pump Accessories for Oil Rotary Pumps

Oil Mist Trap OMT/OMI series

The trap to eliminate oil smoke exhausted from oil rotary vacuum pump.

These traps are particularly effective when operating the pump at high pressure causing excessive oil misting from the pumps
exhaust.

Exchange of only an element (filter) is also possible.

• OMI is pipe connection-type oil-mist trap.



Model*1	Connecting Size	Weight [kg]	Material	Dimensions [mm]	For(pump model)	Remarks*2
ОМТ-050А	G3/4	0.105	Body: resin Filter: resin	dia.65 × 93	G-5DA, G-10DA, G-20DA, G-25SA, G-50SA, G-50DA, GLS-051, GHD-031A, GLD-040, GLD-051	
OMT-100A	G1	0.43	Body: resin Filter: resin	dia.113 × 135	GLD-040,GHD-031,GHD-101	
OMT-200A	G1	0.55	Body: resin Filter: resin	dia.113 × 135	GLD-137AA,GLD-137CC,GLD- 202AA,GLD-202BB	
OMI-100	G1	1.25	Body: steel plate Filter: resin	dia.94 × 177	GLD-040,GHD-031,GHD-101	
ОМІ-200	G1	1.47	Body: steel plate Filter: resin	dia.116 × 178	GLD-137AA,GLD-137CC,GLD- 202AA,GLD-202BB	

*1 Filter replaceable

*2 Adapter for Oil-mist Trap is necessary for GLD-040,GHD-031.

Used to change screw diameter G3/4 to G1 when you want to put an Oil-mist trap (OMT, OMI) on your exhaust port screw G3/4 pump.



Model	Connecting size	Applicable models	Adaptive oil-mist traps
Adapter for Oil-mist Trap	G3/4 × G1	GLD-051, GLS-051, GLD-040, GHD-031	OMT-100A,OMI-100

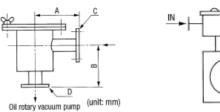
Vacuum Pump Accessories for Oil Rotary Pumps

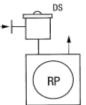
Dust Filter DS series

Dust filter for gases containing dust, glass particle, etc.

- Stainless steel made enclosure powder fore line trap equipped with a filter element inside.
- + Suitable when pumping down gases including dry powder with diameters of 10 $\,\mu\,{
 m m}$ m or more.







					Unit:mm
Model	For (pump model)	A	В	C (inlet port)	D (outlet port)
DS-20	PVD-180, GLD-202	90	90	VG20	VF20
DS-25	PVD-360, GLD-280	90	90	VG25	VF25
DS-40	VD30C / VD301, VD40C / VD401		195	VG40	VF40
DS-50	VD60C / VD601, VD90C / VD901	140	195	VG50	VF50
DS-2	PKS-016		290	VG50	VF50
DS-3	PKS-030	200	530	VG80	VF80
DS-4	PKS-070	220	583	VG100	VF100

Vacuum pump oil ULVOIL series

The ULVOIL series is a vacuum pump oil developed for improving performance and extending life of vacuum pumps.



Model		R-42	R-72	R-80	Super R-7000			
Туре			Mineral oil					
Ultimate p	ressure [Pa](Torr/mb	ar)	<4×1	10 ⁻¹	<7	<7 × 10 ⁻¹		
	Color			Transparent	pale yellow			
	Kinetic viscosity	40°C	46	68	57	68		
	[mm²/s]	100°C	8	10	8	10		
<u>.</u>	Viscosity index		142	132	110	110		
Characte ristics	Water content [%]		<0.01					
ristics	Acid number [mgKOH/g]		<0.0	<0.01		<0.1		
	Density [g/cm ³]		0.86	0.88		0.91		
	Flash point [°C]		276	274	230	220		
	Pour point [°C]		-17.5	-25	-37.5	-20		
Features		For low temperature start-up	For general purpose	For high temperature and load	For active gas exhaust			
And the shift of the second second			Oil rotary va	cuum pump				

Applicable vacuum pump

Mechanical Booster Pump

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Model			D-11	D-31	B-6
Туре		Hydrocarbon	Silicon	Hydrocarbon	
Ultimate pressure [Pa](Torr/mbar)		7 × 10 ⁻⁵	3 × 10 ⁻⁸	2.7 × 10 ⁻²	
	Color		Transparent Pale Yellow	Colorless &	Transparent
Kinetic viscosit	Kinetic viscosity	25°C	-	170	-
	[mm ² /s]	40°C	32	-	22
Characteri stics		20°C	7.3 × 10 ⁻⁵	2.1 × 10 ⁻⁸	1.2 × 10 ⁻⁵
SUCS	Steam pressure [Pa] (Torr / mbar)	40°C	1.7 × 10 ^{−3}	2.1 × 10 ⁻⁶	1.4 × 10 ⁻⁴
	(Torr / Inbar)	100°C	1.5 × 10 ^{−1}	1.1 × 10 ⁻³	3.3 × 10 ⁻¹
	Flash point [°C]	·	220	210	200以上
Features			For general purpose	For stable heat resistant	For ejector pump
			Oil diffus	-	
Applicable	vacuum pump			_	Oil diffusion ejector pump

Model		SMR-100	MR-200	SO-M	R-2			
Туре			Mineral oil Synt			etic oil		
Ultimate	e pressure [Pa](Torr/	mbar)		< 7×:	10-1			
	Color			Transparent F	Pale Yellow			
	Kinetic viscosity	40°C	44.6	71	63.7	17.3		
	[mm ² /s]	100℃	5.5	8.0	9.0	3.9		
_	Viscosity index		100	98	118	121		
Charact eristics	Water content [%]		0.01					
CHISTICS	Acid number [mgK0	DH/g]		0.01 >				
	Density [g/cm ³]		0.88	0.88	0.90	0.82		
	Flash point [°C]		200	250	250	230		
	Pour point [°C]		-15	-10	-15	-50		
Features	5		For low temperature start-up	For high temperature and load	For heat and acid resistance	For low temperature start-up		
Applicab	le vacuum pump		Oil rotary vacuum pump	Mechanical Booster Pump	Oil rotary vacuum pump	Oil rotary vacuum pump		

Vacuum Pump Oil BARRIERTA J FLUID series

A non-flammable and low vapor pressure fluorine oil. Excellent heat-resistance and oxidation resistance.



Model			J25F	J60F	J100F	J100F E	
Туре		Fluorine Oil					
Color			Colorless and	transparent.			
Kinetic viscosity [mm²/s] 40°C 25 60 Characteristics Viscosity index 85 9	Kinetic viscosity	40°C	25	60	95		
	1	3					
	Viscosity index		85		130		
	Steam pressure [Pa] (Torr / mbar) 20°C		2 x 10 ⁻³ (1.5 x 10 ⁻⁵ / 2 x 10 ⁻⁵)	$1 \times 10^{-4} (7.5 \times 10^{-6} / 1 \times 10^{-6})$	$6 \times 10^{-6} (4.5 \times 10^{-8} / 6 \times 10^{-8})$	$9 \times 10^{-5} (6.7 \times 10^{-7} / 9 \times 10^{-7})$	
	Operating temperature range [°C]		-55 to 140	-50 to 160	-40 to 180		
Features			Low steam p	pressure, nonflammable, heat resi	stance, oxidation resistance, alka	li resistance	
			Oil rotation	vacuum pump		_	
Applicable vacuum	n pump		Mechanical	booster pump	Mechanical I	pooster pump	
			-	-	Dry vacuum pump		

Vacuum Pump Mechanical Booster Pump

Mechanical Booster Pump MBS series

A small type of a root type vacuum pump

• No oil leakage by adoption of magnet coupling.

motor, and can pump it from atmospheric pressure.

• Setting of a driver circuit is necessary in 100V system and 200V system.



MBS-053

Model			MBS-053		
		50Hz	F0 (000 (00 0)		
Maximum pumping speed[m ³ /h] (L/min/CFM) 60H		60Hz	50 (833/29.2)		
Ultimate pressure	[Pa] (Torr/mbar)		$4.0 \times 10^{-2} (3.0 \times 10^{-4} / 4.0 \times 10^{-4})$		
	Output [kW](Poles)		0.2 (DC Brushless motor)		
Motor		50Hz			
	Voltage [V]	60Hz	Single phase 100 to 120 / 200 to 240		
		50Hz	1.2 (100V) / 0.8 (200V) ※At Ultimate pressure		
	Current [A]	60Hz	4.33 (100V) / 2.54 (200V) ※At maximum load		
Oil	•	•	ULVOIL SMR-200		
Oil capacity [L]			0.07		
Cooling			Air cooled		
Inlet port			VG40		
Outlet port			VF40		
Weight [kg]			11		
Dimensions W x D x H [mm]			167 x 410 x 130		
Backing pump			Oil rotary vacuum pump 130 to 240L/min		
Applicable standard			-		

· Can run it with the rotating speed that is the optimum which accepted load of a pump by using DC brushless

Mechanical Booster Pumping Systems VMR series

It is the small high vacuum pumping system which made a mechanical booster pump, an oil rotary vacuum pump, and piping unify compactly.



VMR-050

- Handling and maintenance check are easy and ideal for an experiment.
- It is a pressure domain where the pumping speed of a backing pump decreases, and the steep rise of pumping speed is possible.
- An installation space is compact.
- By pushing a button, it exhausts at a stretch to ultimate pressure.

Model			VMR-050	
		50Hz		
Maximum pumping speed[m ³ /h] (L/min) 60Hz			833 (9633.5)	
Ultimate pressu	ıre [Pa](Torr/mbar)		$4.0 \times 10^{-2} (5.32/4.0 \times 10^{-4})$ (at 100Pa)	
Output [kW](Poles)			0.75	
		50Hz		
Motor	Voltage [V]	60Hz	Single phase 100 to 120 / 200 to 240 1.5kVA	
	0 (1)	50Hz	12.5 (100 to 120V , 50Hz / 60Hz)	
	Current [A]	60Hz	6.6~(200~ to $240V$, $~50Hz~/~60Hz)$	
Oil	•		Main pump ULVOIL SMR-200 / Backing pump ULVOIL SMR-100	
Oil capacity [L	.]		Main pump 0.07 / Backing pump 1,1	
Cooling			Air cooled	
Inlet port			VG-40	
Outlet port				
Weight [kg]			42	
Dimensions W x D x H [mm]			241.4 × 532 × 399 (100V) 241.4 × 581 × 399 (200V)	
Backing pump			Oil rotary vacuum pump (200L/min)	
Applicable standard			-	

Vacuum Pump Mechanical Booster Pump

With General-purpose Motor PMB series Ver.D

Mechanical booster pump with general-purpose motor for a wide range of applications.



• It effectively shortens pumping down time by adding this pump to oil rotary vacuum pump or dry vacuum pump. Its maximum pumping speed is in about the range from 1,000Pa (7.5Torr / 10mbar) to 1Pa (7.5 x 10⁻³Torr / 0.01mbar).

- It also helps to achieve further lower ultimate pressure of the oil rotary vacuum pump and dry vacuum pump.
- Atmospheric pressure start operation is possible with the optional inverter.
- Setting for either air-cooled or water-cooled is selectable for the optional inverter.
- Surface treatment (Alumite) is available as an option.

Model			PMB100D	PMB300D	PMB600D	PMB1200D	PMB2400D	
Maximum pump	ing speed [m ³ /h]	50Hz	95 (1,580 / 56)	280 (4,670 / 165)	500 (8,330 / 294)	1,000 (16,667 / 589) / 1,000 (16,667 / 589)	2,500 (41,667 / 1,471) 2,000 (33,330 / 1,177)	
(LPM / CFM)		60Hz	115 (1,920 / 68)	330 (5,500 / 194)	600 (10,000 / 353)	1,200 (20,000 / 706) / 1,200 (20,000 / 706)	3,100 (51,667 / 1,825) / 2,400 (40,000 / 1,412)	
Ultimate pressu	oressure [Pa] (Torr / mbar) 0.4 (3 x 10 ⁻³ / 4 x 10 ⁻³) 0.67(5 x 10 ⁻³ / 6.7 x 10 ⁻³)			⁻³ / 6.7 x 10 ⁻³)				
	Capacity [kW] (P	oles)	0.4(2)	0.75(2)	2.2(2)	3.7(2)	7.5(2)	
Motor	N IN D.C.	50Hz	200 ^{%1}	200 to 240 / 380 to 415 (Multi-Voltage Motor)				
Voltage [V] 60Hz		200 to 220 ^{%1}	200 to 240 / 380 to 460 (Multi-Voltage Motor)					
Oil model	Dil model ULVOIL R-4		ULVOIL R-4	ULVOIL R-4 (Water cooled) / R-7 (Air cooled)				
Oil capacity vol	ume [L]		0.35	0.7	1.5	1.9	4 (2.2 ^{%2})	
Cooling method			Air cooled	Water cooled / Air cooled (options: to be selected by inverter setting)				
Inlet port (optio	nal)		VG50 (KF50 or ISO63F)	VG80 (ISC	080F or 100F)	VG100 (ISO100F)	VG200 (ISO200F)	
Outlet port (opt	ional)		VF50 (KF50 or ISO63F)		VF80 (ISO80F or 100F)		VF200 (ISO200F)	
Weight [kg]			26	51	82	115	260	
Dimensions W	x D x H [mm]		267 x 576 x 180	321 x 685 x 260	362 x 784 x 320	417 x 970 x 340	520 x 1260 x 460	
Standard backing pump VD40C / VD401		VD60C / VD601	VD90C / VD901	VS300 / VS2401	VS650 / PKS-070			
Applicable standard		CE, cTUVus			CE			

*2) Values for the horizontal exhaust direction typ

With Canned Motor PRC series

Mechanical booster pump with canned motor for clean environment



- It effectively shortens pumping down time by adding this pump to oil rotary vacuum pump or dry vacuum pump. Its maximum pumping speed is in about the range from 1,000Pa (7.5Torr / 10mbar) to 1Pa (7.5 x 10⁻³Torr / 0.01mbar).
- It also helps to achieve further lower ultimate pressure of the oil rotary vacuum pump and dry vacuum pump
- · There is no oil leakage to the outside in the case of canned motor. Suitable for clean room
- environment.
- Surface treatment (Alumite) for corrosion resistance is standard specification.
- · Atmospheric pressure start operation is possible with the optional inverter.

Model				PRC-003A	PRC-006A	PRC-012A	PRC-018A		
Maximum pumping s	speed [m ³ /h](LPM /	50Hz	280 (4,670 / 165)	500 (8,330 / 294)	1,000 (16,667 / 590)	1,500 (25,000 / 882)		
CFM)		60Hz	330 (5,500 / 194)	600 (10,000 / 353)	1,200 (20,000 / 706)	1,600 (30,000 / 941)			
Ultimate pressure	[Pa] (Torr /	mbar)		0.4 (3 x 10	⁻³ /4 x 10 ⁻³)	0.67 (5 x 10	⁻³ /6.7 x 10 ⁻³)		
	Capacity [kV	V](Poles	3)	0.75(2)	2.2(2)	3.7(2)	5.5(2)		
Motor	Matter DVI	50Hz			200 (380, 400, 415, 440)				
	Voltage [V] 60Hz			200 to 220 (480)					
Oil model					ULVOI	L R-4			
Oil capacity [L]				0.7	1.5	1.9			
Cooling method				Water cooled					
Inlet port (optional)				VG80 (ISO	30F or 100F)	VG100 (ISO100F)	VG150 (ISO160F)		
Outlet port (optiona	al)				VF80 (ISO80F or 100F)	-	VF100 (ISO100F)		
Weight [kg]				51	86	118	150		
Dimension W x D x	ısion W x D x H [mm] 296 x 575 x 260 356 x 619 x 320 406 x 759 x 34		406 x 759 x 340	406 x 989 x 340					
Standard backing p	ump			VD60C / VD601	VD90C / VD901	VS2401	VS2401		



acuum Pump

Vacuum Valve

Vacuum Gauge

Vacuum Pump Mechanical Booster Pump

For Large Capacity. With General-purpose Motor PMB-C series

Mechanical booster pump with low speed rotation. Suitable for large-scale chambers such as vacuum furnaces, etc.



PMB-040C

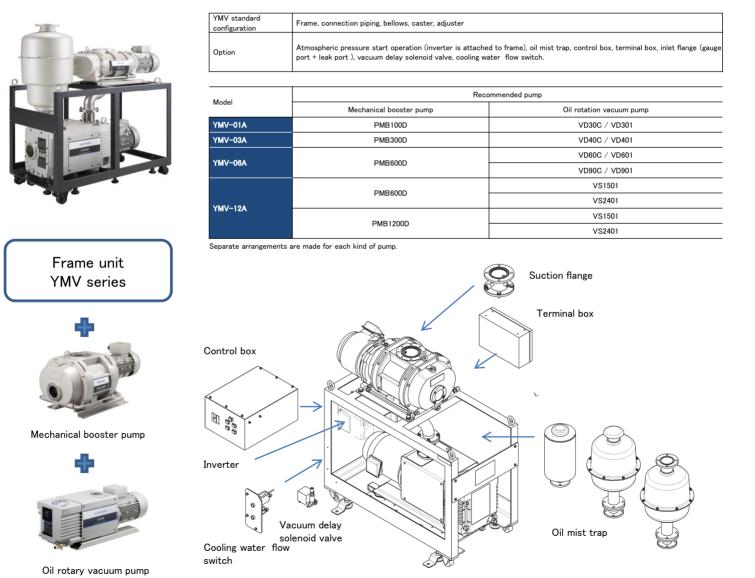
• Belt driven low speed rotation makes it robust.

			PMB-040C	PMB-060C		
Maximum pumping	speed $[m^3/h]$ (LPM / CFM)		3,800 (63,300 / 2,235)	6,200 (103,300 / 3,646)		
Ultimate pressure	[Pa] (Torr / mbar)		0.67 (5 x 10) ⁻³ / 6.7 x 10 ⁻³)		
	Output [kW](Poles)		15(4)	18.5(4)		
Motor	NUE DA	50Hz	200 (380, 4	400, 415, 440)		
	Voltage [V]	60Hz	200 to	220(480)		
Oil model			ULV	ULVOIL R-7		
Oil capacity [L]				8		
Cooling Method			Wate	Water cooled		
Inlet port (optional	1)		VG250 (ISO250F)	VG300 (ISO320F)		
Outlet port (optio	nal)		VF150 (ISO160F)	VF200 (ISO200F)		
Weight(without motor)[kg]			970	1,100		
Dimensions (without motor) W x D x H [mm]			772 x 1182 x 680	772 x 1452 x 680		
Standard backing pump			PKS-070 PKS-070			

Frame Unit for Mechanical Booster Pump YMV series

Frame unit for combining a mechanical booster pump and oil rotary vacuum pump.

Removable frame makes it possible to pull out oil rotary vacuum pump from the system.



Vacuum Pump Turbo Molecular Pump

TMP with separate controller UTM-MS series

This is a turbo molecular pump with a separate controller that uses magnetic bearings. We have a lineup of models with pumping speeds of 300 to 4000 L/s. The controller unit can monitor the operating status and supports various communication standards.



Separated pump body and controller The controller can monitor the operating status and support various communication standards.

- Free mounting direction Free mounting direction makes the system design flexible.
- Pumping speed 300L/s to 4000L/s class lineup
- Pump rotation variable from 25% to 100% Enabling the pressure adjustment in a chamber by changing the rotation speed.

High durability and safety

MS MS<			U1M40	0A-MS		:	Safety confirm	ation tests are	e passed, suc	h as air rushir	ng-in test and t	ouch down test.	. ⁹
Outlet port KF25 KF26 KF20 KF40 KF40 Mate Air Wate Cooling	Model												
Outlet port KF25 KF26 KF20 KF40 KF40 Mate Air Wate Air Wate Cooling C	Inlet port				VG150	/ ICF203	VG200 / ICF253 VG			250		VG350	etecto
Cooling method Water Air valer Air valer Air valer Cooling Coo	Outlet port			K	25				KF40				1
Pumping speed *2 N2 V/s 320 420 800 1080 1300 1500 2100 3200 4400 Compression rate N2 1×10 ⁹ 6×10 ⁸ 1×10 ⁹ 6×10 ⁸ 1×10 ⁹	Cooling method					cooling g	cooling cooling		Water cooling				Power St (DC/RF)
Compression rate N2 1 × 10 ⁹ 6 × 10 ⁸ 1 × 10 ⁹ Max inlet pressure *3 Pa/Torr/mbar Water cooling:200 / 1.5 / 2.0 Air cooling:1.3 / 0.01 / 0.01 Water cooling:300 / 3.0 / 4.0 Air cooling:1.3 / 0.01 / 0.01 133 / 1.0 / 1.3 40 / 0.3 / 0.4 Max outlet pressure *3 Pa/Torr/mbar Water cooling:400 / 3.0 / 4.0 Air cooling:400 / 0.3 / 0.4 Water cooling:665 / 5.0 / 6.7 Air cooling:400 / 0.3 / 0.4 270 / 2.0 / 2.7	Ultimate pressure	e *1	Pa/Torr/mbar	10 ⁻⁷ / 1	0 ⁻⁹ /10 ⁻⁹	10 ⁻⁸ / 10	⁻¹⁰ / 10 ⁻¹⁰			10 ⁻⁷ / 10 ⁻⁹ / 10 ⁻	9		Alddr
Max inlet pressure *3 Pa/Torr/mbar Water cooling: 200 / 1.5 / 2.0 Air cooling: 1.3 / 0.0 / 0.01 Air cooling: 40 / 0.3 / 0.4 Air cooling: 40 /	Pumping speed *	*2 N2	L/s	320	420	800	1080	1300	1500	2100	3200	4400	
Max inlet pressure *3 Pa/1 orr/mbar Air cooling:1.3 / 0.01 / 0.01 Air cooling:3 / 0.01 / 0.01 Air cooling:40 / 0.3 / 0.4 Air coo	Compression rate	e N2			1 × 10 ⁹				10 ⁸		1 × 10 ⁹		
Max outlet pressure '3 P3/1 orr/mbar Air cooling:40 / 0.3 / 0.4 Air cooling:40 / 0.3 / 0.4 Air cooling:40 / 0.3 / 0.4 2/0 / 2.0 / 2.7 2/0 / 2.0 / 2.7 Rotation speed rpm 45000 35000 30300 27000 27600 24000 Start-up time 5minutes or less 0 r less 0 r less or less degitted degitted <td>Max inlet pressur</td> <td>re *3</td> <td>Pa/Torr/mbar</td> <td></td> <td colspan="3">0</td> <td>133 / 1</td> <td>.0 / 1.3</td> <td colspan="2">/ 1.3 40 / 0.3 / 0.4</td> <td></td> <td>EB Powe</td>	Max inlet pressur	re *3	Pa/Torr/mbar		0			133 / 1	.0 / 1.3	/ 1.3 40 / 0.3 / 0.4			EB Powe
Rotation speed ipm 45000 33000 30300 27000 27000 24000 24000 Start-up time 5minutes or less 7minutes or less 11minutes or less 12minutes or less 12minutes or less 12minutes or less 12minutes or less 18minutes or less 0 18minutes or less 0 18minutes or less 0 18minutes 18minutes 18minutes 18minutes 18minutes 18minutes 18minutes 18minutes	Max outlet pressu	ure *3	Pa/Torr/mbar					270 / 2	270 / 2.0 / 2.7		270 / 2.0 / 2.7		r Supply
Start-up time or less or less<	Rotation speed		rpm	45	000	35	000	303	300	27000	27600	24000	
Surface treatment Nickel plating Cooling water Flow rate L/min 1~3 - 1~3 - 1~3 2~4 Noise dB(A) 60 57 60	Start-up time												3 Sourc
Cooling water Flow rate L/min 1~3 - 1~3 - 1~3 - 1~3 2~4 Noise dB(A) 60 57 60 60 57 60	Mounting position	n			In any desired direction								
Noise dB(A) 60 57 60 Weight kg 14 33 32 39 42 70 84 105 Recommended backing pump 200L/min or more 500L/min or more 600L/min or more 1300L/min or more 1500L/min or more	Surface treatmen	nt				Nickel plating						Depo	
Weight kg 14 33 32 39 42 70 84 105 Recommended backing pump 200L/min or more 500L/min or more 600L/min or more 1300L/min or more 1500L/min or more 1500L/min		Flow rate		1~3 -	1~3 -	1~3 —	1~3 -	1-	~3		2~4		sitio
Composition 200L/min or more 500L/min or more 600L/min or more 1300L/min or more 1500L/min or more 1500L/min or more 1500L/min or more Composition Composition Separate type Single phase AC200 ~240V ±10% (50/60Hz ±2Hz) 1.5 Controller Max power 0.55 1.0 1.5 Speed variation Speed is variable between 25% and 100% of the rated speed. (set as 0.1%) 1.5	Noise		dB(A)							-			0
Recommended backing pump or more or more or more or more or more or more Composition Separate type Input electric Power Single phase AC200 ~240V ±10% (50/60Hz ±2Hz) Max power 0.55 1.0 1.5 Speed variation Speed is variable between 25% and 100% of the rated speed. (set as 0.1%) Weight kg 8	Weight		kg				-				-		ntro
Composition Separate type Input electric Power Single phase AC200 ~240V ±10% (50/60Hz ±2Hz) Max power 0.55 Speed variation Speed is variable between 25% and 100% of the rated speed. (set as 0.1%) Weight kg	Recommended b	acking p	ump				-						ller
Weight kg		Composit	ion		nore		nore	-		ormore		nore	Me
Weight kg						Sin	ale phase AC20			H7)			asu
Weight kg	-			0.	55		<u> </u>					- rem	
Weight kg 8						Speed is variab	le between 25%	and 100% of the	he rated speed.	(set as 0.1%)			ient
*1 : digit number is expressed. *2: Without a protective net. *3: Max inlet pressure and Max outlet pressure cannot be satisfied at same time.													· []
	*1 : digit number	is expres	ssed. *2:With	out a protective	net. *3:Max in	let pressure an	d Max outlet pre	ssure cannot be	e satisfied at sa	me time.			Acc

Ceramic Ball Bearing type UTM-B series

Compound turbo molecular pump with ceramic ball bearings. An integrated controller saves installation space. Installation in any orientation makes your system design flexible. Excellent high back pressure performance allows to use smaller backing



UTM70B

ng pump	D.						
Model			UTM70B		UTM300B		
	Inlet flange (*1)		VG65,ICF1	14,ISO63-K	VG100, ICF15	2, ISO100-K	
	Outlet flange		К	F16	KF1	6	
	Cooling method		Natural air cooled	Forced air cooled	Natural air cooled	Forced air cooled	
	Pumping speed(N2) [L/sec]		2	280)	
	Ultimate pressure [Pa] / [Torr] / [mbar] (*2)	After baking	(*3)	$10^{-8} / 10^{-10} / 10^{-10}$	(*3)	$10^{-8} / 10^{-10} / 10^{-10}$	
	[Pa] / [Torr] / [mbar] (*2) (with double stages backing pump)	Before baking	$10^{-6} / 10^{-8} / 10^{-8}$		10 ⁻⁶ / 10 ⁻⁸ / 10 ⁻⁸		
Pump	Maximum compression ratio(N2)		>1	x 10 ⁹	>1 x 10 ⁹		
·	Maximum inlet pressure(N2) [Pa] / [Torr] / [mbar] (*4)		4.3 / 3.2 x 10 ⁻² / 4.3 x 10 ⁻²	1.1 / 8.3 x 10 ⁻³ / 1.1 x 10 ⁻²	6x10 ⁻² / 5 x 10 ⁻⁴ / 6 x 10 ⁻⁴	0.7 / 5 x 10 ⁻³ / 7 x 10 ⁻³	
	Maximum outlet pressure(N2) [Pa] / [Torr] / [mbar] (*4) (*5)		300 / 2.3 / 3	900 / 6.8 / 9	100 / 0.75 / 1.0	1000 / 7.5 / 10	
	Surface treatment		N	one	None		
	Recommended backing pump (when evacuating 10SCCM)		Approx. 60L/min		Approx. 120L/min		
	Weight [kg] VG / ISO / ICF		3.3 / 3.0 / 5.0	3.5 / 3.2 / 5.2	6.0 / 6.0 / 9.0	6.3 / 6.3 / 9.3	
Power Supply	Input voltage, power consumption		DC24V, 120W		DC24V, 180W		
Applicable star	ndard		CE, Tutu's		CE, TUVus		

*1) Select inlet flange type from VG100. ICF152 and ISO100-K when ordering. *2) Value is described by range.

*3) Baking is available only when forced air cooling method with ICF flange is selected.

*4) Max, inlet and outlet pressure are not satisfied at same time, *5) Continuous workable pressure when 5sccm gas flow from the inlet port.

essories

Vacuum Transfer

· Robot

/acuum Valve

Vacuum

Gauge

Process

Gas

Vacuum Pump Turbo Molecular Pump

TMP with integrated controller UTM-MI series

Controller integrated turbo molecular pump with magnetic bearings saves wiring work and installation space.



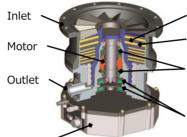
UTM1600A

•Controller integrated with the pump body No wiring work between pump body and controller.

•Free mounting direction

Free mounting direction makes the system design flexible.

- •5 models from 1000L/S to 4000L/S class.
- •Wide range and high flow for the light processes.
- •Pump rotation variable from 25% to 100% Enabling the pressure adjustment in a chamber.
- High durability and safety Safety confirmation tests are passed, such as air rushing-in test and touch down test.



Rotor blade

Stator blade

Radial magnetic bearings

Axial magnetic bearing

Controller

Model		UTM1200A	UTM1600A	UTM2300A	UTM3400A		
Inlet port		VG150 ISO160F	VG200/VG250 ISO200F/ISO250F	VG250 ISO250F	VG300/VG350 ISO320F		
Outlet port		KF40					
Ultimate pressure(*1) [Pa/ torr/ mbar]	$10^{-7} / 10^{-9} / 10^{-9}$					
Pumping speed (*2)(*3) N2 [L/s]		1030	1400	2100	3200		
Compression rate	N2	2	× 10 ⁸	1 × 10 ⁸ or more	1 × 10 ⁹ or more		
Max inlet pressure(*	4) [Pa/ torr/ mbar]	26 /	0.2 / 0.3	4.5 / 0.03 / 0.05	7 / 0.05 / 0.07		
Max outlet pressure(*4) [Pa/ torr/ mbar]	266	/ 2 / 2.7	200 / 1.5 / 2	270 / 2 / 2.7		
Rotation speed	[rpm]	3	7200	33700	27600		
Speed variation		Spe	ed is variable between 25% and 1	00% of the rated speed. (set a	s 0.1%)		
Start-up time		8 minu	tes or less	9 minutes or less	16 minutes or less		
Mounting position			In any desir	red direction			
Surface treatment(*	5)	None					
Communication		D-sub 2	5 pin female	D−sub 37 pin female			
	Contact	Contact input	and output signal	Contact input a	nd output signal		
		Serial	connecter	D-sub 9	pin male		
	Serial	RS232C/RS485 RS232C/RS485					
	Composition	Pump with integrated controller					
Controller	Input electric power	Single phase AC200~240V $\pm 10\%$ (50/60Hz ± 2 Hz)					
	Max power	0.75kVA 1.2kVA					
Cooling method		Water cooled					
	Flow rate [L/min]		3-	~4			
Cooling water(*6)	Pressure [MPaG]		0.2	~0.4			
Noise	[dB(A)]		57	6	0		
Weight	[kg]	43	41	56	94		
Recommended backi	ng pump(*7)	600L/r	nin or more	1500L/min or more			
Applicable standard			CE, T	- UVus			
Standard accessories	S	O-ring(Only VG), Dust cap(Outlet port), Remote-control Connector, Instruction manual(CD-ROM)					
Coloret monto	AC Cable	AC Connector / AC Cable(5m/10m/15m/20m)					
Select parts	Special bolt for fixing pump	M10(Non-RoHS / RoHS)/ M12(Non-RoHS / RoHS)					

*1:A digit number is expressed. *2:Without a protective net. *3:Calculated values:UTM2300A and UTM3400A *4:Max inlet pressure and Max outlet pressure cannot be satisfied at same time. *5:Do not flow reactive gas and corrosive gas. Please contact us when using other gases. *6:Not condensing *7:When evacuating 30SCCM *8:Grade of bolts, Fixing method and etc. are subject to various conditions. Please contact us for the detailed information.

Vacuum Pump Turbo Molecular Pump

Turbo Molecular Pumping System Desktop YTP

bearing turbo mole	um pumping station feature cular pump. ad touch screen control fo	-			gn and ceramic ball	
		Running noise a reduced. >Low noise 43dB(A) or less (Measured by U >User-friendly Simple operation >Pressure indicat	nd vibratio at Ultimat _VAC stan n with eas .ion	vironment on deskt on during operation a te pressure. Indard for ICF flange t ay to read touch pane tion of up to 2 vacuu	ype.) I display	
TTF/0A-D		Model			YTP70A-D	
Start Savaan	Main Savaan	Inlet port			ICF114.VG65.ISO63-K	
		Ultimate pressure(*))	Pa / Torr / mbar	10 ⁻⁶ / 10 ⁻⁸ / 10 ⁻⁸	
			N2	L/s	70	
Desktop FTP		Pumping speed	He	L/s	60	
Software Ver. 10. 20	VAC MENU FIL DEG	(*2)	H2	L/s	49	
Alarm Pop-up	Vacuum gauge selection screen	Backing pump	_	L/min	20	
DEGAS op/off	Menu	Weight		kg	17.5	
	P1 P1 Status:	Noise (*3)		dB(A)	< 43	
Desktop YTP Software Ver. 10. 20 Alarm Pop-up DEGAS en/off PG sensor is abnomal Check Sensor Difference PG sensor is abnomal Check Sensor Difference Software Ver. 10. 20 Vac MENU FIL DEG Vacuum gauge selection screen Menu P1 P2 P2 P2 P2 P2 P2 P2 P2 Setting (0-16) P2 setting (0-PG, D-CC)	P2 Status:	Input power source			Single phase AC100~240V(50/60Hz)	
Duilt in simple intermetion with		Power capacity			300W	
XVacuum gauge sold separately.		Standard accessorie	s		Instruction manual(CD-R),I/F connector, Protective net, Gasket	
ST2/SH2 only ST2/SH2		External option			AC cable (3m) (*4)	
		Applicable standard			CE, cTUVus	
etc.1 etc.2			•	. *2:Without a protectiv rred by ULVAC standard	ve net. for ICF flange type. *4:Plug is selectable.	

Turbo Molecular Pumping System YTP series Ver.B

YTP series version B is a high vacuum pumping system with a ceramic ball bearing turbo molecular pump. Vacuum pumping from atmospheric pressure to high vacuum is possible.

SA type automatically starts up entire system by pushing start button and M type manually starts up turbo molecular pump by checking its back pressure.



- The system with oil rotary backing pump is standard and dry backing pump is also available
- A solenoid fore valve is equipped as standard configuration to prevent back flow and accident in case of black out.
- Pirani vacuum gauge is equipped as a standard configuration to monitor pressure during roughing evacuation

YTP-50MB-DRY

300SAB

19/			

Model		YTP-50MB YTP-50SAB	YTP-50MB-DRY YTP-50SAB-DRY	YTP-300MB YTP-300MB-DI YTP-300SAB YTP-300SAB-D			
Inlet port		VG65,ICF1	14,ISO63-K	VG100, ICF152, ISO100-K			
Ultimate pressure	Before baking	10 ⁻⁶ / 10	0 ^{−8} / 10 ^{−8}	10 ⁻⁶ / 10	0 ⁻⁸ / 10 ⁻⁸		
*1 *2 [Pa] / [Torr] / [mbar]	After baking	10 ⁻⁸ / 10	⁻¹⁰ / 10 ⁻¹⁰	10 ⁻⁸ / 10	⁻¹⁰ / 10 ⁻¹⁰		
Pumping speed	N2	70	L/s	280	L/s		
*3	H2	49	L/s	220	L/s		
Outlet port		G3/4	KF16	G1	KF16		
Baking pump	50Hz	50 L/min	90 L/min	200 L/min	250 L/min		
	60Hz	60 L/min	100 L/min	240 L/min	300 L/min		
Dimension $W \times D \times H$ mm		400 × 592 × 470	$450 \times 592 \times 463$	492 × 665 × 576	542 × 665 × 576		
Weight		55 kg	57 kg	86 kg	85 kg		
TMP back pressure and rough press	sure monitoring	Pirani vacuum gauge $(2.7 \times 10^3 \sim 10^{-1} \text{Pa}) (0.2 \times 10^2 \sim 7.5 \times 10^{-4} \text{Torr}) (2.7 \times 10^1 \sim 10^{-3} \text{mbar})$					
Fore valve		Solenoid valve for rotary pump automatic vent system(Solenoid valve)					
Input power source		Single phase AC100V (50/60Hz)					
Input cable length			5m with 3	3P outlet			
Power capacity		1.2 kVA	0.9 kVA	1.7 kVA	1.6 kVA		
Power consumption during stable of	peration	0.6 kVA 0.4 kVA 1 kVA					

*1 Baking is only available with ICF flange type. *2 A digit number is expressed. (Display only the digits of power.) *3 Without a protective net.

iuna uut

/acuum Valve

Vacuum

Gauge

Proces Gas

Leal Detector

(DC/RF) Iddns

EB Powe Subbl

EB Source

Depos

Controlle

Thin Film Measurement

Accessories

Vacuum Transfer

Robot

Equipment

Vacuum Pump CRYO Pump

CRYO Pump CRYO-U series

An ultra-high vacuum pump that excels in exhausting water and exhausts all gases.

•Provide Ultra clean vacuum which is exclusive to our cryo pumps.



- Vacuum any kind of gas
 No liquid helium needed means low running cost.
- Can be installed in any orientation.
- Easy operation.
- Higher pumping speed compared to ion pumps or turbo molecule pumps.

CRYO-U12HSP / C30VRT

Model	Model		CRYO-U4H	CRYO-U6H	CRYO-U8H	CRYO-U10H
		Nitrogen	450	750	1,700	2,400
Pumping speed	FL (]	Hydrogen	500	1,100	2,700	3,600
@20°C	[L/s]	Argon	370	620	1,400	2,000
		Water	1,100	2,100	4,000	6,900
Ultimate pressure	•	[Pa]		1	0 ⁻⁷	•
	[Pa L/s]	Argon	1.3 x 10 ³	1.1 x 10 ³	1.2 x 10 ³	1.3 x 10 ³
Maximum throughput	[Pa L/s]	Hydrogen	_	1.1 x 10 ²	2.4 x 10 ²	1.5 x 10 ²
Durani an anna aite	[Pa L]	Argon	1.0 x 10 ⁷	5.6 x 10 ⁷	1.0×10^{8}	1.0×10^{8}
Pumping capacity	[Pa L]	Hydrogen	1.5×10^{5}	3.1 x 10 ⁵	1.0×10^{6}	1.2×10^{6}
Mounting flange	lange ISO-K DN100 UVG-150 UVG-200 , 6 ^B ANSI UFC-253 UFC-253		UVG-250 ICF-305			
Cool down time[min]			45 / 40 (50Hz / 60Hz)	80 / 70 (50Hz / 60Hz)	100 / 90 (50Hz / 60Hz)	110 / 100 (50Hz / 60Hz)
Compressor unit			C10T , C10AT	C10T ,	C10AT	C15T
Weight [kg]		14.5	19	25	29	

Model		CRYO-U12H	CRYO-U12HSP	CRYO-U16P	CRYO-U20H	
		Nitrogen	4,000	4,100	5,000	10,000
Pumping speed	FL /-1	Hydrogen	6,000	6,000	10,000	18,000
@20°C	[L/s]	Argon	3,300	3,400	4,200	8,400
		Water	9,500	9,500	16,000	29,000
Ultimate pressure [Pa]				1	0-7	
Maximum throughput	[Pa L/s]	Argon	2.0 x 10 ³	2.0×10^{3}	1.6 x 10 ³	1.7 x 10 ³
	[Pa L/s]	Hydrogen	4.1 x 10 ²	4.1×10^2	4.5 x 10 ²	5.0 x 10 ²
D	[Pa L]	Argon	2.1 x 10 ⁸	4.4×10^{8}	4.3 x 10 ⁸	5.8 x 10 ⁸
Pumping capacity	[Pa L]	Hydrogen	9.8 x 10 ⁵	1.6 x 10 ⁶	2.4 x 10 ⁶	4.6 x 10 ⁶
Mounting flange			UVG-300 , 10 ^B ANSI	UVG-300 , 10 ^B ANSI	UVG-400	UVG-500,20 ^B ANSI ISO-500
O al dava time [asia]			85 / 75	90 / 80	120 / 100	160 / 140
Cool down time[min]		(50Hz / 60Hz)	(50Hz / 60Hz)	(50Hz / 60Hz)	(50Hz / 60Hz)	
Compressor unit			C15T ,	C30VRT	C30VRT	C30PVRT
Weight [kg]		40	42	65	72	

Model			CRYO-U22P	CRYO-U22WB	CRYO-U22H	CRYO-U30HP
		Nitrogen	11,500	13,000	17,000	28,000
Pumping speed	D / J	Hydrogen	14,000	16,500	25,000	43,000
@20°C	[L/s]	Argon	9,700	11,000	14,000	23,000
		Water	39,000	39,000	39,000	70,000
Ultimate pressure [Pa]				1	0-7	•
Maximum [P	[Pa L/s]	Argon	1.7 x 10 ³	3.5 x 10 ³	4.1 x 10 ³	2.7 x 10 ³
throughput	[Pa L/s]	Hydrogen	5.0 x 10 ²	1.3 x 10 ³	1.3 x 10 ³	7.4 x 10 ²
D	[Pa L]	Argon	5.8 x 10 ⁸	8.1 x 10 ⁸	8.1 × 10 ⁸	7.8 x 10 ⁸
Pumping capacity	[Pa L]	Hydrogen	6.0 x 10^6 8.5 x 10^6		8.5 x 10 ⁶	1.5 x 10 ⁷
Mounting flange				UVG-550		VG-750
O	1		180 / 170	165 / 150	150 / 135	240 / 200
Cooldown time[min]		(50Hz / 60Hz)	(50Hz / 60Hz)	(50Hz / 60Hz)	(50Hz / 60Hz)	
Compressor unit			C30PVRT	C30PMVRT × 1	C30VRT x 2	C30PVRT x 2
Weight [kg]		115	125		200	

Export control policy

Vacuum pumps that pump nitrogen gas at pumping speed of 15,000L/s or more fall under row 2(35) of appended table 1 of Japan's Export Trade Control Order, which is based on international export control regimes. Customers must follow all related rules and regulations such as Foreign Exchange and Foreign Trade Act and take appropriate procedures when exporting or re-exporting those products.

Vacuum Pump ►Oil Diffusion Pump

4 to 14 inch ULK series

4 kinds of models from 4" to 14".

Required pumping speed and ultimate pressure are selectable by 2 types of oils and heaters.

- A steady high vacuum pump without mechanical moving parts.
- A mechanism preventing oil backflow to the backing pump is included.



- Major applications

 Vacuum deposition system
- High vacuum laboratory equipments

ULK-14A

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T		

um Pump

Vacuum Valve

Vacuum Gauge

Dep

rolle

Thin Film Measurement

Accessories

Model	ULK	(-04A	ULK	-06A	ULK-10A		ULK	-14A	Pro
Pumping speed [L/sec]	550	500	1,200	1,100	3,400	3,000	5,400	4,900	cess (
Ultimate pressure [Pa] (Torr / mbar)	<2.6 x 10 ⁻⁵ (1.9 x 10 ⁻⁷ / 2.6 x 10 ⁻⁷)	<2.6 x 10 ⁻⁶ (1.9 x 10 ⁻⁸ / 2.6 x 10 ⁻⁸)	<2.6 x 10 ⁻⁵ (1.9 x 10 ⁻⁷ / 2.6x10 ⁻⁷)	<2.6 x 10 ⁻⁶ (1.9x10 ⁻⁸ / 2.6x10 ⁻⁸)	<2.6 x 10 ⁻⁵ (1.9x10 ⁻⁷ / 2.6x10 ⁻⁷)	<2.6 x 10 ⁻⁶ (1.9x10 ⁻⁸ / 2.6x10 ⁻⁸)	<2.6 x 10 ⁻⁵ (1.9x10 ⁻⁷ / 2.6x10 ⁻⁷)	<2.6 x 10 ⁻⁶ (1.9x10 ⁻⁸ / 2.6x10 ⁻⁸	Gas Moni
Critical backing pressure [Pa] (Torr / mbar)	40 (0.3 / 0.4)	60 (0.4 / 0.6)	40 (0.3 / 0.4)	60 (0.4 / 0.6)	35 (0.26 / 0.35)	40 (0.3 / 0.4)	30 (0.22 / 0.3)	30 (0.22 / 0.3)	- tor Le
Oil	ULVOIL D-11	ULVOIL D-31	ULVOIL D-11	ULVOIL D-31	ULVOIL D-11	ULVOIL D-31	ULVOIL D-11	ULVOIL D-31	äkE
Oil capacity [L]	0	.15	0.	35	0	.8	1	.5	Detec
Cooling water capacity [L/min]	1	1	1	1.5	2.5	3	2.5	3.5	ţ
Voltage				Single phas	e, AC200V		•	•	
Required electric power [kW]	0.55	0.73	0.9	1.2	2	2.4	2.25	2.4	DC/F
Recommended backing pump	VD	0201	VD40C / VD401		VD90C / VD901		VS2401		DC/RF)
Dimensions A x B x H [mm]	175 x 1	50 x 341	250 x 180 x 449		340 × 240 × 650		340 x 240 x 670		- Piq
Inlet port	VC	3100	VG150		VG250		VG350		
Outlet port	V	G25	VC	3 40	VG80		VG80		1_
Weight [kg]	-	7.5	1:	3.5	47		56		BPO
Oil level gauge	N	one	No	one	Viewport		Viewport		wer s
Thermostat option	Ava	ilable	Avai	lable	Available		Available		upply
Thermostat setting temperature [°C]	2	250	2	50	1	80	180		EB S

22 to 52 inch PFL series

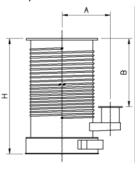
4 kinds of models from 22" to 52" for large size vacuum systems such as vacuum furnaces, etc.



- A steady high vacuum pump without mechanical moving parts.
- An efficient and economical pump because required electric power and oil volume are small.

Major applications

- Vacuum heat treatment furnace, sintering furnace, carburizing furnace, etc.
- Large chamber evacuation.



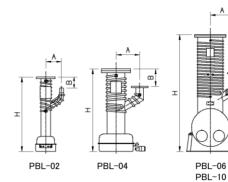
Model	PFL-22	PFL-22TM	PFL-36	PFL-52	er R			
Pumping speed [L/sec]	10,000	10,000	34,000	70,000	Vacuum Transfer Robot			
Ultimate pressure [Pa] (Torr / mbar)		3.0 x 10 ⁻⁴ (2.2 x	x 10 ⁻⁶ / 3.0 x 10 ⁻⁶)					
Maximum fore pressure [Pa] (Torr / mbar)	16 (1.2 x 10	⁻¹ / 1.6 x 10 ⁻¹)	6.7 (5 x 10 ⁻² / 6.7 x 10 ⁻²)	16 (1.2 x 10 ⁻¹ / 1.6 x 10 ⁻¹)	Cryogenic Equipment			
Oil		ULVOIL D-11						
Oil capacity [L]	5	5	13	27	770			
Cooling water capacity [L/min]	12	15	38	50				
Voltage	3 phase, AC200V							
Required electric power [kW]	8	10	10 Start up: 22, Normal: 11 Start					
Recommended backing pump		PMB-040C + PKS-070		PMB-060C + PKS-070 x 2				
Dimensions A x B x H [mm]	480 x 630 x 1,330	480 x 630 x 1,330	725 x 1,022 x 1,732	1,000 × 2,000 × 2,845				
Inlet port	VG550	VG550	VG900	VG type equivalent 52 inch				
Outlet port	VG150	VG200	VG250	VG350				
Weight [kg]	290	290	650	1,400				
Oil level gauge	Viewport	Viewport	Viewport	Viewport				
Thermostat option	Available	Available	Available	Available				
Thermostat setting temperature [°C]	180	180	110	110				

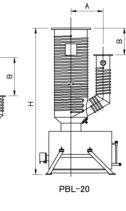
Vacuum Pump ►Oil Diffusion Pump

Oil Diffusion Ejector Pump **PBL series**

It has maximum pumping speed at the range of 10^{-1} Pa (10^{-3} mbar and Torr), where pumping speed of oil rotary vacuum pumps and mechanical booster pumps drop.







PBL-14

- A steady high vacuum pump without mechanical moving parts
- Suitable in intermediate pressure range between oil rotary vacuum pump / mechanical booster pump and oil diffusion pump.
- Body of the pump from the PBL-02 to the PBL-04 is made of stainless copper which is excellent for corrosion resistance.
- Excellent heating efficiency because a pipe heater is placed directly in hydraulic oil for large pumps bigger than the PBL-06.

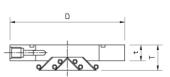
Model	PBL-02	PBL-04	PBL-06	PBL-10	PBL-14	PBL-20				
Pumping speed [L/sec]	80	200	500	1,800	4,000	7,000				
Ultimate pressure [Pa] (Torr / mbar)		2.7 x 10 ⁻² (2 x 10 ⁻⁴ / 2.7 x 10 ⁻⁴)								
Maximum fore pressure [Pa] (Torr / mbar)		40 (3 x 10 ⁻¹ / 4 x 10 ⁻¹)								
Oil		ULVOIL B-6								
Oil capacity [L]	0.1	0.6	7.5	18	36	90				
Cooling water capacity [L/min]	1.5	5	8	12	18	25				
Voltage	Single pha	Single phase, AC200V 3 phase, AC200V								
Required electric power [kW]	ed electric power [kW] 0.44		4 2kW x 2 pcs	8 4kW x 2 pcs	11 5.5kW x 2 pcs	18 6kW x 3 pcs				
Recommended backing pump	VD30C / VD301	PKS-016	PKS-030	PKS-030 PKS-070		PMB-040C + PKS-070				
Dimensions A x B x H [mm]	100 x 70 x 463	150 x 112 x 524	200 x 152 x 973	300 x 346 x 1,321	340 x 548 x 1,687	510 x 444 x 2,320				
Inlet port	VG50	VG100	VG150	VG250	VG350	VG500				
Outlet port	3/4B Hose port	VG40	VG50	VG80	VG100	VG200				
Weight [kg]	6	17	86	198	313	495				
Oil level gauge	None	None	Level gauge	Level gauge	Level gauge	Level gauge				
Thermostat option	None	None	None	None	None	None				
Thermostat setting temperature [°C]	-	-	-	-	160	160				

Water-Cooling Baffle BW series

For reducing oil steam backflow from oil diffusion pump into suction side.



- For preventing inside of vacuum chamber from the oil steam contamination from the oil diffusion pump.
- It is designed to minimize exhaust resistance.
 By setting the adapter for BW-04B and BW-06B, volume of the
- by setting the adapter for BW-04B and BW-06B, volume of th oil stem backflow volume can be suppressed additionally.



BW-04B+Adapter

Model		BW-02	BW-04B	BW-06B	BW-10	BW-14	BW-20	BW-22	BW-36	BW-52
Conductance [L/sec]		100	940	2,200	3,130	5,000	13,000	14,000	54,000	75,000
	D	dia. 120	dia. 149	dia. 199	dia. 350	dia. 450	dia. 625	dia. 680	dia. 1,065	dia. 1,480
Outer diameter Dimensions [mm]	т	16	28	28	44	50	152	101	113	165
Dimensione [mm]	t	16	25	25	22	22	24	26	28	35
Cooling water ports (Si	ze)	Rc 1/8	Rc 1/4	Rc 1/4	Rc 1/4	Rc 3/8	Rc 3/8	Rc 3/8	Rc 3/8	Rc 1/2
Coolant Volume [L/min]	1.5	0.7	1	2	2	3	3	5	5
Weight [kg]		1	1.3	1.7	7.6	11	22	28	66	200

Vacuum Pump ►Sputter Ion Pump

Sputter Ion Pump **PST series**

New type element, which is actor element and optimized magnet filed improves pumping speed in extreme and ultra high vacuum ranges.







PST-100





PST-200



PST-030

DOT 400

P21	-400

PST-														
030CU	PST- 030AU	PST- 050CU	PST- 050AU	PST- 100CX	PST- 100AX	PST- 110AU	PST- 200CX II	PST- 200AX II	PST- 400CX II	PST- 400AX II				
Active Gas Rare Gas					1	Rare Gas	Active Gas	Rare Gas	Active Gas	Rare Gas				
0.03 (0.02)		0.03 (0.02)		0.03 (0.02)		0.03 (0.02) 0.045 (0.03)		0.10 ((0.08)	0.11 (0.06)	(0	20) (0.36)		6)
(0.013)		(0.016) (0.05)		-	(0.02)	(0.105)	(0.04)	(0.19)						
10 ⁻⁹ Pa range (10 ⁻¹¹ Torr and mbar)		10 ⁻⁹ Pa range 10 ⁻⁹ Pa range 10 ⁻⁹ Pa range (10 ⁻¹¹ Torr and mbar) (10 ⁻¹¹ Torr and mbar) (10 ⁻¹¹ Torr and mbar)		10 ⁻⁹ Pa range (10 ⁻¹¹ Torr and mbar)			10 ⁻¹⁰ Pa range (10 ⁻¹² Torr and mbar)							
< 8x10 ⁻³ Pa (<6x10 ⁻⁵ Torr, <8x10 ⁻⁵ mbar)		< 8x10 ⁻³ Pa (<6x10 ⁻⁵ Torr, <8x10 ⁻⁵ mbar)		< 5x10 ⁻³ Pa (<4x10 ⁻⁵ Torr, <5x10 ⁻⁵ mbar)		< 5x10 ⁻³ Pa (<4x10 ⁻⁵ Torr, <5x10 ⁻⁵ mbar)	< 4x10 ⁻³ Pa (<3x10 ⁻⁵ Torr, <4x10 ⁻⁵ mbar)		< 8x10 ⁻³ Pa (<6x10 ⁻⁵ Torr , <8x10 ⁻⁵ mba					
CF	70	CF114		CF152		CF152	CF203		CF203					
GST-07L-B		GST-07L-B		GST-07L-B		GST-07L-B	GST-07L-B		GST-07L-B					
DC +7.5		DC	+7.5	DC	DC +7.5 DC +7.5		DC +7.5		DC +	-7.5				
250		2	50	25	50	250	250		25	0				
About 9.5		Abou	t 12.8	Abou	ut 37	About 37	Abo	ut 65	About	124				
108 x 1	83 x187	x187 153 x 204 x 241		155 x 34	155 x 340 x 340 180 x 390 x 300		296 x 361 x 376		296 x 544 x 376					
-	_	-	•	Single phase	Single phase 200V,320W —		Single phas	e 200V,600W	Single phase 200V,800W					
	Active Gas 0.03 (0.0 10 ⁻⁹ P (10 ⁻¹¹ Torr < 8x1 (<6x10 <8x10 Cf GST- DC 2 Abor 108 x 1	Active Gas Rare Gas $0.03 (0.02)$ (0.013) 10^{-9} Pa range (10^{-11} Torr and mbar) $(5.010^{-5}$ Torr, $<8.10^{-5}$ mbar) $< 8.10^{-5}$ mbar) $< 6.010^{-5}$ Torr, $<8.10^{-5}$ mbar) CF70 CF70 GST-07L-B DC +7.5 DC +7.5 250 About 9.5 108 x 183 x187	Active Gas Rare Gas Active Gas 0.03 (0.02) 0.045 (0.013) 0.045 (0.013) (0.0100) 10 ⁻⁹ Pa range (10 ⁻¹¹ Torr and mbar) 10 ⁻⁹ P (10 ⁻¹¹ Torr (10 ⁻¹¹ Torr and mbar) (10 ⁻¹¹ Torr <8x10 ⁻³ Pa (<6x10 ⁻⁵ Torr, <8x10 ⁻⁵ mbar) <8x10 ⁻¹ (<6x10 ⁻¹ (<7x ⁻¹ (Active Gas Rare Gas Active Gas Rare Gas 0.03 (0.02) 0.045 (0.03) (0.03) (0.013) (0.016) (0.016) 10 ⁻⁹ Parange (10 ⁻¹¹ Torr and mbar) 10 ⁻⁹ Parange (10 ⁻¹¹ Torr and mbar) 10 ⁻⁹ Parange (10 ⁻¹¹ Torr and mbar) < 8x10 ⁻³ Pa (<6x10 ⁻⁵ Torr, <8x10 ⁻⁵ mbar) < 8x10 ⁻³ Pa (<6x10 ⁻⁵ Torr, <8x10 ⁻⁵ mbar) CF70 CF114 GST-07L-B GST-07L-B DC +7.5 DC +7.5 About 9.5 About 12.8 108 x 183 x187 153 x 204 x 241 Single phase 200V,300W	Active Gas Rare Gas Active Gas Rare Gas Active Gas 0.03 (0.02) 0.045 (0.03) 0.10 (0.013) (0.016) (0.01 10 ⁻⁹ Pa range (10 ⁻¹¹ Torr and mbar) 10 ⁻⁹ Pa range (10 ⁻¹¹ Torr 10 ⁻¹⁰ Pa range (10 ⁻¹¹ Torr 155 range CK70 CF114 CF CF DC 155 range GST-07L-B GST-07L-B GST-07L-B GST-07L-B CF DC +7.5 DC +7.5 DC 225 225 About 9.5 About 12.8 About 12.8 About 125 range 108 x 183 x187 153 x 204 x 241 155 x 34 - Single phase 200V.300W Single phase	Active Gas Rare Gas Active Gas Rare Gas Active Gas Rare Gas Rare Gas 0.03 (0.02) 0.045 (0.03) 0.10 (0.08) (0.010) (0.010) (0.010) 10 ⁻⁹ Parage (10 ⁻¹¹ Torr and mbar) < 8x10 ⁻³ Pa (<6x10 ⁻⁵ Torr, <<8x10 ⁻⁵ mbar) < 8x10 ⁻³ Pa (<6x10 ⁻⁵ Torr, <<8x10 ⁻⁵ mbar) < 5x10 ⁻³ Pa (<4x10 ⁻⁵ Torr, <<5x10 ⁻⁵ mbar) CF70 CF114 CF152 GST-07L-B GST-07L-B GST-07L-B QST-07L-B QST-07L-B QST-07L-B DC +7.5 DC +7.5 DC +7.5 250 250 250 About 9.5 About 12.8 About 37 108 x 183 x187 153 x 204 x 241 155 x 340 x 340 - Single phase 200V,300W Single phase	Active Gas Rare Gas Active Gas Rare Gas Active Gas Rare Gas Rare Gas Rare Gas 0.03 (0.02) 0.045 (0.03) 0.10 (0.08) 0.11 (0.06) 0.11 (0.06) (0.013) (0.016) (0.017) (0.016) (0.017) - 10 ⁻⁹ Pa range (10 ⁻¹¹ Torr and mbar) 10 ⁻⁹ Pa range (10 ⁻¹¹ Corr and m	Active Gas Rare Gas Active Gas Rare Gas Active Gas Rare Gas Rare Gas Active Gas 0.03 (0.02) 0.045 (0.03) 0.10 (0.08) 0.11 (0.06) (0 (0.013) (0.016) (0.05) - (0.02) 10 ⁻⁹ Pa range (10 ⁻¹¹ Torr and mbar) 10 ⁻⁹ Pa range (10 ⁻¹¹ Torr and mbar) 10 ⁻⁹ Pa range (10 ⁻¹¹ Torr and mbar) 10 ⁻¹⁰ Pa range (10 ⁻¹¹ Torr and mbar)	$\begin{array}{ c c c c c c } Active Gas & Rare Gas & O.03 & O.02 & O.045 & O.03 & O.10 & O.08 & O.11 & O.06 & O.20 & O.105 & O.10 & O.07 & O.02 & O.105 & O.105 & O.11 & O.06 & O.20 & O.105 & O.105 & O.11 & O.06 & O.20 & O.105 & O.105 & O.11 & O.06 & O.20 & O.105 & O.105 & O.11 & O.06 & O.20 & O.105 & O.105 & O.11 & O.06 & O.20 & O.105 & O.105 & O.11 & O.06 & O.20 & O.105 & O.105$	$\begin{array}{ c c c c c c c c c c c c c c c c c c c$				

*1) During the time of use of the GST-07L-B-Type controller. *2) At 1 x 10^{-7} Pa (8 x 10^{-10} Torr, 1 x 10^{-9} mbar).

Controller for PST series GST-07L-B

The GST-07L-B is a sputter ion pump controller with the high functionality and reliability through the plenty of technology and long time experience in ultra-high vacuum area that ULVAC has engaged.



GST-07L-B

Model	GST-07L-B				
Display range	7 segments LED display				
a) Output current display	2 ranges, mA and μ A, automatic switchable (linear scale)				
b) Output voltage display	DC 0.0 to 7.5kV				
c) Pressure display	10 ⁻² to 10 ⁻⁸ Pa, 10 ⁻⁴ to 10 ⁻¹⁰ mbar)				
	DC +7.5kV (2 points, H and L, setting switchable on the front control panel)				
Output release voltage	Volume variable from about 1.0 to 7.5kV for H and L setting voltage				
Torrest could and a constant	AC100 to 115V ±10%, 50/60Hz, 3.0A or lower				
Input voltage / current	AC200 to 240V \pm 10%, 50/60Hz, 1.5A or lower				
Monitor terminal output signal	Output of signals being proportionate to 7 segments panel display. DC 0 to 10V full scale for each range, more than 100k Ω				
Pressure set point	2 points				
Remote / Local	Switchable on the front control panel				
External control functions	Various input functions (with remote connector) for remote control and RS-232C communication				
	Error display / various protection functions				
Protection functions	High voltage output cutoff when error lighted (ERR 0 to 5)				
	Startup protection timer (adjustable from 1 to 255 minutes)				
Weight	Main unit: Approx. 4kg				
Dimensions W x D x H	240 x 370 x 99 mm (W : 200mm without the rack mounting bracket.)				

ntrolle

ium Pump

Vacuum Valve

Vacuum Gauge

Process Ga

Vacuum Valve ►Selection Guide

Wide range line-up to meet various needs, from vacuum angle valve to pendulum valve, from 16A (5/8 inch) to 900A (36 inch) and from atmospheric pressure to extreme high vacuum.











VLP-SADDKC

VLP-SADDJH

VLH-SB UJH

VLP-SBDDCH VLP-SBDDKF

VFR

■Category chart

Туре	Category	Series
		VLP-SA vacuum angle valve (double acting / stainless / O-ring shaft feedthrough)
		VLP-SB vacuum angle valve (double acting / stainless / bellows shaft feedthrough)
	VLP vacuum angle valve (double acting)	VLP-MB vacuum angle valve (double acting / stainless / ultra-high vacuum)
Vacuum angle valve		VLP-U vacuum angle valve (double acting / iron / O-ring shaft feedthrough)
	VI B viscours and visiting (single patient)	VLB-SA vacuum angle valve (single acting / stainless / O-ring shaft feedthrough)
	VLB vacuum angle valve (single acting)	VLB-SB vacuum angle valve (single acting / stainless / bellows shaft feedthrough)
	VLH vacuum angle valve (manual)	VLH-SB vacuum angle valve (manual / stainless / bellows shaft feedthrough)
		VLH-MB vacuum angle valve (manual / stainless / ultra-high vacuum)
Pendulum valve	VFR pendulum valve	

■Specifications

Series	Vacuum level (*1)	Pressure range abs. [Pa] <mbar> (Torr)</mbar>	Туре	Actuation	Body material	Max. baking temperature [°C] (*2)	Allowable pressure difference [MPa] <bar> (Torr)</bar>
VLP-SA	v	Atm. to [1.0E-5] <1.0E-7> (7.5E-8)	Angle	Double acting	Stainless steel 304	150	[0.10] <1> (750)
VLP-SB	HV	Atm. to [1.0E-6] <1.0E-8> (7.5E-9)	Angle	Double acting	Stainless steel 304	150	[0.10] <1> (750)
VLP-MB	UHV	Atm. to [1.0E-8] <1.0E-10> (7.5E-11)	Angle	Double acting	Stainless steel 304	150 (200)	[0.10] <1> (750)
VLP-U	v	Atm. to [1.0E-5] <1.0E-7> (7.5E-8)	Angle	Double acting	Steel 400+Ni Plating	60	n/a
VLB-SA	v	Atm. to [1.0E-5] <1.0E-7> (7.5E-8)	Angle	Single acting NC(*3)	Stainless steel 304	150	[0.10] <1> (750)
VLB-SB	HV	Atm. to 1.0E-6 <1.0E-8> (7.5E-9)	Angle	Single acting NC(*3)	Stainless steel 304	150	[0.10] <1> (750)
VLH-SB	HV	Atm. to 1.0E-6 <1.0E-8> (7.5E-9)	Angle	Manual	Stainless steel 304	150	[0.10] <1> (750)
VLH-MB	UHV	Atm. to [1.0E-8] <1.0E-10> (7.5E-11)	Angle	Manual	Stainless steel 304	150 (200)	[0.10] <1> (750)
VFR	HV	[1.2E5] <1.2E4> (900) to [1.0E-6] <1.0E-8> (7.5E-9)	Pendulum	Double acting CL retention (*4)	Aluminum Alloy	120	[0.12] <1.2> (900)

*1) Refer to "Feedthrough" about relationship between vacuum level and feedthrough.
*2) Actuator < 60 °C. The value inside the () are when it is opened.
*3) Single acting NC···Normally closed (Valve automatically closes when compressed air is released.).
*4) Double acting CL retention···Double-acting but the valve is kept closed when compressed air is released.

Vacuum Valve Selection Guide

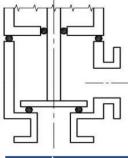
Portfolio table

Nominal	♦A (ISO)	[mm]	016	020	025	040	050	063	080	100	160	200	250	320	-	400	-	500	550	900
diameter	♦A (JIS)	[mm]	-	020	025	040	050	065	080	100	150	200	250	300	350	400	450	500	600	900
(*1)	●В	[inch]	5/8	3/4	1	1.1/2	2	2.1/2	3	4	6	8	10	12	14	16	18	20	22	36
VLP-SA□JH		VF		\diamond		\diamond														
VLP-SA□KF		ISO-KF	•		•	•	•													
VLP-SA□KC	;	ISO-K						•	•	•	•	•	•							
VLP-SB□JH		VF		\diamond																
VLP-SB□KF		ISO-KF	•		•	•	•													
VLP-SB□KC	;	ISO-K						•	•	•	•	•	•							
VLP-SB□CH	1	ISO-CF	•			•														
VLP-MB CH	ł	ISO-CF	•			•		•		•	•									
VLP-U		VF																		
VLB-SA□KF		ISO-KF	•		•	•	•													
VLB-SB□KF		ISO-KF	•		•	•	•													
VLH-SB□JH		VF		\diamond																
VLH-SB□KF		ISO-KF	•		•	•	•													
VLH-SB□KC	;	ISO-K						•	•	•	•									
VLH-SB□CH	1	ISO-CF	•			•														
VLH-MB□CI	4	ISO-CF	•			•		•		•	•									
VFR-D		VF														\diamond		\diamond		

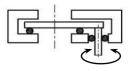
*2) Contact us for details.

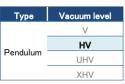
ISO-CF nominal diameter	016	025	040	063	100	160	200	250
ULVAC-UFC nominal diameter	034	054	070	114	152	203	253	306

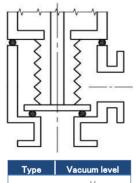
Feedthrough



Туре	Vacuum level
	v
	HV
Angle	UHV
	XHV



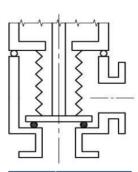




	V						
A	HV						
Angle	UHV						
	XHV						

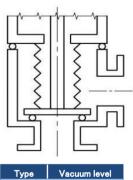


Bellows seal



Туре	Vacuum level			
	V			
Angle	ΗV			
	UHV			
	XHV			

Vacuum level				
V	≦10 ⁻⁵ Pa 10 ⁻⁷ Torr(mbar)			
HV	≦10 ⁻⁶ Pa 10 ⁻⁸ Torr(mbar)			
UHV	≦10 ⁻⁸ Pa 10 ⁻¹⁰ Torr(mbar)			
XHV	≦10 ⁻⁹ Pa 10 ⁻¹¹ Torr(mbar)			



Туре	Vacuum level
	V
	HV
Angle	UHV

XHV

Power Supply / EB Source Deposition Controller Mea	Thi
leasurement	Thin Film
Accessories	
Transfer Robot	Vacuum
Equipment	Cryogenic

Vacuum Pump

Vacuum Valve

Vacuum Gauge

Process Gas Monitor

Leak Detector

Power S (DC/RF)

Supply

45

Vacuum Gauge Selection Guide

Selection Guide

Long time experienced and proven know-how from ULVAC who is the leading company of vacuum technology is also utilized in our vacuum measurement product line-up.

	Ра	1E-11	1E-10	1E-9	1E-8	1E-7	1E-6	1E-5	1E-4	1E-3	1E-2	1E-1	1E+0	1E+1	1E+2	1E+3	1E+4	1E+5
Pruduct	mbar	1E-13	1E-12	1E-11	1E-10	1E-9	1E-8	1E-7	1E-6	1E-5	1E-4	1E-3	1E-2	1E-1	1E+0	1E+1	1E+2	1E+3
	Torr	7.5E-14	7.5E-13	7.5E-12	7.5E-11	7.5E-10	7.5E-9	7.5E-8	7.5E-7	7.5E-6	7.5E-5	7.5E-4	7.5E-3	7.5E-2	7.5E-1	7.5E+0	7.5E+1	7.5E+2
Atmospheric Pressure Sensor																	S	AU
															CC	MT-100	0D	
Course itteration Management of														C	CMT-10)D		
													C	CMT-10	D			
Sepacitance Manometer												(CCMT-1)				
Pirani Gauge			-					-						S	W100			
Pirani Gauge															SP1			
Cold Cathode Type Ionization g	auge									S	C1							
La											ST200							
ransduce												ST20	0 + SWI	J10-R				
											S	5T200 +	SWU10	-R + SA	U			
Multi Ionization Gauge									S	H200								
											SH200	+ SWU1	10-R					
										SH	200 + S	WU10-F	R + SAU					
υ													G	P-1G(R)	Y)/1000	G		
စို Pirani Gauge															001G			
ם									GI-	D7•WIT								
Hot Cathode Type Ionization ga	auge							G	I-D7·W									
ច Extremely High Vacuum Gauge						AxT	RAN											
Samrtphone-Direct Pirani G														SW	/U10-U			

Vacuum Gauge Calibration Service JCSS

ULVAC is the first company in Japan to receive JCSS accreditation in the vacuum field as a vacuum gauge calibration laboratory.





- At June 3, 2010, accredited as a JCSS-MRA calibration laboratory (JCSS 0258), the first ISO/IEC 17025 compliant calibration laboratory of pressure (vacuum) field in Japan.
- Running JCSS calibration based on ISO/IEC17025.
- JCSS-calibration certificate is available around the countries and region of the ILAC and APLAC MRA.
- Vacuum gauge compliant with calibration possible : Thermal conductivity gauge (pirani vacuum gauge), diaphragm vacuum gauge, ionization vacuum gauge, viscosity vacuum gauge.
 - $(\ensuremath{\mathsf{Supports}}\xspace$ all vacuum gauges from our company as well as those manufactured by other companies.)

Designation for the classification of calibration method	Category	Calibration range	Highest measurement capacity (trust level approx. 95%)
		Above 0.1mPa less than1mPa	2.0%
	Viscosity vacuum gauge	Above 1mPa less than 10mPa	1.0%
		Above 10mPa less than 0.1Pa	0.8%
		Above 0.1Pa less than 1Pa	0.7%
	Diaphragm vacuum	Above 1Pa less than 100Pa	1.5%
Vacuum gauge		Above 10kPa less than 133kPa	0.6%
	gauge	Above 0.1mPa less than 1mPa	0.3%
	• • •	Above 0.1mPa less than 1mPa	5.0%
	Ionization gauge	Above 1mPa less than 1Pa	3.0%
	Thermal conductivity gauge	Above 1Pa less than 1kPa	2.0%

Vacuum Gauge Transducer type Vacuum Gauge

Multi-Ionization Gauge G-TRAN series ST200/SH200

Transducer type vacuum gauge which is connectable with different measurement range sensor units. It saves running cost significantly.





Example of combination use with optional unit

ST200/SH200

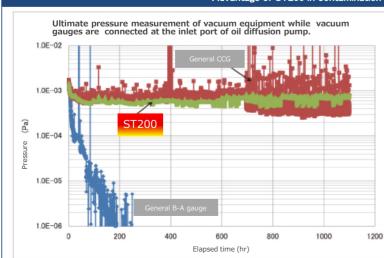


Image of connection by PC/smartphone

- ST200-A/ST200-R
 - The world's first metal type triode ionization gauge (patented). Long lifetime taking advantage of triode type even in harsh environment for vacuum gauges
 - Measurement accuracy is improved at $\pm 10\%$ and sensitivity stability is also improved significantly.
 - For measurement of ultimate pressure of vacuum furnaces / organic EL or touch panel manufactured systems, in atmosphere with lots of hydrocarbon or cleaning fluid, and in equipments where reduction of replacement frequency for sensor heads is required.
- SH200-A/SH200-R
 - · For measurement from ultra-high vacuum to high-vacuum.
 - For measurement of ultimate pressure of sputtering or evaporation system for PV·FPD / SEMI and electronic component manufacturing systems, and pressure monitoring for ultra high vacuum equipment
- Common to ST200/SH200
 - Operable in combination with optional pirani sensor unit and pressure sensor unit.
 - The world's smallest class (56% reduction of controller volume compared to the previous model)
 - Easy set point setting and status check by connecting PC/smartphone.
 - Eilament life alarm function by monitoring filam

Model	ST200-A	ST200-R	SH200-A	SH200-R			
	1 x 10 ⁻⁵ to	1 x 10 ⁺¹ Pa	5 x 10 ⁻⁸ to 1	x 10 ⁺¹ Pa			
Measurement pressure range	7.5 x 10 ⁻⁸ to	7.5 x 10 ⁻² Torr	7.5 x 10 ⁻¹¹ to 7.	5 x 10 ⁻² Torr			
	1 x 10 ⁻⁷ to 1	x 10 ⁻¹ mbar	1 x 10 ⁻¹⁰ to 1 :	x 10 ^{−1} mbar			
Accuracy	\pm 10%: 1 x 10 ⁻⁴ to 3Pa, 7.5 x 10 ⁷ to 2	$\pm 10\%$: 1 x 10 ⁻⁴ to 3Pa, 7.5 x 10 ⁷ to 2.2 x 10 ⁻² Torr, 1 x 10 ⁻⁶ to 3 x 10 ⁻² mbar $\pm 15\%$					
Filament	1 pc (Ir	1 pc (lr/Y ₂ O ₃) 2 pcs (lr/Y ₂ O ₃ and W)					
Degas method		Electron bombardment					
Measurement value output		LOG output (DC 0 to 10V)					
Set point	3 points (open collector output)	None	3 points (open collector output)	None			
Serial communication	None	RS232C / RS485	None	RS232C / RS485			
Power supply voltage		DC 2	0 to 28V				
Dimensions		69 x 63 x 125 mm	n (ST200 / SWT-16)				
Connectable sensor unit		Pirani sensor unit SWU10-R (optional), pressure sensor unit SAU (optional)					
Connectable sensor head	SWT-16 (KF16),	SWT-25 (KF25)	M-44 (KF16), M-45 (KF	25), M-46 (ICF070)			
Applicable standard	CE						

* Connectable with different measurement range sensor units. Measurable from low-vacuum to atmospheric pressure in combination with pirani sensor unit SWU10-R and pressure sensor unit SAU.



Advantage of ST200 in contamination resistance

[General B-A gauge] Sensitivity got deteriorated (measurement value got lower) significantly in short time. Cannot continue to use.

[General CCG]

Measurement value fluctuated and the fluctuation range became wider halfway through measurement. Difficult to continue to use any longer.

[ST200]

Measurement value was stable from start to finish.

Long life of ST200 can be expected in applications much contamination.

Vacuum Pump

Vacuum Gauge Transducer type Vacuum Gauge

Pirani Vacuum Gauge G-TRAN series SW100/SP1

Pirani vacuum gauge which has user-friendly functions with a renewed design.





SW100-A/SW100-R

- Easy set point setting and status check by connecting PC/smartphone
- Wide measurement range: 5×10^{-2} to $1 \times 10^{+5}$ Pa (3.75 x 10^{-4} to 760Torr, 5×10^{-4} to 1,013mbar).
- Excellent shock-resistance and vibration resistance design (patented).
- · For sputtering system, vacuum laminator, vacuum pump carousel system, manufacturing system where there is vibration from vacuum pumps, etc.
- SP1
- · Long time experienced sensor head WP series is used. Sensor head is fully compatible with other ULVAC Pirani vacuum gauges.
- For interlock and sequence control for various kind of vacuum manufacturing equipment, other rough pumping systems, etc.

Model	SW100-A	SW100-R		SP1		
	5 x 10 ⁻² to 1 x 10 ⁺⁵ Pa			4 x 10 ⁻¹ to 3.0 x 10 ⁺³ Pa		
Measurable pressure range	3.75 x 10	⁻⁴ to 760 Torr	3×10^{-3} to 22 Torr			
	5 x 10 ⁻⁴ t	o 1,013 mbar		4 x 10 ⁻³ mbar		
Accuracy	$\pm 10\%$ (1 x 10 ⁻¹ to 1 x 10 ⁺⁴ Pa, 7.5 x 10 ⁻⁴ ± 20\% (5 x 10 ⁻² to 1 x 10 ⁺⁵ Pa, 3.75 x 10 ⁻⁴		±15% ±30% ±50%	$\begin{array}{l} (51 \mbox{ to } 760\mbox{Pa}, \ 3.8 \ x \ 10^{-1} \ \ to \ 5.7\mbox{Torr}, \ 5.1 \ x \ 10^{-1} \ \ to \ 7.6\mbox{mbar}) \\ (10 \ \ to \ 1,000\mbox{Pa}, \ 7.5 \ x \ 10^{-2} \ \ to \ 7.5\mbox{Torr}, \ 0.1 \ \ to \ 10\mbox{mbar}) \\ (0.4 \ \ to \ 3,000\mbox{Pa}, \ 3 \ x \ 10^{-3} \ \ to \ 22\mbox{Torr}, \ 4 \ x \ 10^{-3} \ \ to \ 30\mbox{mbar}) \end{array}$		
Filament	Platinum (Pt)					
Measurement value output	DC 0 to 10V LOG output			DC 0 to 10V non-linear output		
Set point	2 points (open collector output)	None	2 points (open collector output)			
Serial communication / Digital output	None	RS232C/RS485	None			
Power supply voltage	DC 14 to 30V			DC 24V±2 V		
Dimensions	48 x 30 x 104 mm 50 x 30 x 146 mm			50 x 30 x 146 mm		
Sensor head model	SWP-16 (KF16), SWP-25(KF25), SWP-P18(dia.18), SWP-P15(dia.15), SWP-CF16(ICF034), SWP-R1/8 (R1/8) WP-01 (dia.18), WP-02 (dia.15), WP-03 (R3/8), WP-16			01 (dia.18), WP-02(dia.15), WP-03(R3/8), WP-16(KF16)		
Applicable standard		CE	_			

Capacitance Manometer G-TRAN series CCMT

ISG1

Vacuum gauge which detects change of static electric capacitance occurring from the ceramic



diaphragm transforms due to the change of gas pressure.

- Excellent corrosion resistance and long-time stable ceramic (alumina) diaphragm.
- Total pressure measurement not depending on gas types.
- Equipped with temperature compensation circuit.
- Sensor protection structure against contamination from flying objects.
- Warming up time after power-on until stabilization is greatly reduced.
- Coating process control for equipments such as sputtering, evaporator, etc. and pressure monitor for various kind of manufacturing equipment such for photovoltaic cell, etc.

Model	CCMT-1000D	CCMT-100D	CCMT-10D	CCMT-1D			
	133kPa	13.3kPa	1.33kPa	133Pa			
Range full scale (F.S.)	1,000Torr	100Torr	10Torr	1Torr			
	1,330mbar	133mbar	13.3mbar	1.33mbar			
Lowest reading	13Pa, 10 ⁻¹ Torr, 1.3 x 10 ⁻¹ mbar	1.3Pa, 10 ⁻² Torr, 1.3 x 10 ⁻² mbar	0.13Pa, 10 ⁻³ Torr, 1.3 x 10 ⁻³ mbar	0.013Pa, 10 ⁻⁴ Torr, 1.3 x 10 ⁻⁴ mbar			
Practical lowest reading	66.6Pa, 5 x 10 ⁻¹ Torr, 6.7 x 10 ⁻¹ mbar	6.7Pa, 5 x 10 ⁻² Torr, 6.7 x 10 ⁻² mbar	0.67Pa, 5 x 10 ⁻³ Torr, 6.7 x 10 ⁻³ mbar	6.7 x 10 ⁻² Pa, 5 x 10 ⁻⁴ Torr, 6.7 x 10 ⁻⁴ mbar			
Accuracy	\pm 0.2% for the indicated value \pm temperature coefficient (2 hours after power-on at 25 °C)						
Display		None (optional display: ISG1)					
Measurement value output	Linear output (DC 0 to 10V)						
Set point		None					
Material where gas contacts		AL ₂ O ₃ , Vacon70, SUS316, glass ceramic solder, Ag Ti Cu hard solder					
Power supply voltage		DC 14 to 30V					
Dimensions	Dia. 55 x 117 mm						
Fitting		KF16, 1/2 pipe(dia.12.7), 8VCR					
Applicable standard		CE					

Vacuum Gauge Transducer type Vacuum Gauge

Pressure Sensor Unit G-TRAN series SAU

Semiconductor type thin-film element makes measurement near atmospheric pressure (gauge pressure : -100 kPa to 10kPa, - 1bar to 0.1 bar, -14.5psi to 1.45psi) accurate.



SAU

•	Optimum for atmospheric pressure checking because pressure standard is for gauge pressure. It measure atmospheric
	pressure accuracy.
	Semiconductor type this film element makes continuous use in high yearum process pessible (SUS2161)

- Semiconductor type thin film element makes continuous use in high vacuum process possible (SUS316L).
- DC 0-5 linear output as standard.
- Power supply is widely supported from DC 12V to 24V.
- Atmospheric pressure checking or gauge pressure measurement for various kind of coating system such as PV·FPD·SEMI· electronic devices manufacturing system.

Model	SAU
Pressure standard	Gauge pressure
Measurable pressure range (gauge pressure)	−100 to 10kPa −750 to 75Torr −1,000 to 100mbar
Accuracy	±3% F.S.
Measurement value output	DC 0 to 5V linear output
Material	SUS316L
Sensor pressure proof	200kPa, 1,500Torr, 2,000mbar (gauge pressure) *need for the consideration of pressure resistance of the flange and the clamp.
Power supply	DC 12 to 24V±10%
Dimensions	dia. 30 x 68mm
Flange	KF16

Cold Cathode Ionization Gauge G-TRAN series SC1

Reverse magnetron cold cathode gauge.



- Simple structure makes periodical maintenance easy and inexpensive
- No filament. Sensor is recyclable by cleaning.
- 2 set points.
- Various kind of vacuum furnace, evaporator, organic EL manufacturing system and other high vacuum system.

Model	SC1
Measurable pressure range	1 x 10 ⁻⁵ to 1 x 10 ⁰ Pa 7.5 x 10 ⁻⁸ –7.5 x 10 ⁻³ Torr 1 x 10 ⁻⁷ –1 x 10 ⁻² mbar
Accuracy	-50 to +100% (1 x 10 ⁻⁴ to 1 x 10 ⁻¹ Pa, 7.5 x 10 ⁻⁷ -7.5 x 10 ⁻⁴ Torr, 1 x 10 ⁻⁶ -1 x 10 ⁻³ mbar)
Measurement value output	DC 0 to 10V nonlinear output
Set point	2 points (open collector output)
Serial communication / digital output	None
Power supply voltage	DC 24V±2V
Dimensions	dia. 90 x 145 (C-21)
Sensor head model	C-21 (dia. 18/15), C-23 (ICF034), C-24 (KF16), C-25 (KF25)

Display Unit G-TRAN series ISG1

Display for all G-TRAN series and CCMT series.



- Usable with all G-TRAN series (excluding serial communication model: SW100-R/ST200-R/SH200-R)
- 3 set points
- DIN standard compact design
- LED display

Nodel	ISG1
Number of connectable sensor unit	1 unit
onnectable sensor unit	SW100-A, SP1, ST200-A, SH200-A, SC1, CCMT
dication	Digital display mantissa portion: 2 digit Exponent portion: 1 digit
easurement value output	DC 0 to 10V
: point	3 points
npling time	70ms
wer supply	DC 24V±1V
mensions	DIN 48 x 70 x 96 mm
blicable standard	CE

Vacuum Pump

Vacuum

Valve

/acuum Gauge

Gas

Leak Detector

(DC/RF)

EB Powe

Supply / EB Source

Deposition

Controlle

Thin Film Measurement

Acce

Vacuum Gauge General Purpose Type Vacuum Gauge

GP-G series Pirani Vacuum Gauge

Constant temperature Pirani vacuum gauge which utilizes heat conductivity of gases.

Bestseller product, more than 150,000 units.







GP-1G with case

• Display is included as standard. Analog or digital display.

• Long time experienced sensor head WP series is used. Sensor head is fully compatible with other ULVAC Pirani vacuum gauges.

- Filament is corrosion resistant platinum (Pt).
- Various interface function according to usage : Digital output, serial communication, control output signal (set point), etc.

For sputtering system, vacuum laminator, vacuum pump carousel system and interlock and sequence control various kind of vacuum manufacturing system, and other rough pumping systems, etc.

Model	GP-1000G	GP-2001G	GP-1GRY(A)	GP-1G	GP-1G with ca
	0.4 to 2,700Pa	0.4 to 3,000Pa		0.4 to 2,700Pa	
Measurable pressure range	3×10^{-3} to 20Torr	3×10^{-3} to 22.5Torr		3×10^{-3} to 20Torr	
	4 x 10 ⁻³ to 27mbar	4×10^{-3} to 30mbar		4 x 10 ⁻³ to 27mbar	
Pressure unit	Pa or Torr	Pa∕kPa	Pa or Pa / Torr	Pa or	· Torr
Accuracy	±15% (51 to 760Pa, 0.38 t ±30% (10 to 1,000Pa, 0.075 ±50% (0.4 to 2,700 / 3,000Pa, 3 x 10	to 7.5Torr, 0.1 to 10mbar),	Within $\pm 3\%$ of t	he 100% straight scale conve	ersion full scale
Indication	Digital display (LCD) Mantissa portion: 2 columns/exponent Portion: 1 column	Digital display (LED) 4.5 columns		Analog display	
Measurement value output	DC 0 to 10V linear output	DC 0 to 10V linear output	DC 0 to 10mV non-linear output		ut
Set point	3 point (relay contact output)	3 point (open collector output)	2 points (relay contact output)	Νο	ne
Serial communication / digital output	RS232C / BCD output		None		
Power supply voltage	AC100 t	o 240V		AC100 to 240V	
Dimensions (display control unit)	50 x 236 x 99mm	99 x 136 x 48mm	100 x 111 x 100mm	100 x 130 x 100mm	150 x 134 x 191mm
Sensor head	٧	/P-01 (dia. 18), WP-02 (dia. 15), WP-03 (R	3/8), WP-16 (KF16), WPB-10	-034 (ICF034)	
Applicable standard	CE		_		

Ionization gauge / XHV Gauge GI-D7 / AxTRAN

Hot cathode ionization vacuum gauge for medium to ultra / extreme high vacuum range.







GI series

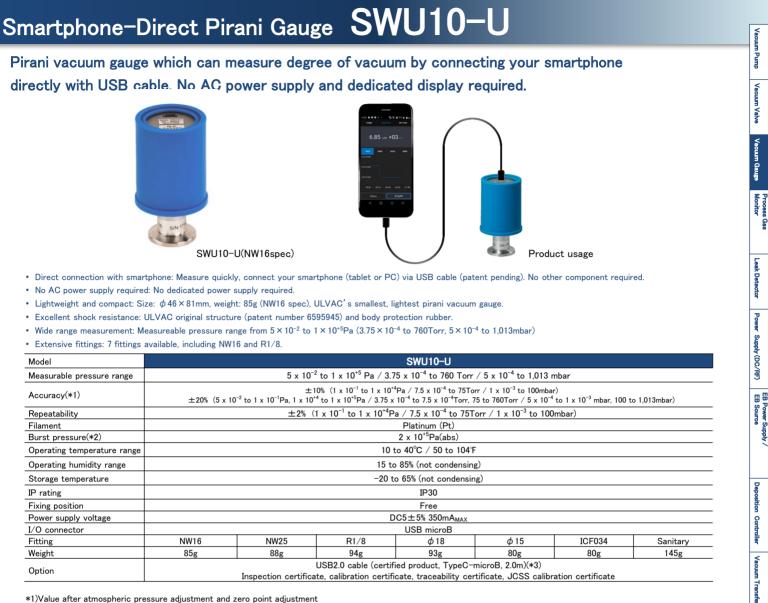
- Medium to ultra high vacuum range.
- · Glass tube and nude type sensor head is available according to your application.
- GI-D7(WIT) is for vacuum heat treatment furnace, vacuum brazing furnace, evaporator (oil diffusion pump), etc. GI-D7(WIB) is for sputtering system, evaporator (turbo molecule pump), various kind of high and ultra-high vacuum system, etc.

AxTRAN

- Ultra high vacuum to extreme high vacuum range. Lowest range is 10⁻¹¹Pa (10⁻¹³Torr, 10⁻¹³mbar). Wide range measurement from 0.5 x 10⁻¹⁰ to 1 x 10⁻²Pa (0.4 x 10⁻¹² to 7.5 x 10^{-5} Torr, 0.5 x 10^{-12} to1 x 10^{-4} mbar).
- Bessel box energy filter reduces residual current such as soft x-rays and ESD ions, etc.
- · For high-energy accelerators, ultra high and extreme high vacuum equipment, etc

Product	(Glass type) ionization vacuum gauge	Extremely high vacuum gauge	
Model	GI-D7	AxTRAN	
Pressure range WIT: 1.3×10^{-5} to 6.7×10^{-1} Pa, 1.0×10^{-7} to 5×10^{-3} Torr, 1.3×10^{-7} to 6.7×10^{-3} mbar WIB: 1.3×10^{-6} to 1.3×10^{-2} Pa, 1.0×10^{-8} to 1.0×10^{-4} Torr, 1.3×10^{-8} to 1.3×10^{-4} mbar		0.5 x 10 ⁻¹⁰ to 9.99 x 10 ⁻³ Pa, 3.7 x 10 ⁻¹² to 7.5 x 10 ⁻⁵ Torr, 0.5 x 10 ⁻¹² to 9.99 x 10 ⁻⁵ mbar	
Pressure unit	Pa or Torr	Pa or Torr	
Accuracy	$\pm 15\%$		
Display	Digital display (LED) mantissa portion: 3 columns / exponent portion: 2 columns		
Measurement value output	Mantissa portion linear output, quasi-LOG output (DC 0 to 10V)		
Set point	2 points (relay contact outp	2 points (relay contact output)	
Serial communication	RS232C / BCD output	RS232C / BCD output (option)	
Power supply	AC 100 V±10 V	AC 85 to 240V	
Dimensions (display control unit)	240 x 380 x 99 mm	240 x 380 x 99 mm	
Sensor head	WIT-G1(W•dia.18/15), WIT-G8(Ir•dia.18/15), WIB-G5(dia.18/15), WIB-N3(ICF070)	X-11 (ICF070)	

Vacuum Gauge Smartphone-Direct Gauge



*2)Consider separately burst pressure of flange and clamp, etc

*3)Select TypeC-microB OTG cable when using a commercial USB cable

Available smartphone(*4)	
Android 6 or later	
Connector: USB TypeC	
*4)For available smartphone models list, see ULVAC web page.	

	() · · · · · · · · · · · · · · · · · · ·	
Application software	"UL-MOBI"(*5)	
For smartphone: Downloa	d from Google Play	

For PC: Download from ULVAC web page

GET IT ON Image of "UL-MOBI" on smartphone Image of "UL-MOBI" on PC Google Play 6.86 6.85 x10 +03 Pressure value display Trend graph display Data logging function Log data is saved as CSV format. Sampling interval: Min. 200ms

Robo

Process Gas Monitor (Residual Gas Analyzer)

Basic Process Gas Monitor Qulee BGM2 series

For various kind of evaporator and vacuum furnace for quality control and yield ratio improvement.



· Residual gas analysis.

- Integrated display does not always require PC for operation. Simple and easy with one touch function.
- Electron stimulated desorption (330V, 5mA) for degas.
- · Preventive maintenance function for ion source, secondary electron multiplier and analyzer tube.
- For evaporator, vacuum furnace, organic EL manufacturing system, PV·FPD·semiconductor manufacturing system and other high vacuum systems.



Quiee BGM2-102

Model	BGM2-101	BGM2-201	BGM2-102	BGM2-202
Mass range	1 to 100 amu	1 to 200 amu	1 to 100 amu	1 to 200 amu
Resolution	M/△M=1M (10%P.H.)			
Detector	Faraday cup		EM tube ∕ faraday cup	
Sensitivity	1 x 10 ^{.7} A/Pa, 1.33 x 10 ^{.5} A/Torr, 1 x 10 ^{.5} A/mbar		4 A/Pa, 532 A/Torr, 400 A/mbar	
Minimum detectable partial pressure	1 x 10 ⁻⁸ Pa, 7.5 x 10 ⁻¹¹ Torr, 1 x 10 ⁻¹⁰ mbar		1 x 10 ⁻¹² Pa, 7.5 x 10 ⁻¹⁵ Torr, 1 x 10 ⁻¹⁴ mbar	
Maximum operating pressure	1 x 10 ⁻² Pa, 7.5 x 10 ⁻⁵ Torr, 1 x 10 ⁻⁴ mbar			
Maximum bake out temperature	120°C, 248F (when analyzer tube is connected) 250°C, 482F (without analyzer tube)			
Interface	Ethernet			
Software	Qulee QCS Ver.4.2 later (Windows 8/10/11 supported)			
Applicable standard			CE	

High Performance Process Gas Monitor Qulee HGM2 series

For research & development equipment



Qulee HGM2-202

		Monitor Qulee HGM2 series				
Interface : Ethernet						
 Highest sensitivity 2.5 x 10⁻⁶ A/F Measurable while baking at 250 Electron stimulated desorption (Preventive maintenance functio For thermal desorption gas anal environmental analysis, etc. 	°C (482F) or below. Maximur 330V, 5mA) for degas. n for ion source, secondary e	n 300°C (572F) when ana	vzer tube.			
Model	HGM2	-202	HGM	0.000		
			101	2-302		
Mass range	1 to 200) amu		00 amu		
Mass range Resolution	1 to 200) amu M/△M=1M (1 to 30			
¥	1 to 200 Faraday cup		1 to 30			
Resolution		M/△M=1M	1 to 30 (10% P.H.)	D0 amu		
Resolution Detector	Faraday cup 2.5 x 10 ⁻⁶ A/Pa 3.3 x 10 ⁻⁴ A/Torr	M/△M=1M EM tube 4 A/Pa 532 A/Torr	1 to 30 (10% P.H.) Faraday cup 2 x 10 ⁻⁶ A/Pa 2.6 x 10 ⁻⁴ A/Torr	00 amu EM tube 4 A/Pa, 532 A/Torr		
Resolution Detector Sensitivity	Faraday cup 2.5 x 10 ⁶ A/Pa 3.3 x 10 ⁴ A/Torr 2.5 x 10 ⁻⁴ A/mbar 1 x 10 ⁻⁹ Pa 7.5 x 10 ⁻¹² Torr	M/△M=1M EM tube 4 A/Pa 532 A/Torr 400 A/mbar 1 x 10 ⁻¹³ Pa 7.5 x 10 ⁻¹⁶ Torr	1 to 30 (10%P.H.) 2 x 10 ⁶ A/Pa 2.6 x 10 ⁴ A/Torr 2 x 10 ⁴ A/mbar 1 x 10 ³ Pa 7.5 x 10 ⁻¹² Torr 1 x 10 ⁻¹¹ mbar	00 amu EM tube 4 A/Pa, 532 A/Torr 400 A/mbar 1 x 10 ⁻¹³ Pa 7.5 x 10 ⁻¹⁶ Torr		

Ethernet Qulee QCS Ver.4.2 later (Windows 8/10/11 supported)

CF

Compact Process Gas Monitor Qulee CGM2 series

For sputtering system for process control, quality control and yield ratio improvement.

Interface

Software Applicable standard

- No differential pumping system required for process monitoring up to 1Pa (7.5 x 10⁻³Torr, 1 x 10⁻²mbar).
 - Integrated display does not always require PC for operation. Simple and easy with one touch function.
 - Electron stimulated desorption (330V, 5mA) for degas.
 - · Preventive maintenance function for ion source, secondary electron multiplier and analyzer tube.
 - For sputtering system.

Model	CGM2-051	CGM2-101	CGM2-052	CGM2-102
Mass range	1 to 50 amu	1 to 100 amu	1 to 50 amu	1 to 100 amu
Resolution	M/△M=1M (10%P.H.)			
Detector	Faraday cup		EM tube ∕ faraday cup	
Sensitivity	1 x 10 ⁻⁷ A/Pa, 1.33 x 10 ⁻⁵ A/Torr, 1 x 10 ⁻⁵ A/mbar		1 x 10 ⁻⁴ A/Pa, 1.33 x 10 ⁻² A/Torr, 1 x 10 ⁻² A/mbar	
Minimum detectable partial pressure	1 x 10 ⁻⁷ Pa, 7.5 x 10 ⁻¹⁰ Torr, 1 x 10 ⁻⁹ mbar		1 x 10 ⁻¹⁰ Pa, 7.5 x 10 ⁻¹³ Torr, 1 x 10 ⁻¹² mbar	
Maximum operating pressure	2Pa, 1.5 x 10 ⁻² Torr, 2 x 10 ⁻² mbar		1 x 10 ⁻² Pa, 7.5 x 10 ⁻⁵ Torr, 1 x 10 ⁻⁴ mbar (SEM) 2Pa, 1.5 x 10 ⁻² Torr, 2 x 10 ⁻² mbar (FC)	
Maximum bake out temperature			alyzer tube is connected) nout analyzer tube)	
Interface	Ett		ernet	
Software		Qulee QCS Ver.4.2 later (V	Vindows 8/10/11 supported)	
Applicable standard		(Æ	



Qulee CGM2-051/101

Process Gas Monitor (Residual Gas Analyzer)

Process Gas Monitor with Pumping System/ Vacuum model

Qulee with YTP-H

For wide range of usage from process control, residual gas analysis of various vacuum equipments to R&D.

- Excellent cost performance : From processing monitoring to residual gas analysis by single unit.
- BGM2-101 and 102 for 1-100amu, BGM2-201 and 202 for 1-200 amu and HGM2-302 for 1-300 amu
- The analytical pressure can be selected from 3000 Pa, 500 Pa, 100 Pa, 10 Pa, 1 P or VLV specifications.compact design : Utilizes standard
- vacuum unit model desktop YTP
- Low noise : 43dB(A) or less at Ultimate pressure.

Process gas monitor		Select from BGM2-101, BGM2-102, BGM2-201, BGM2-202, HGM2-302
Maximum operation pressure		Select from, 3,000,500,100,10,1Pa / 22.5,3.75,7.5,0.75,0.075Torr / 30,5,1,0.1,0.01mbar
Gas introduction system (Vac (3000 to 1Pa, 22.5 to 0.0751)		Manual bellows valve (2 way), Flange : IFC070
	Turbo Molecular Pump	70L/s (N ₂)
Pump unit desktop YTP (YTP70A-D)	Dry pump	20L/min
(TIP/UA-D)	Ultimate pressure	Below 10 ⁻⁶ Pa
Power supply		Single phase AC100-240V, 300W (Vacuum type)
Software		Qulee QCS Ver.4.2 later (Windows 7/8/10/11 supported)

* Pumping system desktop YTP, Qulee main unit, gas inlet and other parts are packaged separately. Please refer to the assembly manual for set up.

Process Gas Monitor with Pumping System/ Atmospheric pressure specification model Quiee with YTP-H

For wide range of usage from process control, residual gas analysis of various vacuum equipments to R&D.



Qulee with YTP-H Vacuum model

Qulee with YTP-H Atmospheric pressure specification Model

Quiee RGM2-201F

•	Excellent cost performance : From processing monitoring to residual gas analysis by single unit.
•	BGM2-101 and 102 for 1-100amu, BGM2-201 and 202 for 1-200 amu and HGM2-302 for 1-300 amu.
•	Able to measure atmospheric pressure
	Compact design : Utilizes standard vacuum unit model deskton YTP

- Compact design : Utilizes standard vacuum unit model desktop
- Low noise : 43dB(A) or less at Ultimate pressure.

Process gas monitor		Select from BGM2-101, BGM2-102, BGM2-201, BGM2-202, HGM2-302
Maximum operation pressure		Atmospheric pressure
Atmospheric pressure	Dry vacuum pump	DAP-6D, ultimate pressure: 6700Pa, 50Torr, 67mbar
sampling unit	Control unit	APS-001
(atmospheric pressure)	Capillary unit	Manual bellows valve (1 way): Joint 1/4" Swagelok
	Turbo Molecular Pump	70L/s (N ₂)
Pump unit desktop YTP	Dry pump	20L/min
(YTP70A-D)	Ultimate pressure	Below 10 ⁻⁶ Pa
Power supply	·	Single phase AC100-240V, 300W (Vacuum type)
Software		Qulee QCS Ver.4.2 later (Windows 7/8/10/11 supported)

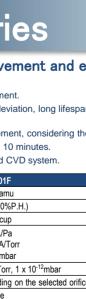
* Pumping system desktop YTP, Qulee main unit, gas inlet and other parts are packaged separately. Please refer to the assembly manual for set up.

Reactive Process Gas Monitor Qulee RGM2 series

For etching and CVD system for process control, quality control, yield ratio improvement and end point monitoring.

- Stable and long-time measurement in reactive gases or corrosive gases environment.
- Adoption of a magnetic closed-type ion source: Soft ionization with minimal gas deviation, long lifespan, and two filaments.
- · Compact size: Integrated exhaust and control systems, allowing for vertical placement, considering the footprint.
- Outstanding maintenance: Ion source replacement can be done in approximately 10 minutes.
- For process monitoring residual gas analysis and leak test for etching system and CVD system.

Model	RGM2-201F
Mass range	1 to 200 amu
Resolution	М/ДМ=1М (10%Р.Н.)
Detector	Faraday cup
Sensitivity (EM tube)	2 x 10 ⁻⁶ A/Pa 2.67 x 10 ⁻⁴ A/Torr 2 x 10 ⁻⁴ A/mbar
Minimum detectable partial pressure	1 x 10 ⁻¹⁰ Pa, 7.5 x 10 ⁻¹³ Torr, 1 x 10 ⁻¹² mbar
Sampling pressure	0.1 to 500 Pa (adjustable depending on the selected orifice)
Total pressure measurement function	Capable
Ion source / filament	Closed ion source with magnet /V-shaped filament Ir/Y ₂ O ₃ (2 piece)
Maximum Baking Temperature	110±10°C (Standard Equipped with Dedicated Block-Type Heater Unit)
Interface	Ethernet
Software	Qulee QCS Ver.4.2 later (Windows 8/10/11 supported)



Process Gas Monitor (Residual Gas Analyzer)

• Standard software for all Qulee series. (Windows 8/10/11 supported)

• User-friendly with many shortcut buttons on the screen.

Software for Gas Analysis Qulee QCS

Standard software for Qulee series.

<text>

Model	Quiee QCS Ver.4.2			
os	Microsoft Windows 8/10/11			
Interface	Ethernet			
Connectable quantity	Maximum 16. Any type of Qulee series are connectable.			
Supported model	Qulee BGM2 / Qulee HGM2/ Qulee CGM2 / Qulee RGM2 / Qulee with YTP-H			
Recipes to save	100 (user area 70)			
Measurement speed	50, 100, 200, 500, 1,000, 2,000 ms			
Analog input	0 to 10V (2 points)			
Partial pressure set point	2ch partial pressure set point (error and warning) setting (trend mode only)			
	HDD: 2MB (measurement data excluded.), RAM: 256MB or more, display area: 1024 x 768 or more. CD-ROM Drive			
PC required specifications	Ethernet port, CPU:Corei5 or higher,(8 units or more/Corei7 or higher)			

Various measurement mode such as scan mode, trend mode, analog mode, sensitivity-calibration mode, etc.
Ethernet support for up to 16 simultaneous Qulee measurements (any combination of Qulee series).

Vacuum Pump
Vacuum Valve
Vacuum Gauge
Process Gas Monitor
Leak Detector
Power Supply (DC/RF)
EB Power Supply / EB Source
Deposition Controller
Thin Film Measurement
Accessories
Vacuum Transfer Robot
Cryogenic Equipment

Leak Detector

Leak Detector HELIOT900 series

HELIOT 900 series is a leak detector which has high speed pumping capability and user-friendliness. The search gases are helium gas and hydrogen.



- High speed pumping capability 5L/sec helium in ULTRA flow mode.
- Tablet wireless remote control as standard.
- Simple and eye-friendly high-definition screen.
- Backing pump is selectable from oil rotary pump and dry scroll pump in different sizes.
- Mobile-friendly with maneuverable cart (904 series) and low height floor cart (901 series).
- moone menuly with maneuverable cart (304 series) and low neight moor cart (301 series)
- Easy maintenance. Tool-free removal panel, easy access to each part and maintenance instruction movies installed.
- Aside from helium, hydrogen detection is possible in vacuum method.

Model				901W1	901D2	904W2	904D3	904D4	
Body type	9			Po	rtable		Mobile		
Detectabl	e gas			⁴ He, ² H ₂					
Minimum detectable leak rate (⁴ He)				<5E−13 Pa•m³/sec, <5E−12 mbar·L/sec, <5E−12 Torr·L/sec					
Leak rate display range			0.01E-12 to E-6 Pa·m ³ /sec, 0.01E-11 to E-5 mbar·L/sec, 0.01E-11 to E-5 Torr·L/sec						
		⁴He	FINE		0.01E-10 to E-5 Pa*m ³ /sec, 0.01E-9 to E-4 mbar·L/sec, 0.01E-9 to E-4 Torr·L/sec				
Leak rate display range		GROSS	0.01E-8 to E-3 Pa·m ³ /sec, 0.01E-7 to E-2 mbar·L/sec, 0.01E-7 to E-2 Torr·L/sec						
		$^{2}H_{2}$	FINE		0.01E-8 to E-5 Pa·m ³ /sec	, 0.01E- 7 to E-4 mbar·L/sec,	0.01E-7 to E-4 Torr·L/sec		
T-1-4	ping speed (⁴ He)[L/se		ULTRA			5			
Inlet pump	ping speed (He/LL/ se	ec]	FINE			1		5	
			ULTRA			<2 Pa, <0.02 mbar, <0.015 Torr			
Maximum	connecting pressure		FINE			<100 Pa, <1 mbar, <0.75 Torr			
			GROSS	<1,200 Pa, <12 mbar, <9 Torr					
Main pump : pumping speed [L/sec]				Turbo molecule pump :31					
				Oil rotary pump:	Dry scroll pump:	Oil rotary pump:	Dry scroll pump:	Dry scroll pump:	
Backing p	ump speed (50Hz/60	Hz)		30/36 L/min, 1.8/2.2 m ³ /h, 1.1/1.3 cfm	90/108 L/min, 5.4/6.5 m³/h, 3.2/3.8 cfm	135/162 L/min, 8.1/9.7 m ³ /h, 4.8/5.7 cfm	250/300 L/min, 15/18 m³/h, 8.8/10.6 cfm	500/600 L/min, 30/36 m³/h, 17.6/21.2 cfm	
Weight (in	cluding floor cart)[k	[g]		About 33 (about 46)	About 37 (about 50)	About 79	About 74	About 96	
Dimensior	ns W x D x H [mm] (fl	oor ca	rt included.)	320 x 480 (652) x 505.5 (917) 444 x 660 x 991					
Power cor	nsumption [VA]			600	500	1100	650	1150	
Power sup	pply [V]			Single phase 100 to 120 or 200 to 240					
Inlet port	flange			KF25					
Start-up f	time [min]			<2					
External in	nterface			RS232C, RS485, analog DC output, digital input output					
Display la	nguage			Japanese, Chinese, Korean, Chinese (simplified character), Chinese (traditional character), German, Spanish, Russian					
Controller	r unit			7inch tablet-type industrial computer (wireless standard :IEEE 802.11 b/g/n) (*1)					
	Operation range [m]		Cable		Cable len	gth : 2 (standard attachment), 5	(optional)		
Wireless			Wireless	40 (*2)					
	Battery lasting time [[hr]				3 to 5(*3)			
Operating	temperature range [°C]				10 to 40 (non condensation.)			
Applicable standard				CE, IP30 CE					

*1) Applicable radio law. 1) Tablet: Telec, CE, FCC. 2) Main unit: Telec, CE, FCC, IC, C-TICK. 3) "Wired operation spec" that doesn't emit radio waves is also available (tablet controller has wireless radio on/off function). *2) May change depending on operating environment. *3) May change depending on communication condition, brightness, volume, etc. *4) Be careful about inrush current. Check if specification is sufficient when using drum reel.

Sniffer					
Model	AS9	BT9			
Detected gas	⁴ He				
Leak rate display range	0.01E-8 to E-5 Pa•m ³ /sec, 0.01E-7 to E-4 mbar·L/sec, 0.01E-7 to E-4 Torr·L/sec	0.01E-7 to E-3 Pa•m ³ /sec, 0.01E-6 to E-2 mbar·L/sec, 0.01E-6 to E-2 Torr·L/sec			
Flow rate [SLM]	<0.03	About 3			
Sniffing inlet port	Handy probe	Handy probe dia. 6mm hose joint			
Tube [m]	1 to 10				

Leak Detector

Optional accessories for HELIOT900 series



Integration type Leak Detector HELIOT ZERO

Leak detector specially designed for system integration.







Power supply unit

•	Analyzer	and	control	unit	can	be	separated	up	to	30	meters
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- Analyzer unit can be mounted in any orientation.
- Small footprint.
- Sniffer method (optional).

Model		HELIOT ZERO			
Detectabl	e gas	⁴ He			
Vacuum method detection range		E-12 to E-3 Pa·m ³ /sec E-11 to E-2 Torr·L/sec E-11 to E-2 mbar·L/sec			
Sniffer m	ethod detected range	E-8 to E-3 Pa · m³/sec E-7 to E-2 Torr·L/sec E-7 to E-2 mbar·L/sec			
Test port / fore line port		KF16			
Language		Japanese, English, Chinese (simplified character)			
Power su	oply [V] / power consumption [W]	Single phase AC90 to 240 (50/60Hz) / 700			
Weight	Analysis unit + Test port unit [kg]	Approx. 7.4			
	Power supply unit + Display unit [kg]	Approx. 10.5			
Cable length between analyzer unit and power supply unit [m]		Max. 10			
Cable length between power supply unit and display unit [m]		Max. 20			
Applicable	e standard	CE, IP30:Power supply unit, IP20:Analyzer unit, IP65:Display unit			

Power Supply (DC/RF) ►DC Power Supply

High Power DC Power Supply DC series

10kW / 20kW for sputtering system



DC-10/20

- High reliability design based on long time experienced ULVAC know-how.
- Stable process is ensured by excellent arc handling by ULVAC who is also vacuum process equipment supplier and has full knowledge about plasma processes.
- Extremely low ark energy by utilizing an optional high-speed arc shutoff circuit. It contributes to high productivity and improves manufacturing yield.
- 800V and 1000V are available. High-impedance load resistance.
- 400V class input corresponding model is also lined up.

	Model	DC-10-AM	DC-10-H-AM	DC-10-4-AM	DC-20	DC-20-H-AM	DC-20-4-AM		
Input specification	Rated input voltage	3-Phase 187 to 229VAC		3-Phase AC342 to 440V	3-Phase 187 to 229VAC		3-Phase AC342 to 440V		
specification	Input capacity	13.5kVA or less				25kVA or less			
	Maximum rated power		10kW			20kW			
Output	Rated current	25A	18A	25A	50A	40A	50A		
specification	Rated voltage	-800V	-1000V	-800V	-800V	-1000V	-800V		
	Abnormal discharge control	Shutoff by inverter stop or high-speed arc shutoff circuit*1 when abnormal discharge is detected							
	Control method	Constant power control (P control)/constant current control (I control)/constant voltage control (V control)							
Control	Control precision	Constant power control (P Control) : Below $\pm 0.5\%$ of the rated output or $\pm 1\%$ of the set value, whichever is constant current control (I Control) : Below $\pm 1\%$ of the rated output or $\pm 2\%$ of the set value, whichever is constant voltage control (V Control) : Below $\pm 1\%$ of the rated output or $\pm 2\%$ of the set value, whichever is					never is larger.		
	Control compensation range		Constant	0 100% of rated p	d power value				
	Parallel operation	Up to 12units can be controlled by master/slave communication*2							
	External interface	analog/digital,RS-232C or 485							
Cooling metho	bd	Forced air-cooling							
Dimension W x D x H		483mm x 630mm x 133mm (excluding protrusions)							
Weight		29kg 36kg							
Applicable star	ndard	CE/ SEMI F47/ RoHS							

High Power DC Power Supply DC-30-H

30kW high-impedance DC power supply

- Extremely low ark energy by utilizing an optional high-speed arc shutoff circuit. It contributes to high productivity and improves manufacturing yield.
- 1200V output with high-impedance load resistance.
- EtherCAT communication is available.



DC-30-44H-E

Model		DC-30-44H-E
Input	Input voltage	3 phase AC 396 to 484V
specifications	Input capacity	41.5kVA or less
	Rated power	30kW
	Rated current	55A
Output	Rated voltage	-1200V
specifications	Ignition voltage	-1500V
	Abnormal discharge	Stop the inverter or shutoff with high-speed arc shutoff circuit
	control	when abnormal discharge is detected.
	Control method	Rated power control (P Control)
		Rated current control (I Control)
		Rated voltage control (V Control)
	Control precision	P Control:Less than $\pm 0.5\%$ of the rated output or $\pm 1\%$ of the set value, whichever is larger.
Control		I Control: Less than $\pm 1\%$ of the rated output or $\pm 2\%$ of the set value, whichever is larger.
Control		V Control:Less than $\pm 1\%$ of the rated output or $\pm 2\%$ of the set value, whichever is larger.
	Control guarantee	
	scope	10 to 100% of rated power value
	External interface	RS-232C or 485, EtherCAT
Parallel operat	tion	Maximum up to 12 units
Cooling metho	d	Forced air cooled
Dimensions W	/ x D x H	483 x 650 x 177mm(excluding protrusions)
Weight		45kg
Applicable sta	ndard	CE/ SEMI F47/ RoHS

Power Supply (DC/RF) ►DC Power Supply

High Power DC Power Supply DC series

10kW / 20kW for sputtering system



DC-10-D/20-D

- High reliability design based on long time experienced ULVAC know-how.
- Stable process is ensured by excellent arc handling by ULVAC who is also vacuum process equipment supplier and has full knowledge about plasma processes.
- Extremely low ark energy by utilizing an optional high-speed arc shutoff circuit. It contributes to high productivity and improves manufacturing yield.
- 800V and 1000V are available. High-impedance load resistance.
- 400V class input corresponding model is also lined up.

	Model	DC-10-D	DC-10-HD	DC-20-D	DC-20-HD			
Input specification	Rated input voltage	3-Phase 18	7 to 229VAC	3-Phase 187 to 229VAC				
	Input capacity	13.5kVA	or less	25kVA	or less			
	Maximum rated power	10	«W	20	κW			
Output specification	Rated current	25A	18A	50A	40A			
	Rated voltage	-800V	-1000V	-800V	-1000V			
	Abnormal discharge control	Shutoff by inverter st	op or high-speed arc shuto	ff circuit*1 when abnormal o	discharge is detected			
	Control method	Constant power control (P	Constant power control (P control)/constant current control (I control)/constant voltage control (V control					
Control	Control precision	constant current control	Constant power control (P Control): Below ±0.5% of the rated output or ±1% of the set value, whichever is larg constant current control (I Control): Below ±1% of the rated output or ±2% of the set value, whichever is larg constant voltage control (V Control): Below ±1% of the rated output or ±2% of the set value, whichever is larg					
Control	Control compensation range	Constant power control, 10 to 100% of rated power value						
	Parallel operation	Up to	Up to 12units can be controlled by master/slave communication*2					
	External interface		analog/digital,RS-232C or 485					
Cooling method			Forced air-cooling					
Dimension W x D x H			483mm x 630mm x 133mm (excluding protrusions)					
Weight		29	29kg 36kg					
Applicable standard			CE/ SEMI F47/ RoHS					



High speed ARC handling Would you like to improve the efficiency of pre-sputtering processes and Improvement of processes that are difficult to maintain discharge due to interruption of abnormal discharge

ULVAC's DC power supply makes it possible 4 options

High performance RAMP Problems with transient phenomena are improved by changing the way Ignition is applied before the start of discharge, instead of the conventional RAMP operation after the start of discharge.



Superior performance ARC handling ARC cut-off time is not cut off for a set time, but an era where the power supply judges according to the load situation. "Change the vacuum process with power Supply"

High Control accuracy Realization of high reproducibility that suppresses variations in the output of the power supply for delicate processes and the guaranteed wide range of output required when processing multiple processes Vacuum Pump

Vacuum Valve

Vacuum Gauge

Process

Gas Monito

Power Supply (DC/RF) ►DC Power Supply

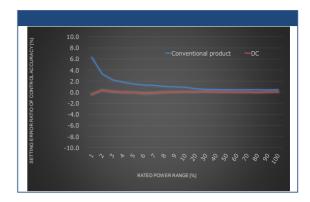
Low Power DC Power Supply DC series

2kW/4kW for sputtering system



• Highly accurate output characteristics in the range of 1% to 100% rated power.

- Higher quality sputtering process is ensured by excellent repeatability.
- High reliability design based on long time experienced ULVAC know-how.



	Model	DC-2	DC-4			
	Rated input voltage	3phase AC180 to 242V				
input specification	Input capacity	3.5kVA or less	6.2kVA or less			
	Rated power	2kW	4kW			
	Rated current	5A	10A			
Output specifications	Rated voltage	-800V				
	Ignition voltage	-1200V				
	Abnormal discharge control	Shut-off by resonant circuit or inverter stop when abnormal discharge is detected.				
	Control method	Constant power control (P control)/constant current control (I control)/constant voltage control (V contro				
De esta de	Control precision	\pm 1% of the set value				
Control	Control guarantee scope	1 to 100% of rated power value				
	External interface	Analog/Digital,RS-232C or 485				
Parallel operation		None				
Cooling method		Forced air cooled				
Dimensions W x D x H		241x610x133mm (excluding protrusions)				
Weight		15kg				
Applicable standard		CE				

Low Power DC Power Supply DCS series

500W / 2kW / 4kW for sputtering system

- It provides a stable process with high reliability performance proved by more than 20 years experience.
 - Excellent repetitive and repeatable output ensures higher quality sputtering processes.



DCS0052B

Model		DCS0052B		
The state of the s	Input voltage	Single phase AC95 to 121V/AC190 to 242V		
Input specifications	Input capacity	1kVA		
	Maximum rated power	500W		
o	Rated current	1.25A		
Output specifications	Rated voltage	-800V		
	Abnormal discharge control	Stop the Inverter when abnormal discharge is detected.		
	Control method	Rated Power Control (P Control) / Rated Current Control (I Control) / Rated Voltage Control (V Control)		
Control	Control precision	Rated power control (P Control) : Less than ±2% of the rated power value. Rated current control (I Control) : Less than ±1% of the rated current value. Rated voltage control (V Control) : Less than ±1% of the rated voltage value.		
	Control guarantee scope	10% to 100% of the rated output value		
Parallel operation		None		
Cooling method		Forced air cooled		
Dimensions W x D x H		240 x 450 x 99mm (excluding protrusions)		
Weight		9kg		

Power Supply (DC/RF) ►Accessories

Abnormal Discharge Prevention Unit A2K series

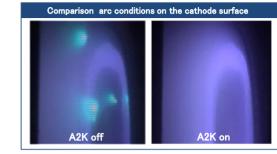
A2K series is the accessory of DC power supply which neutralize the charge built up on the cathode (target) by charging positive voltage pulse to DC power output in the reactive sputtering processes.







A2K-20K/40K



High reliability design based on long time experienced ULVAC know-how.

• Adding A2K series to the existing DC power supply improves productivity and throughput.

• Long time experienced ULVAC arc handling technology minimizes arc energy.

Model		A2KH-25	A2K-20K	A2K-40K		
Control electrical	Input voltage	Single phase AC90 to 110V	Single phase AC90 to 264V			
power input specifications Input capacity		100VA	400VA			
Maximum operating volt		-800V				
Input specifications	Maximum operating current	25A	50A	100A		
	Input structure	MS3106B 22-2P	One quick connection connector	Two quick connection connectors		
Output	Oscillation frequency	When pulse range is 5 μ s: 2, 5, 10, 15, 20kHz When pulse range is 10 μ s: 1, 2.5, 5, 7.5, 10kHz	1k to 50kHz			
specifications	Reverse pulse range	$5\mu{ m s}/10\mu{ m s}$ (Internal Switch Switching)	3 to 18 μ s (Setting range limited by oscillation frequency)			
	Output structure	MS3106B 22-2S	One-touch Connector			
Parallel operation		None	Maximum up to 6 units (with same model only)			
Cooling method		Forced air cooled				
External dimensions W x D x H		238 x 450 x 149mm (excluding protrusions)	483 x 630 x 177mm (excluding protrusions)			
Weight		16kg	30kg	45kg		
Applicable standard		_	CE			

Bipolar unit for dual cathode MFU series

MFU series is designed for bipolar output power system for dual cathode.



- · High reliability design based on long time experienced ULVAC kno how
- · Wide range oscillation frequency, 10k to 100kHz, supports various processes.
- Square wave makes duty cycle changeable and power supply to e cathode adjustable for more stable processes.

		CHAMBER
	INPUT	CATHODE
now-		
	DC power generator	Bipolar unit
ıs		
each		

Bipolar output power system configuration

Model		MFU-20K	
0	Input voltage	Single phase AC 90 to 264V	
Control power input	Input capacity	400VA	
	Operating voltage	0 to -1000V	
Input specifications	Ignition voltage	-1200V	
	Maximum operating current	50A	
	Maximum voltage	1000V (RMS) (oscillation frequency limited when output voltage is over 800V)	
	Ignition voltage	DC -1200V	
Output specifications	Maximum current	50A	
	Oscillation frequency	10k to 100kHz (output current and voltage limited when oscillation frequency is 60kHz or more)	
	Duty cycle	10 to 90% (setting range limited by oscillation frequency)	
Parallel operation		Maximum up to 6 units	
Cooling method		Forced air cooled	
Dimensions W x D x H		483 x 630 x 177mm (excluding protrusions)	
Weight		29kg	
Applicable standard		CE	

Vacuum Pump

Vacuum

Valve

Power Supply (DC/RF) ►DC Pulse Power Supply

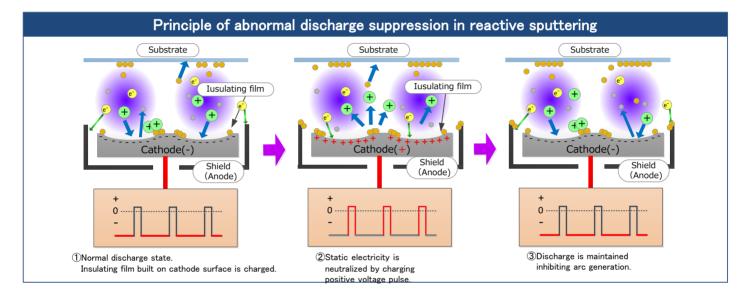
DC Pulse Power Supply DC-Pulse series

DC pulse power supply which neutralize the charge built up on the cathode (target) by charging positive voltage pulse to DC power output in the reactive sputtering processes.



· High reliability design based on long time experienced ULVAC know-how

• High throughput process is available because of high power input by suppressing abnormal discharge.



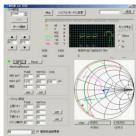
Model		DC-5-P	DC-10-P		
In and the second Constitution	Input voltage	3 phase AC187 to 229V			
Input specifications	Input capacity	8kVA	13.5kVA		
	Maximum rated power	5kW	10kW		
	Rated current	12.5A	25A		
o	Rated voltage	650V (Oscillation frequency more than 155kHz)	/ 800V (Oscillation frequency less than150kHz)		
Output specifications	Ignition voltage	1500V			
	Oscillation frequency	5k to 250kHz			
	Reverse pulse range	0.4 μ to 5 μ s (Setting range limited by oscillation frequency)			
	Control method	Rated electric power control (P Control) / Rated current control (I Control) / Rated voltage control (V Contr			
Control	Control precision	Less than $\pm 0.5\%$ of rated output or $\pm 1\%$ of the set value, whichever is larger.			
	Control guarantee scope	10 to 100% of rated electric power value.			
Parallel operation		Maximum up to 6 units (with same model only)			
Cooling method		Forced air cooled			
Dimensions W x D x H		483 x 630 x 133mm (excluding protrusions)			
Weight		29kg 36kg			
Applicable standard		CE			

Power Supply (DC/RF) ►RF Power Supply

RF Power Supply / Matching Box RFS-N series

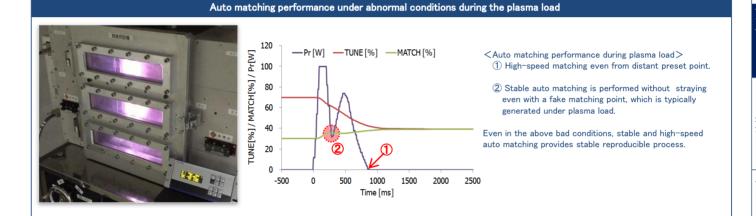
High frequency power supply for plasma generation in LCD and Semiconductor manufacturing systems.





Matching Assistant Tool

- 0.5kW, 1kW, 3kW, 5kW at 13.56MHz.
- · High reliable design based on long time experienced ULVAC know-how.
- Simple configuration with the built-in auto-matching controller.
- Stable process is committed by stable auto-matching function which tracks the plasma unique impedance fluctuation through ULVAC original algorithm.
- Matching conditions can be monitored by the optional matching assistant tools.



RF Power Supply

Model		RFS-1305N	RFS-1310N	RFS-1330N	RFS-1350N	
	Input voltage	AC180 to 242V, single phase		AC180 to 242	AC180 to 242V, three phase	
Input specification	Input capacity	1.2kVA	1.8kVA	5kVA	8kVA	
	Oscillating frequency		13.56MHz			
Output	Rate travelling wave power	500W (under 50 Ω load)	1kW (under 50Ω load)	3kW (under 50 Ω load)	5kW (under 50 Ω load)	
specification	Maximum reflected wave power	100W		500W		
	Harmonic distortion ratio	-35dB or less (Rate output time 50 Ω Loading time)				
0	Control accuracy	Rated output ±2% or less				
Control	Guaranteed control range	10 % to 100 % of rated power value				
Cooling method		Forced air cooled		Water cooled (4L / min)	Water cooled (6L / min)	
Dimensions W x D x H		240 x 495 x 150mm (excluding protrusions)		480 x 495 x 150mm (excluding protrusions)		
Weight		11kg 23kg				
Applicable standard		CE				

Matching box

Model	MBX-1305N	MBX-1310N	MBX-1330N	MBX-1350N
Permissible input power	10 to 500W	10 to 1000W	30 to 3000W	50 to 5000W
Permissible output current	30	30A		120A
Permissible output voltage	2.5k	2.5kVpp		10kVpp
Cooling method	Forced a	Forced air cooled		d (2L / min)
Dimensions W x D x H		375 x 250 x 120mm (excluding protrusions)		450 x 500 x 248mm (excluding protrusions)
Weight	8k	8kg		21kg
Applicable standard	CE			

Vacuum Pump

Vacuum Valve

Vacuum Gauge

Process Gas Monitor

Leak Detector

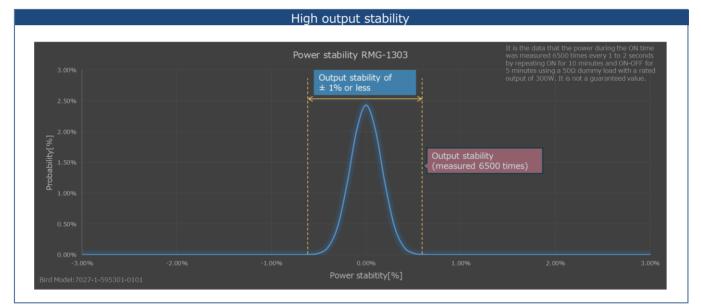
Power Supply (DC/RF) ►RF Power Supply

Matching unit integrated High-Frequency Power Supply RMG series

High-frequency power supply for plasma generation used in electronic components and semiconductor manufacturing equipment



- This is an RF power supply with an integrated matching unit of 13.56MHz and 300W output for plasma processes such as RF sputtering and plasma CVD etching.
- High reliable design based on long time experienced ULVAC know-how.
- Simple configuration with the built-in auto-matching controller.
- By integrating the matching unit and RF power supply, we have achieved miniaturization and weight reduction.
- It can be controlled with low output, and can be used in a wide range of fields from research and development applications to mass production equipment.



■ RF Power Supply

Model		Part of RF Power Supply
Input	Input Voltage	Single phase AC100~220V
Input	Input Capacity	700VA
	Frequency	13.56MHz
Output	Rated Power	300W(50Ω load)
Output	Maximum Reflected Power	80W
	Harmonic distortion ratio	<-35dB (Full power output 50 Ω load)
Control	Control accuracy	Less than ± 2 W or ± 1 % of the set value, whichever is larger.
Control	Guaranteed control range	1 % to 100 % of rated power value
Cooling		Forced air cooled
Dimensions WxDxH		200x200x350mm (Include Matching BOX)
Weight		10kg
Applicable standard		CE

Matching Box

Model	Part of Matching Box
Permissible input power	300W
Permissible output current	10A
Permissible output voltage	2.5kVpp
Output Option	N·HN·M·DIN-7/16

Power Supply (DC/RF) ►RF Power Supply

RF Power Supply Option **MEX-N series**

Matching box switching unit for RFS-N series

- Switching for multiple matching boxes.
- Not for simultaneous discharge. Using this unit reduces quantity of power supplies and leads to cost down.





Consoltu	Qty. of	Qty. of matching box which is switchable by the matching box switching unit								
Capacity		2 units	3 units	4 units	5 units	6 units	7 units	8 units		
500,1kW		MEX2N-1k	MEX3N-1k	MEX4N-1k	MEX5N-1k	MEX6N-1k	MEX7N-1k	MEX8N-1k		
3kW	Model	MEX2N-3k	MEX3N-3k	MEX4N-3k	MEX5N-3k	MEX6N-3k	MEX7N-3k	MEX8N-3k		
5kW		MEX2N-5k	MEX3N-5k	MEX4N-5k	-	-	-	-		

RF Power Supply Option EXN series

Switching unit for multiple cathodes

Switching for matching box output

- Greatly contributes to cost reduction for the various systems as it is not necessary to install matching box per cathodes.
- Manual and motor driving type are provided as switching method. A water cooled type is also available for higher power.
- Useable as a switching unit for DC power supply and DC pulse power supply.
- Since only single matching box is used with this unit, it is not available to mutual loads exceeding matching range.

Switching		Air cooled (1kW or less)		Water cooled (3kW)	
points		Manual	Motor driven	Manual	Motor driven
2 points		EXN2T-40A	EXN2M-40A	EXN2T-70W	EXN2M-70W
3 points	Model	EXN3T-40A	EXN3M-40A	EXN3T-70W	EXN3M-70W
4 points		EXN4T-40A	EXN4M-40A	EXN4T-70W	EXN4M-70W

RF Power Supply Option PHS-N series

Output phase control of multiple RF power supplies.

• Phase control of maximum 4 or 8 units of RF power supplies

• It provides stable process with very small variation by adjusting differences occurs between cathodes by phase shift function.



Model		PHS-04N	PHS-08N	
Innut on colfications	Input voltage	Single phase AC100 to 240V		
Input specifications	Input capacity	70VA		
	Output channel	4	8	
Output specifications	Oscillation frequency	13.56MHz ±0.05%		
	Phase setting scope	0 to 360°		
Dimensions W x D x H		480 x 192 x 49mm (e	xcluding protrusions)	

RF Power Supply Option EX0-13

Output phase synchronization of multiple RF power supplies.

Phase synchronization of maximum 4 units of RF power supplies



EXO-13

Model		EXO-13	
Level and if a diama	Input voltage	Single phase AC90 to 110V	
Input specifications	Input capacity	10VA or less	
Output specifications	Oscillation frequency	13.56MHz ±0.05%	
Dimensions W x D x H		145 x 110 x 44mm (excluding protrusions)	



Vacuum Pump

Vacuum

Valve

Vacuum

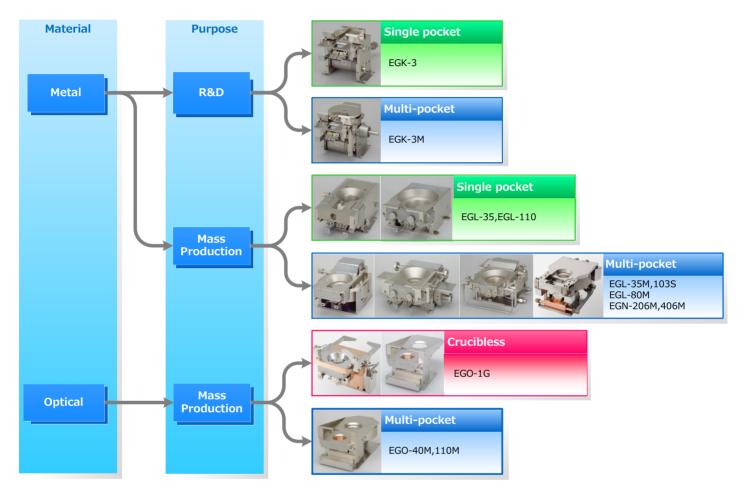
Gauge

Process

Gas Monito

Electron beam source with a long-life filament by having the structure to prevent pollution from evaporation materials.

EGK series with small volume pocket for experiment purposes. EGL and EGN series with small medium to large volume pocket are for mass production purposes. EGO and EGP series are for optical applications.



■EB source selection table based on the qty. of pockets (for metal film)

Qty. of	Pocket volume						
pockets	Зсс	10cc	20cc	40cc	110cc		
1	EGK-3			EGL-35	EGL-110		
3		EGL-103S					
4	EGK-3M	EGL-35M (10cc x2) (40cc x2)		EGL-35M (10cc x2) (40cc x2)	EGL-80M		
6			EGN-206M	EGN-406M			
Power Supply	HPS-510S		HPS-1000N		HPS-1600F		

EB source selection table based on qty. of pocke	ts
(for optical film)	

Qty. of	Pocket volume				
pockets	10cc	40cc	110cc	_	
0				EGO-1G	
4	EGO-40M (10cc x2)	EGO-40M (10cc x2) (40cc x2)	EGO-110M		
Power Supply	HPS-1000N				

EB source selection table based on EB power supply system

EB power supply system		Number of	Recommended electron beam source	Electron beam source controller	
Capacity	Model	deposition source	Recommended electron beam source	Electron beam source controller	
5kW	HPS-510S	1 source	EGK-3/3M, EGL-35/35M	None (The source controller is equipped in the power supply)	
	HPS-1000N-100 1 source		EGL-35/35M. EGL-103S. EGN-206M/406M		
10kW	HPS-1000N-200	2 sources	EGE 33/33M, EGE 1033, EGN 200M/400M		
TUKW	HPS-1000N-G100	1 source	EGO-1G. EGO-40M. EGO-110M	EGC-10GS G-TYPE	
	HPS-1000N-G200	2 sources			
	HPS-1600F-S100 1 source		EGL-110	EGC-16S	
16kW	HPS-1600F-S200	2 sources			
	HPS-1600F-S101	1 source with high- power	EGL-80M	EGC-16H	

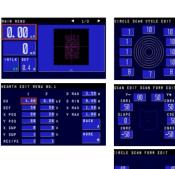
*) EB power supply system model decides depend on which model of the source controller use.

EB Power Supply / EB Source ►EB Power Supply

High Function EB Power Supply HPS-N series

6kW/10 kW EB power supply designed with stabilized circuit and improved performance.





- · Usable for both optical and metal film by using highly-functional EB source controller.
- Using graphic user interface assists to multi-functional and complicated operation and it leads to productivity improvement.
- Stable deposition is ensured by excellent arc handling by ULVAC who is also vacuum process equipment supplier and
- has full knowledge about deposition processes.

Model		HPS-1000N-100	HPS-1000N-200			
	Input voltage	3 phase AC190 to 231V				
Input specification	Input capacity	14kVA	15kVA			
	Rated output power	10k1	w			
Output specifications	Voltage range	-4k to -10kV				
	Ripple rate	$\pm 2\%$ or lower at rated output				
	Beam current	0 to 1000mA				
Cooling method		Forced air	r cooled			
Dimensions W x D x H		494 x 701 x 712mm (excluding protrusions)				
Weight		120kg	145kg			
Applicable standard		CE				
EB source contr	oller specifications					
Model		EGC-10GS G-TYPE (for optical film)	EGC-10GS S-TYPE (for metal film)			
Input specifications		Supplied from EE	3 power supply			
	Variable range	0 to ±1.5A	-0.4 to -3.5A			

Input specifications		Supplied from	EB power supply			
	Variable range	0 to ±1.5A	-0.4 to -3.5A			
X shaft coil output specifications	Voltage range	±	_24V			
output specifications	Frequency	10 to 800Hz	0.1 to 5Hz			
Y shaft coil output specifications	Variable range	0 to ±1.5A	0 to ±1.2A			
	Voltage range	±24V				
output specifications	Frequency	10 to 800Hz	0.1 to 22Hz			
Deflection coil output	Variable range	-0.4 to -3.5A				
specifications	Voltage range	+24V				
Dimensions W x D x H		480 x 499 x 149mm (excluding protrusions)				
Weight		11.5kg				
Applicable standard		CE				

EB Power Supply HPS series

5kW/16kW for electron beam source.



HPS-1600F

- Stable process is ensured with high quality and high-reliability proven through more than 15 years experience.
- Stable deposition is ensured by excellent arc handling by ULVAC who is also vacuum process equipment supplier and has full knowledge about deposition processes.

Model		HPS-510S	HPS-1600F -S100	HPS-1600F -S200	HPS-1600F -S101			
Input	Input voltage		3 phase AC	190 to 231V				
specification	Input capacity	7kVA	21kVA	22kVA	21kVA			
	Rated out power	5kW	5kW 16kW					
Output specification	Voltage range	-4k to -10kV						
	Ripple ratio	Less than $\pm 2\%$ at rated output						
	Beam current	0 to 500mA 0 to 1600mA						
Cooling metho	d		Forced a	ir cooled				
Dimensions	Power supply	480 x 620 x 300mm	500 x 700 x 710mm (excluding protrusions)					
W×D×H	Source controller	(excluding protrusions)	480 x 480 x 149mm (excluding protrusions)		rusions)			
\A/ - ! - l - t	Power supply	501	113kg	136kg	113kg			
Weight	Source controller	50kg	20)kg	17kg			

Vacuum Transfer

· Robot

Cryogenic Equipment

Vacuum Pump

Vacuum

1 Valve

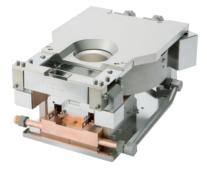
Vacuum

1 Gauge

EB Power Supply / EB Source ►EB Source

EB Source for Metal Film EGN-206M/406M

EB deposition source with full flat top configuration without any structural object above the hearth cover.

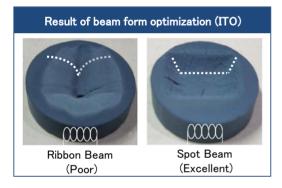


EGN-206M/406M



EGN-206M/406M with health cover shield

- By changing a part of EB source, the ribbon-shaped beam suitable for metal deposition or spot-shaped beam suitable for sublime substances/oxides and compounds deposition is selectable.
- Built-in electronic reflection trap mechanism suppresses temperature increase on the substrate which may become critical problem for evaporation process.
- Using the optional hearth cover shield makes maintenance time short and improves productivity.





Hearth cover shield

Model		EGN-206M	EGN-406M		
Beam deflection angle		270°			
Qty of pocket		6			
Pocket capacity		20cc	40cc		
Pocket dimensions Top x Bottom x Depth		Φ42 x Φ32 x 19mm	Φ50 x Φ41 x 25mm		
Casling water flow rate	Pocket	10 L/min			
Cooling water flow rate	Hearth cover	2 L/min			
Dimensions W x D x H		214 x 343 x 144mm (excluding protrusions)			
Weight		28kg			
Effective evaporation angle		More than 100°			
Deposition speed		1.6 μ m/min (Ribbon beam, Al, 8kW, 40cc pocket, 250mm from health cover)			
Maximum acceleration voltag	ge	-10kV			
Maximum emission current		800mA	1000mA		
EB power supply system		HPS-1000N-100/200			

Optional accessories

Accessory	Model	Required qty.	Remarks
High voltage feedthrough	BERH311A	2	
Feedthrough for magnet coil	PTS-004	2	For coil wiring , For hearth positioner
Ground terminal	ERZ-003	1	
Vacuum interlock switch	DTA-002	1	
Cooling water feedthrough	DK5203-045	4	Φ10

EB Power Supply / EB Source ►EB Source



Accessory	Model	EGK-3	EGK-3M	EGL-103S	EGL-35	EGL-35M	EGL-110	EGL-80M	
High voltage feedthrough	BERH311A	2	2	(*1)	2	2	2	2	Deposi
Current terminal	PTS-004	1	1	(*1)	1	2	2	1(*2)	tion Contr
Ground terminal	ERZ-003	1	1	(*1)	1	1	1	1	oller
Vacuum checker	DTA-002	1	1	(*1)	1	1	1	1	Thin Meas
Cooling water terminal	DK5203-045	Φ x2 Φ10 x2	Φ6 x2 Φ10 x2	(*1)	Φ10 x2	Φ6 x2 Φ10 x2	Ф12 x2	Φ6.35 x2 Φ12.7 x2	in Film basurem
	*1) Ultra-high vacuum specification is necessary. Please contact us separately.								

*1) Ultra-high vacuum specification is necessary. Please contact us separately.
 *2) The current terminal for the hearth positioner is PTS-004. However, 3p-16A is used in the case of the current terminal for coil driving.

EB Source for Optical Film EGO series

High reliable EB source designed based on ULVAC long time experienced technologies.

Model

Weight

Beam deflection angle

Cooling water flow rate

Dimensions W x D x H

Power supply system

Qty. of pocket

Pocket capacity



EGO-1G



EGO-40M



Pocket

Coil

Optional accessories						
Accessory	Model	EGO-1G	EGO-40M	EGO-110M		
High voltage terminal	BERH311A	2	2	2		
Current terminal	PTS-004	1	2	2		
Ground Terminal	ERZ-003	1	1	1		
Vacuum Checker	DTA-002	1	1	1		
Cooling water terminal	DK5203-045	Ф10 x2	Φ10 x2	Φ10 x2 / Φ12.7 x2		

• High performance deflection coil makes sweep performance high and deposition process stable and uniform.

EGO-1G

0

2L / min

168 x 285 x 174mr

10kg

EGO-40M

270[°]

4

10cc x2 / 40cc x2

10 L/min

2 L/min

18kg

HPS-1000N-G100/G200

170 x 309x174m

EGO-110M

Accessories

Vacuum Transfer

Robot

Cryogenic Equipment

EGO-110M

4

110cc

19 L/min

2 L/min

232 x 368 x 174mm

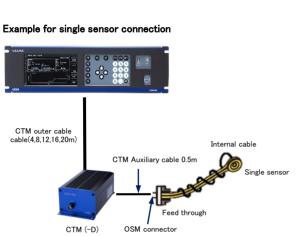
30kg

CRTM-R1 Quartz Crystal Deposition Controller

ULVAC has developed the new quartz crystal deposition controllers based on our longtime experience and technologies. Contributes to improved quality and reliability in vapor deposition processes.



- Excellent rate stability and resolution make it suitable for low rate control.
- Ability value (CI value) measurement function improves crystal anomaly detection.
- Simultaneous vapor deposition control of up to 8 sources is possible. (add option)
- lineup of Deposition monitor "CRTM-R1-EL" optimized for organic film deposition applications

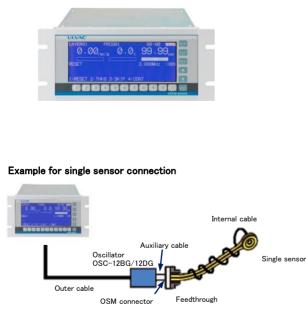


Ale MATERIA CONTRACTOR					ODTO	
* When using	requires	options	such as	,capies and	URIS	sensor

Model		CRTM-R1(-EL)
F	Measurement Range	4.00~3.00MHz@4MHz 5.00~3.50MHz@5MHz 6.00~4.50MHz@6MHz
Frequency	Measurement Resolution	1mHz
	Display Resolution	1mHz
	Measurement Range	0.000~999.9Å/s (0~99.99nm/s)
Deposition rate	Measurement Resolution	0.0028Å/s @4MHz 0.0018Å/s @5MHz 0.0012Å/s @6MHz
	Display Resolution	0.001 Å/s
	Measurement Range	0.000∼9999kÅ (0∼999.9µm)
Film thickness	Measurement Resolution	0.0028Å @4MHz 0.0018Å @5MHz 0.0012Å @6MHz
	Display Resolution	0.001k Å
Number of sens	ors that can be attached	Single senosr:2 (Max.8) Multi-sensor:2 (Max.8)
Simultaneous m	neasurement & control	2 (Max.8)
Sampling rate		100msec
Number of mult	ilayer	99
Number of proc	ess programs	99
Number of depo	sition programs	999
Dimensions W×	:D×H	480×320×130 mm

Crystal Oscillation type Deposition Controller CRTM-6000G

Deposition controller with excellent cost / performance features. Wide deposition control range for single as well as multilayer films.



*When using CRTM-6000G, requires options such as Oscillator, cables and CRTS sensor.

- Two sensors can be switched for deposition control.
- (The simultaneous measurement cannot be done. It is a switch type.)
- Excellent response is obtained with a sampling rate of 125 ms.
- Up to 99 deposition programs can be stored with battery backup
- Memory of the controller can record up to 30 process sequences.

Model		CRTM-6000G
	Measurement Range	3.0~5.01MHz @5MHz 4.0~6.01MHz @6MHz
Frequency	Measurement Resolution	24mHz
	Display Resolution	0.001MHz
	Measurement Range	0.000~999.9Å/s (0~99.99nm/s)
Deposition rate	Measurement Resolution	0.041 Å/s @5MHz 0.029 Å/s @6MHz
	Display Resolution	0.1 Å/s
Measurement Range		$0\sim 999.9$ k Å
	Measurement Resolution	0.041 Å : 5MHz, 0.029 Å : 6MHz
Thickness Display Resolution		0.001kÅ: 0 ~ 9.999kÅ 0.01kÅ: 10 ~ 99.99kÅ 0.1kÅ: 100 ~ 999.9kÅ
Number of s	sensors that can be attached	Single sensor : 2(The simultaneous measurement cannot be done. It is a switch type.), Multi senor : 1
Simultaneou	is measurement & control	1
Sampling ra	te	125msec
Number of r	multilayer	99 layer
Number of p	process programs	30
Number of a	deposition programs	99
Dimensions	W×D×H	240×350×99 mm

Deposition Control •Quartz crystal

Deposition Controller Sensor CRTS series

Various line-up for various deposition processes.







Single sensor

- To be selected depends on deposition condition such as with or without baking, temperature range, etc.
- Compact sensor head makes installation in the chamber easy.
- Long life time oscillator is available.
- Specified sensor length and pipe shape are available

Multi-sensor

- Multiple crystals, 6 or 12. Crystal is exchangeable by its holder.
- High reliability with ULVAC original driving system with vacuum motor
- Crystal is automatically switched by detecting abnormal crystal oscillation (end of life).



CRTS-M6

CRTS-12NS

Vacuum Pump

Vacuum Valve

Vacuum

Gauge

Proces

Gas Monito

Leak Detector

(DC/RF)

ddne

EB Power Supp / EB Source

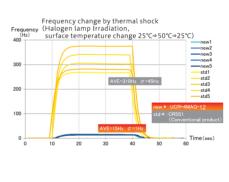
Single sensor Multi-sensor CRTS-0 CRTS-4 CRTS-6 CRTS-4U CRTS-6U CRTS-M6 CRTS-12NS Mode +Water Cooling Ultra-high vacuum Ultra-high vacuum Deposition in Deposition in Deposition in Deposition in Continuous deposition for thick film Process sition in sition in 350°C . 80°C or less 300°C or les . 100°C or less 200°C or less 100°C or less 200°C or less Qty. of crystals 6 12 1 4MHz, 5MHz (6MHz. Contact us or further information) Crystal frequency 100 to 800mm Length Diameter 6mm 4mm 6mm 4mm 6mm 1/4 inch _ Cooling water pipe Capacity _ 400 cc/mir 200 cc/min 400 cc/min 200 cc/min 400 cc/min 1 L/min 3/8 inch 3/8 inch 1/4VC0 Connector 1/4 inch 3/8 inch 1/4 inch

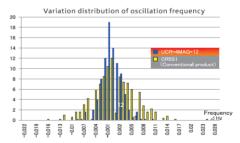
Quartz Crystal UCR series

ULVAC's Quartz crystal "UCR series" for quartz crystal type deposition controller has excellent temperature characteristics and enable stable measurement. The lineup includes 4MHz silver electrode, 5MHz gold/silver electrode and 6MHz gold electrode, allowing you to select the optimal product for your application.

- · Excellent temperature characteristics during deposition
- Small fluctuation and change by thermal shock during shutter opening/closing.
- Small and stable frequency fluctuation
- Excellent rate measurement stability
- The new 12-piece package enables batch replacement of quartz crystals when using ULVAC multi-sensors







 Thin Film
 Vacuum
 Cryogenic

 Measurement
 Accessories
 Transfer Robot
 Equipment

Thin Film Measurement Spectroscopic Ellipsometer

Spectroscopic Ellipsometer UNECS series

UNECS series is Spectroscopic Ellipsometer which measures thin film thickness and refractive index with high speed and high precision. Unique measurement method makes high speed measurement and compact size design.



UNECS-1M

UNECS-Portable



UNECS-1500M

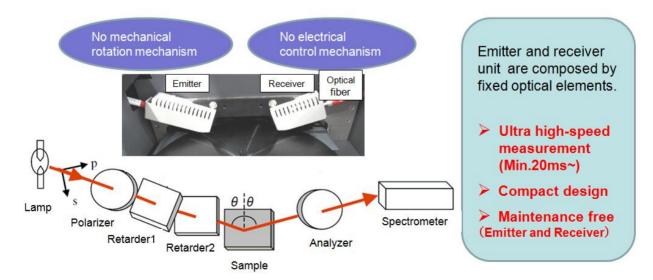


UNECS-1500A/2000A



UNECS-3000A

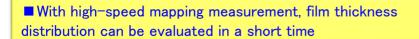
- Unique measurement method which does not have a rotation mechanism makes measurement speed extremely high in 20ms.
- Wavelength of standard type from 530nm to 750nm and visible spectroscopy type from 380nm to 760nm.
- The emitter and receiver sensor consists of only optical elements which does not include any rotating mechanism. It makes weight and design light and compact, and periodical maintenance cycle very low.
- Various mode available from unique portable, manual stage and auto stage type. A built-in type for vacuum environment is also available.

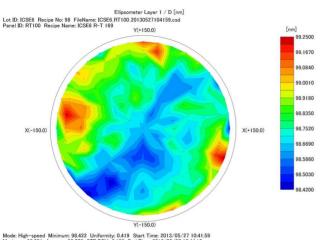


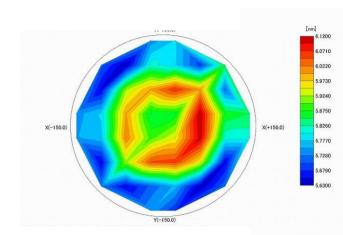
Configuration of emitter and receiver sensor

Thin Film Measurement Spectroscopic Ellipsometer

Spectroscopic Ellipsometer UNECS series







Mode: High-speed Minimum: 98.422 Uniformity: 0.419 Start Time: 2013/05/27 10:41:59 Maximum: 99.251 Average: 98.773 STD.DEV.: 0.158 End Time: 2013/05/27 10:44:12

169 points measurement for SiO2_100nm film on Φ 300mm wafer

Only 133 sec 44 points measurement for HfO2 5nm film on Φ 300mm wafer

Model		UNECS-Portable	UNECS-1500M	UNECS-1500A	UNECS-2000A	UNECS-3000A	
Measurement m	ethod		Spectroso	opic ellipsometry (spectral ellipsometr	y)		
Measureable filn	ı		Tran	sparent film or semitransparent film			
Wavelength rang	e			530 to 750nm or 380 to 760nm			
Light source				Halogen lamp or xenon lamp			
Spot diameter				Φ1mm or Φ0.3mm			
Multilayer film m	easurement			laximum 6 layers (film thickness) n thickness and optical parameter (N,K)	is only the top layer		
Incidence angle				70°			
Film thickness r	epeatability			0.1nm			
Film thickness n range	neasurement			1nm to 2 μ m			
Scanning time				20ms to 3000ms (configurable)			
Calculation time				300ms			
Sample stage		Approx. Φ 150mm (detachable)	Φ15	0mm	Ф 200mm	Ф 300mm	
Stage moving range	R	_	100mm: manual	0 to 75mm: programmable (resolution 0.1mm)	0 to 100mm: programmable (resolution 0.1mm)	0 to 150mm: programmable (resolution 0.1mm)	
	θ	_	360°: manual	0 to 359.9 $^\circ$: programmable (resolution 0.1 $^\circ$)		°)	
Automatic multi measurement	ole point	t _ 200 points (optional 2,000 points)				2,000 points	
Focus (Z- axis)	adjustment	Mar	ual		Automatic	•	
Maximum sample	e thickness	10n	nm		30mm		
Vaximum sample	e weight			10kg			
Measurement•a	nalysis function) and Δ (λ) measurement (2)film th	ickness (D), refraction index (N), calcul	ated value of extinction coefficier	nt (K)	
Mapping display		_	-	2D color map display (Optional: 3D display)			
Control and ana	yzing PC			Laptop type, OS Windows 7			
Dimensions	Main unit	220 x 268 x 244mm	300 x 400 x 384mm	400 x 525 x	370mm	450 x 620 x 370mm	
WxDxH	Controller	_	_		204 x 500 x 509mm		
Weight	Main unit	2.2kg	10.3kg	24kg		31kg	
		Stage: 1.3kg	_		Controller: 19kg		
Utility	Power	AC100 /200V M	lax 3A 50/60Hz	AC	C100 /200V Max 6A 50/60Hz		
	Vacuum	_	-	75kPa or les	s (necessary when using vacuum	chuck)	
Applicable stand	ard	С	E	_		CE	

Vacuum Pump

Vacuum Valve

Vacuum Gauge

Process Gas Monitor

Leak Detector

Power Supply (DC/RF)

EB Power Supply / EB Source

Depo

Accessories

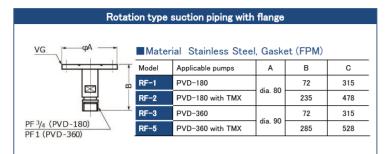
Vacuum Transfer

· Robot

Cryogenic Equipment

Vacuum parts such as piping, bellows, etc.

Various kinds of optional accessories are available.



				Ur	nit : m	m
Sh	ort piping v	vith gauge port				
VF φ18 → Gauge portVG	Materia	al Stainless Stee	l, Gas	ket (F	PM)	
	Model	Applicable pumps	dia. D	dia. d	dia. p	t
	TP-20	PVD-180 (B)	80	27.2	60	8
╚╎ ╎ ╞╡┼╌╴┤╴ ╏	TP-25	PVD-360 (B)	90	34.0	70	8
└──\\ └──\\ └	TP-40	VD301,VD401	105	48.6	85	10
t - Leak port - t 100 4-010	TP-50	VD601,VD901	120	60.5	100	10

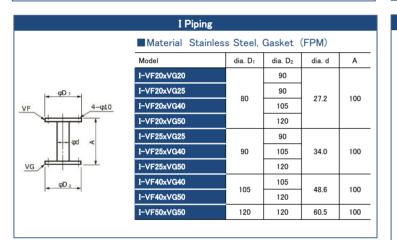
Bellows joints BJ series

Flexible hose

Rotation type exhaust piping with flange

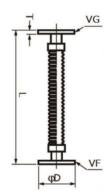
VG B O-ring

Materia	Stainless Steel, (Gasket	(FPM)	
Model	Applicable pumps	А	В	С
RF-7	PVD-180	dia. 80	PF3/4"	50
RF-8	PVD-360	dia. 90	PF1"	80
RF-9	PVD-180 with TMX	dia. 80	PF1.1/2"	50
RF-10	PVD-360 with TMX	dia. 90	PF1.1/2	50



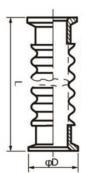
L piping 🖊 T piping								
A VG	L piping	Material	Stainless S	teel, Gaske	et (FPM)			
Г	Model	dia. D	dia. d	А	Т			
Real T	L-20	80	27.2	60	8			
	L-25	90	34.0	65	8			
¢D VF	L-40	105	48.6	80	10			
L-Type Piping	L-50	120	60.5	90	10			
	T piping	Material	Stainless S	teel, Gaske	et (FPM)			
4-q10	Model	dia. D	dia. d	А	В			
	T-20	80	27.2	50	100			
8	T-25	90	34.0	55	100			
	T-40	105	48.6	60	130			
	T-50	120	60.5	60	150			
T-Type Piping								

Material Stainless Steel, Gasket (FPM) VG Model A в BJ-25A 65 90 BJ-40A 90 105 2 BJ-50A 105 120 BJ-80A 110 160 BJ-100A 110 185 BJ-150A 100 235



VF

JIS standard vacuum flange model



ISO standard KF flange model

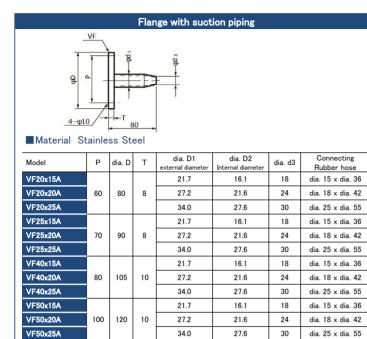
KFH-50-2000

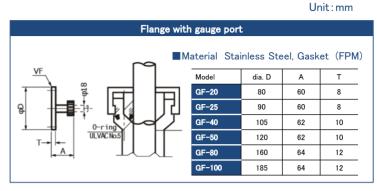
JIS standard va	1	-	
Model	D	L	Т
VFH-20-200		200	
VFH-20-500	80	500	8
VFH-20-1000		1000	
VFH-25-200		200	
VFH-25-500	90	500	8
VFH-25-1000		1000	
VFH-40-500		500	
VFH-40-1000	105	1000	10
VFH-40-2000		2000	
VFH-50-500		500	
VFH-50-1000	120	1000	10
VFH-50-2000		2000	
ISO standard KF	flange	e model	
Model	D	L	
		200	
KFH-20-200		200	_
KFH-20-200 KFH-20-500	40	500	
	40		
KFH-20-500	40	500	
KFH-20-500 KFH-20-1000	40	500 1000	
KFH-20-500 KFH-20-1000 KFH-25-200		500 1000 200	
KFH-20-500 KFH-20-1000 KFH-25-200 KFH-25-500		500 1000 200 500	
KFH-20-500 KFH-20-1000 KFH-25-200 KFH-25-500 KFH-25-1000		500 1000 200 500 1000	- - - -
KFH-20-500 KFH-20-1000 KFH-25-200 KFH-25-500 KFH-25-1000 KFH-40-500	40	500 1000 200 500 1000 500	- - - -
KFH-20-500 KFH-20-1000 KFH-25-200 KFH-25-500 KFH-25-1000 KFH-40-500 KFH-40-1000	40	500 1000 200 500 1000 500 1000	- - - - -
KFH-20-500 KFH-20-1000 KFH-25-200 KFH-25-500 KFH-25-1000 KFH-40-500 KFH-40-1000 KFH-40-2000	40	500 1000 200 500 1000 500 1000 2000	- - - - -

2000

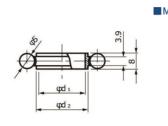
Accessories ► Vacuum parts such as piping, bellows, etc.

Vacuum parts such as piping, bellows, etc.



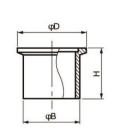


0-Ri



ing	ng seat									
/lat	erial Stainless	Steel, Gasket								
-	Model	Nominal diameter								
	KBR-10	KF10								
	KBR-16	KF16								
	KBR-25	KF25								
	KBR-40	KF40								
	KBR-50	KF50								

Coupling (Short)



Material Stainless Steel Nominal Model dia. B dia. D н diameter KSC-10 15 30 16 KF10 KSC-16 KF16 20 30 16 KSC-25 KF25 30 40 20 KSC-40 45 55 KF40 20 KSC-50 KF50 56 75 20

Clamp						
	Material Alur	ninum Alloy				
	Model	Nominal diameter				
	KQC-16	KF10/16				
	KQC-25	KF25				
, , ,	KQC-40	KF40				
Clamp	KQC-50	KF50				

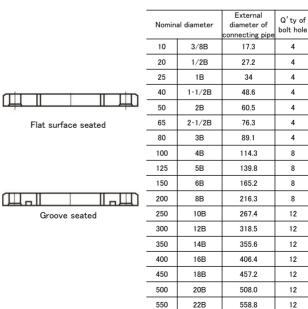
Quick coupling connection adapter									
	Material	Stainle	ss Steel						
	Model	D1	D2	D1 Part	D2 Part				
	KCG-10	30	80	KF10	VG20				
φD 1	KCG-16	30	80	KF16	VG20				
	KCG-25	40	90	KF25	VG25				
	KCG-40	55	105	KF40	VG40				
VF or VG	KCG-50	75	120	KF50	VG50				
	KCF-10	30	80	KF10	VF20				
+	KCF-16	30	80	KF16	VF20				
φD 2	KCF-25	40	90	KF25	VF25				
€ ₽	KCF-40	55	105	KF40	VF40				
	KCF-50	75	120	KF50	VF50				

Coupling (Long)

KLC-10 KF10 15 KLC-16 KF16 20 KLC-25 KF25 30			Model	Nominal diameter	dia. B
4			KLC-10	KF10	15
		0	KLC-16	KF16	20
		KLC-25	KF25	30	
KLC-40 KF40 45		KLC-40	KF40	45	

Vacuum flange

Material Stainless Steel



Depositio Controlle Thin Film Measurement SSOFIE

Vacuum Pump

Vacuum

Valve

Vacuum

1 Gauge

Process

Gas Monitor

Leal

Detector

(DC/RF)

Iddne

EB Power Suppl / EB Source

(FPM)

dia. D

30

30

40

55

Bolt size

M8

M8

M8

M8

M8

M10

M10

M10

M10

M10

M12

M12

M12

M12

M16

M16

M16

M16

4

4

4

4

4

4

4

8

8

8

8

12

12

12

12

12

12

12

Vacuum Transfer Robot

Vacuum Transfer Robot ELEC / COVOT series

Clean and high reliable vacuum transfer robot.



- Various models are available for different kind of vacuum systems.
- Various kinds of arms are available to meet specification of vacuum systems.
- Highly rigid arm and reliable actuator makes wafer transfer stable.
- Model ELEC-RZ and COVOT are for high vacuum application, up to 1 x $10^{-6} Pa$ / 1.0 x $10^{-8} mbar$ / 7.5 x $10^{-9} Torr.$



Teaching pendant





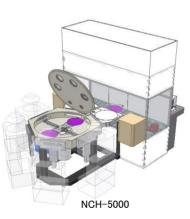
COVOT-LC							COVOT-6	A	rm specifica	tion table
				5	Standard	arm			Dedicated Am	n
Arm model		252	271	325	419		424	F	RV	C V 6
Maxinum distance (m	m)*1	700	760	880	1040		1050	7	40	880
Minimum rotation diam (mm)∗1	ıeter	606	644	802	940		964	6	000	
Numberofhands			10	or 2			1or 2		1	4
0 utine*2					Ð					Special for COVOT-6
ELEC-RZ		0	0	0	0		0		0	
COVOT-LC		0	0	0	n/a		n/a		0	n/a
C O V O T-6		n/a	n/a	n/a	n/a	n/a			n/a	0
*1) *2) W hen optio	nalUL	VAC sta	andard	hand (s) f	or 300m m	i is used. C	ontactus for requ	irem entofo	herhand.	
Model					ELEC-R	Z	COVOT	-LC	COV	0 T6
Pressure range				1.0 x 10 ⁻⁶ Pa		1.0 x 10 ⁻	⁵ Pa	1.0 x 10 ⁻¹ Pa		
Atm ospheric pressure to:		F	1.0 x 10 ⁻⁸ m bar		1.0 x 10 ⁻⁷ m bar		1.0 x 10 ⁻³ m bar			
			F	7.5 x 10 ⁻⁹ Torr			7.5 x 10 ⁻⁶	Torr	7.5 x 1	0 ⁻⁴ Torr
Wafersize				200m m /300m m		200m m /3	00m m	300	m m	
Numberofhandlingw	afer			1 or 2		1 or 2		4	ļ	
Maximum reachable o	listance)				ŝ	ee above ann spe	cification table)	
Rotation angle					±210°		-15° to 3	75°	360° e	ndkess
Zaxis stroke					50m m		None		110	m m
M in in um rotation dian	neter					¢	ee above ann spe	cification table	.)	
Transportable weight	(includi	ngpickı	ıp)	1kg		1kg		16	g	
Speed R axis			Max 2.5 sec / full stroke		M ax 2.5 sec / full stroke		Max 1.5sec / full stroke			
	θaxis			M ax 3.0 sec /180°		M ax 2.5 sec /180°		M ax 2.0sec / 180°		
	Zaxis		M ax 1.5 sec / 20r)m m	_		Max 1.5sec	/ 20m m	
Repetition position	Raxis			±0.1m m		±0.2m m		±0.2	2m m	
precision	θaxis				±0.2m m		±0.2m	m	±0.2	2m m
	Zaxis				±0.2m m		-		±0.2	2m m
Vacuum seal				M ag	netic fluid	seal	Contact	seal	Contac	stseal
Teaching pendant					Inc luded		0 ptio	n	hci	ıded
Controller				Sep	arate ly sh	ipped	h temally eq	uipped	Separately shipped	

Platform NCH series

A vacuum transport platform for Φ 200mm / 300mm wafers.



NCH-4000



- For 4 to 8 connection ports.
- · Equipped with 25 slot cassette lifting type load lock chamber.
- Vacuum pumps and gauges are available as option.

Wafer size	200mm, 300mm
Connection ports	4 to 8 ports
Standard transfer robot	ELEC-RZ (option: COVOT)
Load lock	25 slot cassettes lifting type (in-line type available)
Vacuum pump and gauge	Option

Cryogenic Equipment

LN2 Generator EMP series



EMP-20W

Model	EMP-U/A	/ EMP-0/W
LN ₂ Production Capacity	,	8L / day (60Hz) 6L / day (50Hz)
Air processing Capacity		5.2 m² / day
	EMP-07A	EMP-07W
LN ₂ Production Capacity	8L / day (60Hz) 、6L / day (50Hz)	
LN ₂ Storage Capacity	40L	
Dimensions (W×D×H)	600 × 750 × 1628mm	
Weight	Approx.220kg	Approx.230kg
Power Supply	AC100V Single phase Approx.1.2/1.4kW (50 / 60Hz) Breaking capacity 20A	
Cooling Water	Not needed (Air cooled)	Entrance:5 to 35°C Flow rate:2to5L/min Pressure:<0.8MPa Water quality: Tap water equivalent

Model	EMP-14A	/ EMP-14W
LN ₂ Production Capacity		14L / day (60Hz)
		14L / day (50Hz)
Air processing Capacity		9.1 m³ / day
	EMP-14A	EMP-14W
LN ₂ Production Capacity	14L / day (60Hz)、14L / day (50Hz)	
LN ₂ Storage Capacity	40L	
Dimensions	600 × × 750 × 1688mm	
(W×D×H)		
Weight	Approx.235kg	Approx.230kg
Power Supply	AC200V Three phase	AC200V Three phase
	Approx.1.7 / 2.0kW	Approx.1.6 / 1.9kW
	(50Hz / 60Hz)	(50Hz / 60Hz)
	Breaking capacity 20A	Breaking capacity 20A
Cooling Water	Not needed (Air cooled)	Entrance:5 to 35°C
		Flow rate:2to6L / min
		Pressure:<0.8MPa
		Water quality: Tap water
		equivalent
Nitrogen gas generator	:GN-10i	

Nitrogen gas generator:GN-10

Model	EMP-20W	
IN Duaduation Consoli	20L / day (60Hz)	
LN ₂ Production Capacit	.y 19L / day (50Hz)	
Air processing Capacity	/ 13.0m [°] ∕ day	
	EMP-20W	
LN ₂ Production	20L / day (60Hz)、19L / day (50Hz)	
Capacity		
LN ₂ Storage Capacity	80L	
Dimensions	930 × × 740 × 1661mm	
(W×D×H)		
Weight	Approx.340kg	
Power Supply	AC200V Three phase	
	Approx.3.3 / 4.1kW (50Hz / 60Hz)	
	Breaking capacity 30A	
Cooling Water	Entrance:10 to 30°C	
	Flow rate:3to6L / min	
	Pressure:<0.8MPa	
	Water quality:Tap water equivalent	

	equivalent	
Nitrogen gas generator:G	N-10i	
Model	MP-300K	
IN Broduction Consoity	30L / day (60Hz)	
LN ₂ Production Capacity	28L / day (50Hz)	
Air processing Capacity	19.4 m [*] / day	
	MP-300K	
LN ₂ Production	30L / day (60Hz)、28L / day (50Hz)	
Capacity	30L / day (00112), 20L / day (30112)	
LN ₂ Storage Capacity	100L	
Dimensions	1050 × × 740 × × 1795mm	
(W×D×H)		
Weight	Approx.430kg	
	AC190~220V (50Hz) Three phase	
	AC200 \sim 230V (60Hz) Three phase	
Power Supply	Approx.4.3 / 5.2kW (50Hz / 60Hz)	
	Breaking capacity 30A	

Entrance:10 to 30°C Flow rate:5to12L / min

Pressure:<0.8MPa

Water quality:Tap water equivalent

Nitrogen gas generator:GN-15i

Typical Usage

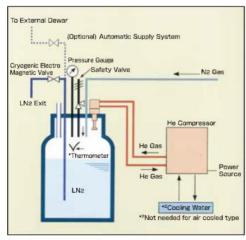
Vacuum Evacuation Device LN₂ Cold Trap

Material Analyzing Device

Electron Microscope EDS(EDX) Detector

Cryopreservation Container (Biological - Sample)

Flow Diagram inside EMP



Nitrogen gas generator:GN-20i

Cooling Water

OPERATING PRECAUTIONS

- When installing EMP in a room without appropriate size windows, a ventilating fan of above 1,000 m³/h (2,000 m³/h or above for EMP-20W) must be furnished to prevent oxygen shortage. It is recommended to install an oxygen alarm as well.
- LN2 is ultra low temperature liquefied gas. Always handle with care.
- Touching LN2 or cryogenic part like LN2 exit may result in low temperature burns. Make sure to wear protective gloves such as leather gloves.
- EMP must not be operated in organic solvent atmosphere.
- Maintenance is necessary according to the time used.

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